# Technical Information Cerabar M PMC51, PMP51, PMP55

Process pressure measurement

# Pressure transmitter with ceramic and metallic sensors

# Application

The device is used for the following measuring tasks:

- Absolute pressure and gauge pressure measurement in gases, steams or liquids in all areas of process engineering and process measurement technology
- Level, volume or mass measurements in liquids
- High process temperature
  - without diaphragm seals up to 130  $^\circ C$  (266°F), for a maximum of 60 minutes 150  $^\circ C$  (302°F)
  - with diaphragm seals up to 400  $^\circ C$  (752  $^\circ F)$
- High pressure up to 400 bar (6000 psi)
- International usage thanks to a wide range of approvals

# Your benefits

- Very good reproducibility and long-term stability
- High reference accuracy: up to ±0.15%, as PLATINUM version: ±0.075%
- Turn down up to 100:1
- Standardized platform for differential pressure, hydrostatics, and pressure (Deltabar S – Deltapilot S – Cerabar S)
- Simple, fast commissioning through a user interface designed for real-world applications
- Used for process pressure monitoring up to SIL2, certified to IEC 61508 Edition 2.0 and IEC 61511 by TÜV NORD
- New TempC diaphragm for diaphragm seals: Minimum temperature effects, maximum diaphragm thickness and short recovery times
- Device versions compliant with ASME-BPE





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# **Document information**

## Symbols used

# Safety symbols

Symbol	Meaning
A0011189-EN	<b>DANGER!</b> This symbol alerts you to a dangerous situation. Failure to avoid this situation will result in serious or fatal injury.
A0011190-EN	<b>WARNING!</b> This symbol alerts you to a dangerous situation. Failure to avoid this situation can result in serious or fatal injury.
	<b>CAUTION!</b> This symbol alerts you to a dangerous situation. Failure to avoid this situation can result in minor or medium injury.
NOTICE A0011192-EN	<b>NOTE!</b> This symbol contains information on procedures and other facts which do not result in personal injury.

# Electrical symbols

Symbol		Meaning
	A0018335	<b>Direct current</b> A terminal at which DC voltage is present or through which direct current flows.
~	A0018336	Alternating current A terminal at which alternating voltage is present or through which alternating current flows.
$\sim$	A0018337	<ul> <li>Direct current and alternating current</li> <li>A terminal at which alternating voltage or DC voltage is present.</li> <li>A terminal through which alternating current or direct current flows.</li> </ul>
<u> </u>	A0018338	<b>Ground connection</b> A grounded terminal which, as far as the operator is concerned, is grounded via a grounding system.
	A0018339	<b>Protective ground connection</b> A terminal which must be connected to ground prior to establishing any other connections.
\$	A0011201	<b>Equipotential connection</b> A connection that has to be connected to the plant grounding system: This may be a potential equalization line or a star grounding system depending on national or company codes of practice.

# Tool symbols

Symbol	Meaning
A0011219	Phillips head screwdriver
0	Flat-blade screwdriver
A0013442	Torx screwdriver
Ю́Г 40011222	Hexagon wrench
A0011221	Allen screw

Symbol	Meaning
A0011182	<b>Permitted</b> Indicates procedures, processes or actions that are permitted.
A0011183	<b>Preferred</b> Indicates procedures, processes or actions that are preferred.
A0011184	Forbidden Indicates procedures, processes or actions that are forbidden.
A0011193	<b>Tip</b> Indicates additional information.
A0015483	<b>Reference to documentation</b> Refers to the corresponding device documentation.
A0015484	<b>Reference to page</b> Refers to the corresponding page number.
A0015486	<b>Reference to graphics</b> Refers to the corresponding graphic number and page number.
1. , 2. ,	Series of steps
A0015488	Help in the event of a problem

# Symbols for certain types of information

# Symbols in graphics

Symbol	Meaning
1, 2, 3, 4 etc.	Numbering for main items
1. , 2. ,	Series of steps
A, B, C, D etc.	Views
A-A, B-B, etc.	Sections
<b>EX</b> A0011187	Hazardous area Indicates the hazardous area.
A0011188	Safe area (non-hazardous area) Indicates the non-hazardous area.

## Terms and abbreviations

Term/abbreviation	Explanation		
MWP	The MWP (maximum working pressure) for the individual sensors depends on the lowest-rated element, with regard to pressure, of the selected components, i.e. the process connection has to be taken into consideration in addition to the measuring cell. Pay attention to the pressure-temperature dependence also. For the relevant standards and additional notes, see section " $\rightarrow \triangleq 40$ ".		
OPL .	The OPL (over pressure limit = sensor overload limit) for the sensor depends on the lowest-rated element, with regard to pressure, of the selected components, i.e. the process connection has to be taken into consideration in addition to the measuring cell. Pay attention to the pressure-temperature dependence also. For the relevant standards and additional notes, see section " $\rightarrow \square 40$ ".		
LRL	Lower range limit		
URL	Upper range limit		
LRV	Lower range value		
URV	Upper range value		
TD	Turn down		
Case 1: • $ Lower range value (LRV)  \le  Upper range value (URV) $ Example: • Lower range value (LRV) = 0 bar • Upper range value (URV) = 0.5 bar (7.5 psi) • Nominal value (URL) = 1 bar (15 psi) Turn down: • TD = URL /  URV  = 2:1 Set span: • URV - LRV = 0.5 bar (7.5 psi) This span is based on the zero point. Case 2: •  Lower range value (LRV)  $\le$  Upper range value (URV)  Example: • Lower range value (LRV) = 0 bar • Upper range value (URV) = 0.5 bar (7.5 psi) • Nominal value (URL) = 1 bar (15 psi) Turn down: • TD = URL /  URV  = 2:1 Set span:	$1 = 2$ $LRL = LRV \qquad URV \qquad URL$ $4 = 5$ $4 = 5$ $Example: 1 bar (15 psi) measuring cell$ $1 = 2$ $LRL \qquad LRV \qquad URV \qquad URL$ $4$ $3$ $4$ $5$		
<ul> <li>URV – LRV = 0.5 bar (7.5 psi) This span is based on the zero point.</li> </ul>	Example: 1 bar (15 psi) measuring cell		
Case 3: • $ Lower range value (LRV)  \ge  Upper range value (URV) $ Example: • Lower range value (LRV) = -0.6 bar (-9 psi) • Upper range value (URV) = 0 bar • Nominal value (URL) = 1 bar (15 psi) Turn down: • TD = URL / $ LRV  = 1.67:1$ Set span: • URV - LRV = 0.6 bar (9 psi) This span is based on the zero point.	1 = 2         LRL LRV URV URL         4         5         A001645         Example: 1 bar (15 psi) measuring cell         1       Set span         2       Span based on zero point         3       Nominal value = upper range limit (URL)         4       Nominal measuring range         5       Sensor measuring range		

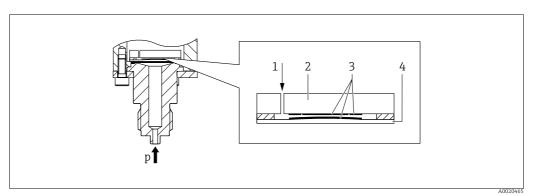
# Function and system design

## **Device selection**

Cerabar M –	PMC51	PMP51	PMP55
Product family			
	A0023673	A0023675	A0023676
	With capacitive measuring cell and ceramic process isolating diaphragm (Ceraphire <sup>®</sup> )	With piezoresistive measuring cell and metallic welded process isolating diaphragm	With diaphragm seal
Field of application	<ul> <li>Gauge pressure and absolute pressure</li> <li>Level</li> </ul>		
Process connections	<ul> <li>Thread</li> <li>EN flanges DN 25 - DN 80</li> <li>ANSI flanges 1" - 4"</li> <li>JIS flanges 50 A - 100 A</li> <li>Flush-mounted hygienic connections</li> </ul>	<ul> <li>Thread</li> <li>EN flanges DN 25 - DN 80</li> <li>ANSI flanges 1" - 4"</li> <li>Prepared for diaphragm seal mount</li> <li>Flush-mounted hygienic connections</li> </ul>	<ul> <li>Wide range of diaphragm seals</li> </ul>
Measuring ranges	From -100/0 to 100 mbar         From -400/0 to 400 mbar (-6/0 to 6 psi)           (-1.5/0 to 1.5 psi)         to -1/0 to 400 bar (-15/0 to 6000 psi)           to -1/0 to 40 bar (-15/0 to 600 psi)         to -1/0 to 400 bar (-15/0 to 6000 psi)		1 ,
OPL	Max. 60 bar (900 psi)	Max. 600 bar (9000 psi)	
Process temperature range	-40 to +130 °C (-40 to +266°F) For a maximum of 60 minutes: +150 °C (+302°F)	-40 to +130 °C (-40 to +266°F) For a maximum of 60 minutes: +150 °C (+302°F)	-70 to 400 °C (-94 to +752°F) depending on the filling oil
Ambient temperature range	<ul> <li>Without LCD display: -40 to +85 °C (-40 to +185°F)</li> <li>With LCD display: -20 to +70 °C (-4 to +158°F) (extended temperature application range (-40 to 85 °C (-40 to 185°F)) with restrictions in optical properties such as display speed and contrast)</li> <li>Separate housing: -20 to +60 °C (-4 to +140°F)</li> <li>Diaphragm seal systems depending on the version</li> </ul>		
Reference accuracy	<ul> <li>Up to ±0.15% of the set span</li> <li>PLATINUM version: up to ±0.075% of the set span</li> </ul>		
Supply voltage	<ul> <li>11.5 to 45 V DC (versions with plug-in connection 35 V DC)</li> <li>For intrinsically safe device versions: 11.5 to 30 V DC</li> </ul>		
Output	4 to 20 mA, 4 to 20 mA with superimposed HART protocol		
Options	<ul> <li>PMP51, PMP55: NACE-compliant materials</li> <li>PMC51, PMP51, PMP55: inspection certificate 2.2 or 3.1 or other certificates</li> <li>3A approval and EHEDG approval</li> <li>Specific firmware versions</li> <li>Initial device settings</li> <li>Separate housing</li> <li>Broad range of accessories</li> </ul>		
Specialties	<ul> <li>Metal-free measurement with PVDF connection</li> <li>Special cleaning of the transmitter to remove paint-wetting substances, for use in paint shops</li> </ul>	<ul> <li>Process connections with minimum oil volume</li> <li>Gas-tight, elastomer-free</li> </ul>	<ul> <li>Wide range of diaphragm seals</li> <li>For extreme medium temperatures</li> <li>Process connections with minimum oil volume</li> <li>Completely welded versions</li> </ul>

#### Measuring principle

#### Ceramic process isolating diaphragm used in PMC51 (Ceraphire®)



#### Ceramic sensor

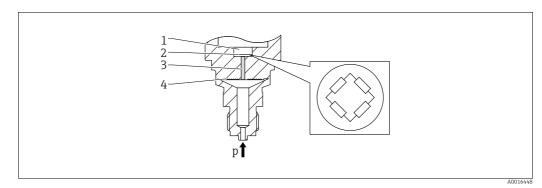
- 1 Air pressure (gauge pressure sensors)
- 2 Ceramic substrate Electrodes 3
- 4 Ceramic process isolating diaphragm

The ceramic sensor is a dry sensor, i.e. the process pressure acts directly on the robust ceramic process isolating diaphragm and deflects it. A pressure-dependent change in capacitance is measured at the electrodes of the ceramic substrate and the process isolating diaphragm. The measuring range is determined by the thickness of the ceramic process isolating diaphragm.

Advantages:

- Guaranteed overload resistance up to 40 times the nominal pressure
- Thanks to ultrapure 99.9% ceramic (Ceraphire<sup>®</sup>, see also "www.endress.com/ceraphire")
  - extremely high chemical stability, comparable with Alloy C
  - less relaxation
  - high mechanical stability
- Can be used in absolute vacuum
- Outstanding surface finish,  $R_a \leq 0.3 \mu m$  (11.8  $\mu in$ )

#### Metallic process isolating diaphragm used in PMP51 and PMP55



Metallic sensor

- Silicon measuring element, substrate Wheatstone bridge 1
- 2
- 3 Channel with fill fluid 4 Metallic process isolating diaphragm

#### PMP51

The operating pressure deflects the process isolating diaphragm and a fill fluid transfers the pressure to a resistance bridge (semiconductor technology). The pressure-dependent change in the bridge output voltage is measured and evaluated.

Advantages:

- Can be used for process pressure up to 400 bar (6000 psi)
- High long-term stability
- Guaranteed overload resistance up to 4 times the nominal pressure
- Significantly less thermal effect compared to diaphragm seal systems

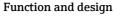
#### PMP55

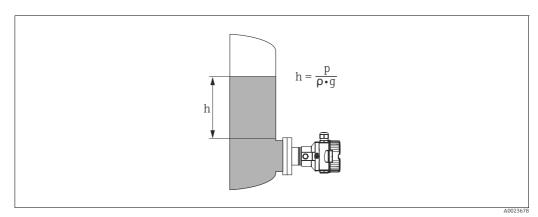
The operating pressure acts on the process isolating diaphragm of the diaphragm seal and is transferred to the process isolating diaphragm of the sensor by a diaphragm seal fill fluid. The process isolating diaphragm is deflected and a fill fluid transfers the pressure to a resistance bridge. The pressure-dependent change in the bridge output voltage is measured and evaluated.

Advantages:

- Depending on the version, can be used for process pressure up to 400 bar (6000 psi) and simultaneous extreme process temperatures
- High long-term stability
- Guaranteed overload resistance up to 4 times the nominal pressure

Level measurement (level, volume and mass)



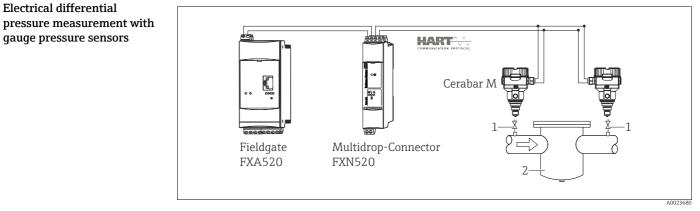


Level measurement

- h Height (level)
- p Pressure
- ho Density of the medium
- g Gravitation constant

#### Your benefits

- Choice of different level measuring modes in the device software
- Volume and mass measurements in any vessel shapes by means of a freely programmable characteristic curve
- Choice of diverse level units
- Has a wide range of uses, even in the following cases:
  - in the event of foam formation
  - in vessels with agitators or screen fittings
  - in the event of liquid gases



1 Shut-off valves

2 e.g. filter

In the example given, two Cerabar M devices (each with a gauge pressure sensor) are interconnected. The pressure difference can thus be measured using two independent Cerabar M devices.

# **A** WARNING

Risk of explosion!

• If using intrinsically safe devices, strict compliance with the rules for interconnecting intrinsically safe circuits as stipulated in IEC60079-14 (proof of intrinsic safety) is mandatory.

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Communication and data	<ul> <li>4 to 20 mA without communication protocol (analog electronics)</li> </ul>
processing	4 to 20 mA with HART communication protocol
	<ul> <li>PROFIBUS PA</li> </ul>
	<ul> <li>The Endress+Hauser devices meet the requirements of the FISCO model.</li> </ul>
	– Due to the low current consumption of $11 \text{ mA} \pm 1 \text{ mA}$ , the following number of devices can be
	operated on one bus segment if installing as per FISCO:
	<ul> <li>up to 8 Cerabar M for Ex ia, CSA IS and FM IS applications</li> </ul>
	– up to 31 Cerabar M for all other applications, e.g. in non-hazardous areas, Ex nA, etc.
	Further information on PROFIBUS PA can be found in Operating Instructions BA00034S
	"PROFIBUS DP/PA: Guidelines for planning and commissioning" and in the PNO Guideline.
	<ul> <li>FOUNDATION Fieldbus</li> </ul>
	<ul> <li>The Endress+Hauser devices meet the requirements of the FISCO model.</li> </ul>
	– Due to the low current consumption of $16 \text{ mA} \pm 1 \text{ mA}$ , the following number of devices can be
	operated on one bus segment if installing as per FISCO:
	– up to 6 Cerabar M for Ex ia, CSA IS and FM IS applications
	– up to 22 Cerabar M for all other applications, e.g. in non-hazardous areas, Ex nA, etc.
	Further information on FOUNDATION Fieldbus, such as requirements for bus system components can be found in Operating Instructions BA00013S "FOUNDATION Fieldbus Overview".

# Input

#### Measured variable

- Analog electronics: Absolute pressure and gauge pressure
- HART electronics: Absolute pressure and gauge pressure, from which level (level, volume or mass) is derived

Measuring range	PMC51 – with ceramic process isolating diaphragm (Ceraphire $^{\circ}$ ) for gauge pressure						
Nominal value			Smallest calibratable span (preset at the factory) <sup>1)</sup>	MWP	OPL	Vacuum resistance	Option <sup>2)</sup>
	lower (LRL) upper (URL)						
	[bar (psi)]	[bar (psi)]	[bar (psi)]	[bar (psi)]	[bar (psi)]	[bar <sub>abs</sub> (psi <sub>abs</sub> )]	
100 mbar (1.5 psi)	-0.1 (-1.5)	+0.1 (+1.5)	0.01 (0.15)	2.7 (40.5)	4 (60)	0.7 (10.5)	1C
250 mbar (3.75 psi)	-0.25 (-3.75)	+0.25 (+3.75)	0.01 (0.15)	3.3 (49.5)	5 (75)	0.5 (7.5)	1E
400 mbar (6 psi)	-0.4 (-6)	+0.4 (+6)	0.02 (0.3)	5.3 (79.5)	8 (120)	0	1F
1 bar (15 psi)	-1 (-15)	+1 (+15)	0.05 (1)	6.7 (100.5)	10 (150)	0	1H
2 bar (30 psi)	-1 (-15)	+2 (+30)	0.1 (1.5)	12 (180)	18 (270)	0	1K
4 bar (60 psi)	-1 (-15)	+4 (+60)	0.2 (3)	16.7 (250.5)	25 (375)	0	1M
10 bar (150 psi)	-1 (-15)	+10 (+150)	0.5 (7.5)	26.7 (400.5)	40 (600)	0	1P
40 bar (600 psi)	-1 (-15)	+40 (+600)	2 (30)	40 (600)	60 (900)	0	1S

1) Factory calibration turn down: Max 20:1, higher on request or configurable in the device.

2) Product Configurator, "Sensor range" ordering feature

PMC51 – with ceramic process isolating diaphragm (Ceraphire $^{\circ}$ ) for absolute pressure							re
Nominal value			Smallest calibratable span (preset at the factory) <sup>1)</sup>	MWP	OPL	Vacuum resistance	Option <sup>2)</sup>
	lower (LRL) upper (URL)						
	[bar <sub>abs</sub> (psi <sub>abs</sub> )]	[bar <sub>abs</sub> (psi <sub>abs</sub> )]	[bar (psi)]	[bar <sub>abs</sub> (psi <sub>abs</sub> )]	[bar <sub>abs</sub> (psi <sub>abs</sub> )]	[bar <sub>abs</sub> (psi <sub>abs</sub> )]	
100 mbar (15 psi)	0	+0.1 (+1.5)	0.01 (0.15)	2.7 (40.5)	4 (60)	0	2C
250 mbar (3.75 psi)	0	+0.25 (+3.75)	0.01 (0.15)	3.3 (49.5)	5 (75)	0	2E
400 mbar (6 psi)	0	+0.4 (+6)	0.02 (0.3)	5.3 (79.5)	8 (120)	0	2F
1 bar (15 psi)	0	+1 (+15)	0.05 (1)	6.7 (100.5)	10 (150)	0	2H
2 bar (30 psi)	0	+2 (+30)	0.1 (1.5)	12 (180)	18 (270)	0	2K
4 bar (60 psi)	0	+4 (+60)	0.2 (3)	16.7 (250.5)	25 (375)	0	2M
10 bar (150 psi)	0	+10 (+150)	0.5 (7.5)	26.7 (400.5)	40 (600)	0	2P
40 bar (600 psi)	0	+40 (+600)	2 (30)	40 (600)	60 (900)	0	2S

PMC51 – with ceramic proces	ss isolating diaphragm	n (Ceraphire <sup>®</sup> ) :	for absolute pressure
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Factory calibration turn down: Max 20:1, higher on request or configurable in the device. 1)

2) Product Configurator, "Sensor range" ordering feature

Nominal value			Smallest calibratable span (preset at the factory) <sup>1)</sup>	MWP	OPL	Vacuum resistance <sup>2)</sup> Silicone oil/ Inert oil/ Synthetic oil	Option <sup>3)</sup>
	[bar (psi)]	[bar (psi)]	[bar (psi)]	[bar (psi)]	[bar (psi)]	[bar <sub>abs</sub> (psi <sub>abs</sub> )]	
400 mbar (6 psi)	-0.4 (-6)	+0.4 (+6)	0.02 (0.3)	4 (60)	6 (90)		1F
1 bar (15 psi)	-1 (-15)	+1 (+15)	0.05 (1)	6.7 (100)	10 (150)		1H
2 bar (30 psi)	-1 (-15)	+2 (+30)	0.1 (1.5)	13.3 (200)	20 (300)		1K
4 bar (60 psi)	-1 (-15)	+4 (+60)	0.2 (3)	18.7 (280.5)	28 (420)	0.01/0.04/0.01	1M
10 bar (150 psi)	-1 (-15)	+10 (+150)	0.5 (7.5)	26.7 (400.5)	40 (600)	(0.15/0.6/0.15)	1P
40 bar (600 psi)	-1 (-15)	+40 (+600)	2 (30)	100 (1500)	160 (2400)	-	1S
100 bar (1500 psi)	-1 (-15)	+100 (+1500)	5 (75)	100 (1500)	400 (6000)		1U
400 bar (6000 psi)	-1 (-15)	+400 (+6000)	20 (300)	400 (6000)	600 (9000)		1W

PMP51 and PMP55 – metallic process isolating diaphragm for gauge pressure

1) Factory calibration turn down: Max 20:1, higher on request or configurable in the device.

2) The vacuum resistance applies to the measuring cell at reference conditions. The pressure and temperature application limits of the selected filling oil must also be observed for the PMP55. → <a>Pml 101, "Diaphragm seal filling oils" ordering feature.</a>

3) Product Configurator, "Sensor range" ordering feature

Nominal value			Smallest calibratable span (preset calibratable span (preset at the factory) <sup>1)</sup>	MWP	OPL	Vacuum resistance <sup>2)</sup> Silicone oil/ Inert oil/ Synthetic oil	Option <sup>3)</sup>
	[bar <sub>abs</sub> (psi <sub>abs</sub> )]	[bar <sub>abs</sub> (psi <sub>abs</sub> )]	[bar (psi)]	[bar <sub>abs</sub> (psi <sub>abs</sub> )]	[bar <sub>abs</sub> (psi <sub>abs</sub> )]	[bar <sub>abs</sub> (psi <sub>abs</sub> )]	
400 mbar (6 psi)	0	+0.4 (+6)	0.02 (0.3)	4 (60)	6 (90)		2F
1 bar (15 psi)	0	+1 (+15)	0.05 (1)	6.7 (100)	10 (150)		2H
2 bar (30 psi)	0	+2 (+30)	0.1 (1.5)	13.3 (200)	20 (300)		2K
4 bar (60 psi)	0	+4 (+60)	0.2 (3)	18.7 (280.5)	28 (420)	0.01/0.04/0.01	2M
10 bar (150 psi)	0	+10 (+150)	0.5 (7.5)	26.7 (400.5)	40 (600)	(0.15/0.6/0.15)	2P
40 bar (600 psi)	0	+40 (+600)	2 (30)	100 (1500)	160 (2400)		2S
100 bar (1500 psi)	0	+100 (+1500)	5 (75)	100 (1500)	400 (6000)		2U
400 bar (6000 psi)	0	+400 (+6000)	20 (300)	400 (6000)	600 (9000)		2W

#### PMP51 and PMP55 - metallic process isolating diaphragm for absolute pressure

1) Factory calibration turn down: Max 20:1, higher on request or configurable in the device.

3) Product Configurator, "Sensor range" ordering feature

# Output

**Output signal** 

- 4 to 20 mA analog, 2-wire
- 4 to 20 mA with superimposed digital communication protocol HART 6.0, 2-wire
- Digital communication signal PROFIBUS PA (Profile 3.02)
- Digital communication signal FOUNDATION Fieldbus

Output	Option <sup>1)</sup>
4 to 20mA	1
4 to 20mA HART	2
PROFIBUS PA	3
FOUNDATION Fieldbus	4

Product Configurator, "Output" ordering feature 1)

Signal range	4 to 20 mA analog, 4 to 20 mA HART: 3.8 to 20.5 mA
Signal on alarm	<ul> <li>As per NAMUR NE 43</li> <li>4 to 20 mA Analog: <ul> <li>Signal overshoot: &gt; 20.5 mA</li> <li>Signal undershoot: &lt; 3.8 mA</li> <li>Min Alarm (3.6 mA)</li> </ul> </li> <li>4 to 20 mA HART <ul> <li>Options:</li> <li>Max. alarm: can be set from 21 to 23 mA (factory setting: 22 mA)</li> <li>Hold measured value: last measured value is held</li> <li>Min. alarm: 3.6 mA</li> </ul> </li> <li>PROFIBUS PA: can be set in the Analog Input block, <ul> <li>Options: Last Valid Out Value (factory setting), Fail-safe Value, Status Bad</li> </ul> </li> <li>FOUNDATION Fieldbus: can be set in the Analog Input block, <ul> <li>Options: Last Good Value, Fail-safe Value (factory setting), Wrong Value</li> </ul> </li> </ul>
Load - 4 to 20 mA analog and 4 to 20 mA HART	$\begin{array}{c} R_{Lmax} \\ 1456 \\ 1239 \\ 804 \\ 369 \\ 11.5 20 30 40 45 \\ \hline  V  \end{array}$

Load diagram

- 1
- Power supply 11.5 to 30 V DC for intrinsically safe device versions Power supply 11.5 to 45 V DC (versions with plug-in connector 35 V DC) for other types of protection and for uncertified device 2 versions

2

 $3 \rightarrow R_{Lmax} \leq \frac{U - 11.5 V}{23 mA}$ 

3 R<sub>Lmax</sub> Maximum load resistance

U Supply voltage A0023090

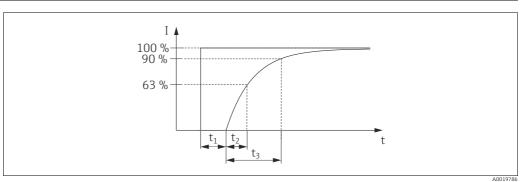
# i

When operating via a handheld terminal or via a PC with an operating program, a minimum communication resistance of 250  $\Omega$  must be taken into account.

#### Resolution

- Current output: 1 μA
- Display: can be set (factory setting: presentation of the maximum accuracy of the transmitter)

#### Dead time, Time constant



Presentation of the dead time and the time constant

Dynamic behavior: current output (analog electronics)		Туре	Dead time (t <sub>1</sub> ) [ms]	Time constant T63 (= t <sub>2</sub> ) [ms]	Time constant T90 (= t <sub>3</sub> ) [ms]	
(analog electronics)	Max.	PMC51	60	40	50	
	Max.	PMP51	40	40	50	
	Max.	PMP55	PMP51 + influence of the diaphragm seal			

Dynamic behavior: current output (HART electronics)		Туре	Dead time (t <sub>1</sub> ) [ms]	Time constant T63 (= t <sub>2</sub> ) [ms]	Time constant T90 (= t <sub>3</sub> ) [ms]		
(IIARI Electronics)	Max.	PMC51	50	85	200		
	Max.	PMP51	70	80	185		
	Max.	PMP55	PMP51 + influence of the diaphragm seal				

# Dynamic behavior: digital output (HART electronics)

	Туре	Dead time (t <sub>1</sub> ) [ms]	Dead time $(t_1)$ [ms] + Time constant T63 (= $t_2$ ) [ms]	Dead time (t <sub>1</sub> ) [ms] + Time constant T90 (= t <sub>3</sub> ) [ms]		
min.	PMC51	210	295	360		
Max.	PINCOL	1010	1095	1160		
min.	PMP51	210	285	345		
Max.	PIMPDI	1010	1085	1145		
Max.	PMP55	PMP51 + influence of the diaphragm seal				

### Reading cycle

- Acyclic: max. 3/s, typical 1/s (depends on command # and number of preambles)
- Cyclic (Burst): max. 3/s, typical 2/s

The Cerabar M commands the BURST MODE function for cyclic value transmission via the HART communication protocol.

### Cycle time (update time)

Cyclic (Burst): min. 300 ms

#### Response time

- Acyclic: min. 330 ms, typical 590 ms (depends on command # and number of preambles)
- Cyclic (Burst): min. 160 ms, typical 350 ms (depends on command # and number of preambles)

#### Dynamic behavior: PROFIBUS PA

	Туре	Dead time (t <sub>1</sub> ) [ms]	Dead time (t <sub>1</sub> ) [ms] + Time constant T63 (= t <sub>2</sub> ) [ms]	Dead time (t <sub>1</sub> ) [ms] + Time constant T90 (= t <sub>3</sub> ) [ms]	
min.	PMC51	85	170	235	
Max.	PINCOL	1185	1270	1335	
min.	PMP51	85	160	220	
Max.	PINIPUL	1185	1260	1320	
Max.	PMP55	PMP51 + influence of the diaphragm seal			

#### Reading cycle

- Cyclic: max. 30/s (dependent on the number and type of function blocks used in a closed-control loop)
- Acyclic: typical 25/s

#### Cycle time (update time)

min. 100 ms

The cycle time in a bus segment in cyclic data communication depends on the number of devices, on the segment coupler used and on the internal PLC cycle time.

#### **Response time**

- Cyclic: approx. 8 to 13 ms (depends on Min. Slave Interval)
- Acyclic: approx. 23 to 35 ms (depends on Min. Slave Interval)

Dynamic behavior: FOUNDATION Fieldbus		Туре	Dead time (t <sub>1</sub> ) [ms]	Dead time (t <sub>1</sub> ) [ms] + Time constant T63 (= t <sub>2</sub> ) [ms]	Dead time (t <sub>1</sub> ) [ms] + Time constant T90 (= t <sub>3</sub> ) [ms]
	min.	PMC51	95	180	245
	Max.	PINCOL	1095	1180	1245
	min.	PMP51	95	170	230
	Max.		1095	1170	1230
	Max.	PMP55	PMP51 + influence of the diaphragm seal		

#### Reading cycle

- Cyclic: max. 10/s (dependent on the number and type of function blocks used in a closed-control loop)
- Acyclic: typical 5/s

#### Cycle time (update time)

Cyclic: min. 100 ms

#### **Response time**

- Cyclic: max. 20 ms (for standard bus parameter settings)
- Acyclic: typical 70 ms (for standard bus parameter settings)

#### Damping

- A damping affects all outputs (output signal, display).
- Via on-site display, handheld terminal or PC with operating program, continuous from 0...999 s
- Via DIP-switch on the electronic insert, switch position "on" (= set value) and "off" (= damping switched off)
- Factory setting: 2 s

## Firmware version

Designation	Option 1)
01.00.zz, FF, DevRev01	76
01.00.zz, PROFIBUS PA, DevRev01	77
01.00.zz, HART, DevRev01	78

1) Product Configurator, "Firmware version" ordering feature

## Protocol-specific data

HART				
Manufacturer ID	17 (11 hex)			
Device Type Code	25 (19 hex)			
Device Revision	01 (01 hex) - SW version 01.00.zz			
HART spezification	6			
DD Revision	<ul><li>01 (netherlands)</li><li>02 (russian)</li></ul>			
Device description files (DTM, DD)	Information and files can be found: • www.endress.com • www.hartcomm.org			
HART load	Min. 250 Ω			
HART device variables	The measured values can be freely assigned to the device variables:			
	Measured values for PV (primary variable)  Pressure Level Tank content			
	<ul> <li>Measured values for SV, TV (second and third variable)</li> <li>Pressure</li> <li>Level</li> </ul>			
	Measured values for QV (fourth variable) <ul> <li>Temperature</li> </ul>			
Supported functions	<ul> <li>Burst mode</li> <li>Additional Transmitter Status</li> <li>Device Locking</li> <li>Alternative operating modes</li> </ul>			

# PROFIBUS PA

Manufacturer ID	17 (11 hex)
Ident number	1554 hex
Profile Version	3.02 • SW Version 01.00.zz
GSD Revision	5
DD Revision	1
GSD File	Information and files can be found:
DD Filos	<ul><li>www.endress.com</li><li>www.profibus.org</li></ul>
Output values	Measured values for PV (über Analog Input Function Block) <ul> <li>Pressure</li> <li>Flow</li> <li>Level</li> <li>Tank content</li> </ul>
	Measured values for SV <ul> <li>Pressure</li> <li>Temperature</li> </ul>
Input values	Input value sent from PLC, can be shown on display

Supported functions	<ul> <li>Identification &amp; Maintenance Simple device identification via control system and nameplate</li> <li>Condensed status<sup>1)</sup></li> <li>Automatic ident number adaptation and switchable to following ident numbers<sup>1)</sup>: <ul> <li>9700: Profile-specific transmitter identification number with the "Classic" or "Condensed" status".</li> <li>151C: Compatibility mode for the old Cerabar M (PMC41, PMC45, PMP41, PMP45, PMP46, PMP48).</li> <li>1553: Identification number for the new Cerabar M (PMC51, PMP51, PMP55).</li> </ul> </li> <li>Device locking: The device can be locked by hardware or software.</li> </ul>
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1) Only with Profile Version 3.02

# Data of the FOUNDATION Fieldbus interface

Device Type	0x1019
Device Revision	01 (hex)
DD Revision	0x01021
CFF Revision	0x000102
ITK Version	5.2.0
ITK Certification Driver No.	IT067700
Link-Master (LAS) capable	Yes
Link Master / Basic Device selectable	Yes; Factory setting: Basic Device
Number of VCRs	44
Number of Link Objects in VFD	50
Number of FB-Schedule Objects	40

# Virtual communication references (VCRs)

Permanent Entries	44
Client VCRs	0
Server VCRs	5
Source VCRs	8
Sink VCRs	0
Subscriber VCRs	12
Publisher VCRs	19

# Link settings

Slot time	4
Min. inter PDU delay	12
Max. response delay	40

## Transducer Blocks

Block	Content	Output values
TRD1 Block	Contains all parameters related to the measurement	<ul> <li>Pressure or level (channel 1)</li> <li>Process temperature (channel 2)</li> <li>Measured pressure value (channel 3)</li> <li>Max. pressure (channel 4)</li> <li>Level before linearization (channel 5)</li> </ul>
Diagnostic Block	Contains diagnostic information	<ul> <li>Error code via DI channels (channel 10 to 15)</li> </ul>
Display Block	Contains parameters to configure the onsite display	No output values

#### Function blocks

Block	Content	Number of blocks	Execution time	Functionality
Resource Block	The Resource Block contains all the data that uniquely identify the device. It is an electronic version of a nameplate of the device.	1		enhanced
Analog Input Block 1 Analog Input Block 2	The AI Block receives the measuring data from the Sensor Block, (selectable via a channel number) and makes the data available to other function blocks at its output. Enhancement: digital outputs for process alarms, fail safe mode.	2	25 ms	enhanced
Digital Input Block	This block contains the discrete data of the Diagnose Block (selectable via a channel number 10 to 15) and provides them for other blocks at the output.	1	20 ms	Standard
Digital Output Block	This block converts the discrete input and thus initiates an action (selectable via a channel number) in the DP Flow Block or in the im TRD1 Block. Channel 20 resets the counter for max. pressure transgressions value and Channel 21 resets the Totalizer.	1	20 ms	Standard
PID Block	The PID Block serves as a proportional-integral- derivative controller and is used almost universally for closed-loop-control in the field including cascade and feedforward. Input IN can be indicated on the display. The selection is performed in the Display Block (DISPLAY_MAIN_LINE_CONTENT).	1	40 ms	Standard
Arithmetic Block	This block is designed to permit simple use of popular measurement math functions. The user does not have to know how to write equations. The math algorithm is selected by name, chosen by the user for the function to be performed.	1	35 ms	Standard
Input Selector Block	The Input Selector Block facilitates the selection of up to four inputs and generates an output based on the configured action. This block normally receives its inputs from AI Blocks. The block performs maximum, minimum, average and 'first good' signal selection. Inputs IN1 to IN4 can be indicated on the display. The selection is performed in the Display Block (DISPLAY_MAIN_LINE_1_CONTENT).	1	30 ms	Standard
Signal Characterizer Block	The Signal Characterizer Block has two sections, each with an output that is a non-linear function of the respective input. The non-linear function is generated by a single look-up table with 21 arbitrary x-y pairs.	1	40 ms	Standard

Block	Content	Number of blocks	Execution time	Functionality
Integrator Block	The Integrator Block integrates a variable as a function of the time or accumulates the counts from a Pulse Input Block. The block may be used as a totalizer that counts up until reset or as a batch totalizer that has a setpoint, where the integrated or accumulated value is compared to pre-trip and trip settings, generating a binary signal when the setpoint is reached.	1	35 ms	Standard

#### Additional function block information:

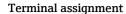
Instantiate Function Block Y	
Number of instantiate blocks	20

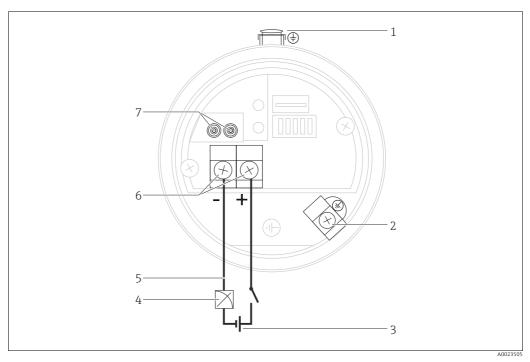
# **Power supply**

#### **A** WARNING

### Incorrect connection can limit electrical safety!

- When using the measuring device in hazardous areas, installation must comply with the ► corresponding national standards and regulations and the Safety Instructions or Installation or Control Drawings. → 🖹 111 ff, "Safety instructions" and "Installation/Control Drawings" ordering features.
- All explosion protection data are given in separate documentation which is available upon request. ► The Ex documentation is provided with all Ex-systems as standard  $\rightarrow$  111 ff, "Safety instructions" and "Installation/Control Drawings" ordering features.
- According to IEC/EN61010 a suitable disconnector has to be installed for the device
- ▶ HART: Overvoltage protection HAW569-DA2B for the non-hazardous area, ATEX II 2 (1) Ex ia IIC and IEC Ex ia can be ordered as an option (see "Ordering information" ordering feature).
  - Protective circuits against reverse polarity, HF influences and overvoltage peaks are installed.
- The digital communication signal is transmitted to the bus via a 2-wire connection. The bus also provides the power supply.





#### Electrical connection

- External grounding terminal 1
- Internal grounding terminal Supply voltage  $\rightarrow \square 20$ 2
- 3
- 4...20 mA for HART devices 4
- 5 For HART and FOUNDATION Fieldbus devices: With a handheld terminal, all the parameters can be configured anywhere along the bus line via menu operation. 6
- Terminals
- For HART devices: test terminals, see section "Taking 4 to 20 mA test signal"

#### Supply voltage

#### 4 to 20 mA HART

Type of protection	Supply voltage
<ul> <li>Intrinsically safe</li> </ul>	11.5 30 V DC
<ul><li>Other types of protection</li><li>Devices without certificate</li></ul>	11.5 to 45 V DC (versions with plug-in connection 35 V DC)

#### Taking 4 to 20 mA test signal

A 4 to 20 mA test signal may be measured via the test terminals without interrupting the measurement.

#### **PROFIBUS PA**

• Version for non-hazardous areas: 9 to 32 V DC

#### **FOUNDATION Fieldbus**

• Version for non-hazardous areas: 9 to 32 V DC

# Current consumption• PROFIBUS PA: 11 mA ± 1 mA, switch-on current corresponds to IEC 61158-2, Clause 21• FOUNDATION Fieldbus: 16 mA ± 1 mA, switch-on current corresponds to IEC 61158-2, Clause 21

#### **Electrical connection**

Cable entry	Degree of protection	Option <sup>1)</sup>
M20 gland	IP66/68 NEMA 4X/6P	А
G ½" thread	IP66/68 NEMA 4X/6P	С
NPT ½" thread	IP66/68 NEMA 4X/6P	D
M12 plug	IP66/67 NEMA 4X/6P	Ι
7/8" plug	IP66/68 NEMA 4X/6P	М
HAN7D connector, 90 deg	IP65	Р
PE cable 5m <sup>2)</sup>	IP66/68 NEMA4X/6P + pressure compensation via cable	S
M16 valve connector	IP64	V

1) Product Configurator, "Electrical connection" ordering feature

2) Only for FMB50

#### **PROFIBUS PA**

The digital communication signal is transmitted to the bus via a 2-wire connection. The bus also provides the power supply. For further information on the network structure and grounding, and for further bus system components such as bus cables, see the relevant documentation, e.g. Operating Instructions BA00034S "PROFIBUS DP/PA: Guidelines for planning and commissioning" and the PNO Guideline.

#### **FOUNDATION Fieldbus**

The digital communication signal is transmitted to the bus via a 2-wire connection. The bus also provides the power supply. For further information on the network structure and grounding and for further bus system components such as bus cables, see the relevant documentation, e.g. Operating Instructions BA00013S "FOUNDATION Fieldbus Overview" and the FOUNDATION Fieldbus Guideline.

#### Terminals

Cable entry

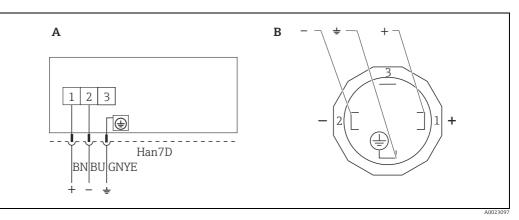
For wire cross-sections of 0.5 to  $2.5 \text{ mm}^2$  (20 to 14 AWG).

Approval	Туре	Clamping area
Standard, CSA GP ATEX II1/2G or II2G Ex ia, IEC Ex ia Ga/Gb or Ex ia Gb, FM/ CSA IS	Plastic M20x1.5	5 to 10 mm (0.2 to 0.39 in)
ATEX II1/2D Ex t, II1/2GD Ex ia, II3G Ex nA, IEC Ex t Da/Db	Metal M20x1.5 (Ex e)	7 to 10.5 mm (0.28 to 0.41 in)

For other technical data, see the housing section  $\rightarrow$   $\triangleq$  41 ff'.

#### Connector

### Devices with valve connector

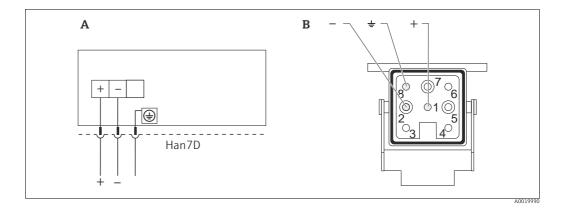


BN = brown, BU = blue, GNYE = green/yellow

Electrical connection for devices with valve connector View of the connection on the device A B

#### Material: PA 6.6

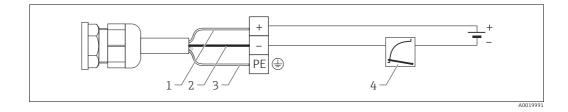
#### Devices with Harting plug Han7D



A B Electrical connection for devices with Harting plug Han7D View of the connection on the device

Material: CuZn, gold-plated contacts of plug-in jack and connector

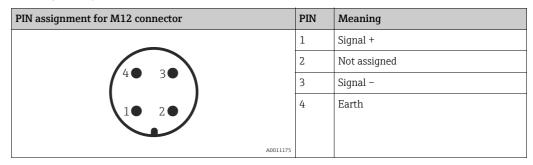
#### Connecting the cable version



- 1
- rd = red bk = black 2 3 4
- gnye = green 4 to 20 mA

#### Devices with M12 plug

PIN assignment for M12 connector



Endress+Hauser offers the following accessories for devices with an M12 plug: Plug-in jack M 12x1, straight

- Material: body PA; coupling nut CuZn, nickel-plated
- Degree of protection (fully locked): IP66/67
- Order number: 52006263

Plug-in jack M 12x1, elbowed

- Material: body PBT/PA; coupling nut GD-Zn, nickel-plated
- Degree of protection (fully locked): IP66/67
- Order number: 71114212

Cable 4x0.34 mm<sup>2</sup> (20 AWG) with M12 socket, elbowed, screw plug, length 5 m (16 ft)

- Material: body PUR; coupling nut CuSn/Ni; cable PVC
- Degree of protection (fully locked): IP66/67
- Order number: 52010285

#### Devices with 7/8" plug

PIN assignment for 7/8" connector

PIN assignment for 7/8" connector		Meaning
	1	Signal –
	2	Signal +
	3	Not assigned
	4	Shield
A0011176		

External thread: 7/8 - 16 UNC

- Material: 316L (1.4401)
- Protection: IP66/68

#### **Cable specification**

# HART

- Endress+Hauser recommends using twisted, shielded two-wire cables.
- The cable outer diameter depends on the cable entry used.

#### PROFIBUS PA

Use a twisted, shielded two-wire cable, preferably cable type A

# i

For further information on the cable specifications, see Operating Instructions BA00034S "PROFIBUS DP/PA: Guidelines for planning and commissioning", the PNO Guideline 2.092 PROFIBUS PA User and Installation Guideline" and IEC 61158-2 (MBP).

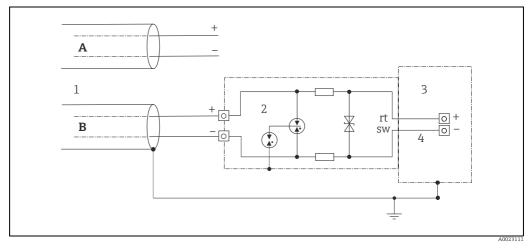
#### **FOUNDATION Fieldbus**

Use a twisted, shielded two-wire cable, preferably cable type A

# i

For further information on the cable specifications, see Operating Instructions BA00013S "FOUNDATION Fieldbus Overview", FOUNDATION Fieldbus Guideline and IEC 61158-2 (MBP).

Start-up current	<ul> <li>Analog electronics: 12 mA</li> <li>HART: 12 mA or 22 mA (selectable)</li> </ul>
Residual ripple	No influence on 4 to 20 mA signal up to $\pm$ 5 % residual ripple within the permitted voltage range [according to HART hardware specification HCF_SPEC-54 (DIN IEC 60381-1)]
Influence of power supply	$\leq 0.001$ % of URL/V
Overvoltage protection (optional)	The device can be fitted with overvoltage protection. The overvoltage protection is mounted at the factory on the housing thread (M20x1.5) for the cable gland and is approx. 70 mm (2.76 in) in length (take additional length into account when installing). The device is connected as illustrated in the following graphic. For details refer to TI001013KEN, XA01003KA3 and BA00304KA2. Ordering information: Product Configurator, "Mounted accessories" ordering feature, option NA

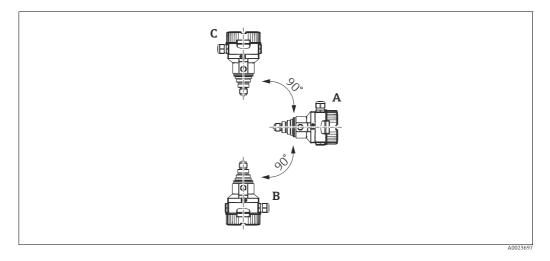


- Without direct shield grounding
- With direct shield grounding
- A B 1 2 3 4 Incoming connection cable HAW569-DA2B
- Unit to be protected
- Connection cable

# Performance characteristics of the ceramic process isolating diaphragm

<ul> <li>Input of LOW SENSOR TRIM and HIGH SENSOR TRIM for lower range value and upper range value</li> <li>Span based on zero point</li> <li>Material of the process isolating diaphragm: Al<sub>2</sub>O<sub>3</sub> (aluminum-oxide ceramic, Ceraphire<sup>®</sup>)</li> <li>Supply voltage: 24 V DC ± 3 V DC</li> <li>Load with HART: 250 Ω</li> </ul>	Reference operating conditions	<ul> <li>Span based on zero point</li> <li>Material of the process isolating diaphragm: Al<sub>2</sub>O<sub>3</sub> (aluminum-oxide ceramic, Ceraphire<sup>®</sup>)</li> <li>Supply voltage: 24 V DC ± 3 V DC</li> </ul>
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## Influence of orientation



#### Measuring error in mbar (psi)

Process isolating diaphragm axis is horizontal (A)	Process isolating diaphragm pointing upwards (B)	Process isolating diaphragm pointing downwards (C)
Calibration position, no measuring error	< +0.2 mbar (0.003 psi)	< -0.2 mbar (0.003 psi)



Position-dependent zero point shift can be corrected at the device.  $\rightarrow \triangleq 34$ , "General installation instructions" ordering feature and  $\rightarrow \triangleq 102$  ff, "Installation instructions" ordering feature.

Uncertainty of measurement for small absolute pressure ranges

The smallest expanded uncertainty of measurement that can be returned by our standards is: • 0.4% of the measured value in the range of 1 to 30 mbar

• 1% of the measured value in the range < 1 mbar.

Reference accuracy - PMC51The reference accuracy comprises the non-linearity according to limit point setting, hysteresis and<br/>non-reproducibility as per IEC 60770. The data refer to the calibrated span.

Gauge pressure sensors			
Measuring cell	Standard reference accuracy	Platinum reference accuracy	
100 mbar (1.5 psi)	<ul> <li>TD 1:1 to ≤ TD 10:1 = ±0.15 %</li> <li>TD &gt; 10:1 to TD 20:1 = ±0.2 %</li> </ul>	<ul> <li>TD 1:1 to ≤ TD 10:1 = ±0.075 %</li> <li>TD &gt; 10:1 to TD 20:1 = ±0.0075 x TD</li> </ul>	
250 mbar (3.75 psi), 400 mbar (6 psi), 1 bar (15 psi), 2 bar (30 psi), 4 bar (60 psi), 10 bar (150 psi)	<ul> <li>TD 1:1 to ≤ TD 10:1 = ±0.15 %</li> <li>TD &gt; 10:1 to TD 20:1 = ±0.2 %</li> </ul>	<ul> <li>TD 1:1 to ≤ TD 10:1 = ±0.075 %</li> <li>TD &gt; 10:1 to TD 20:1 = ±0.1 %</li> </ul>	
40 bar (600 psi)	<ul> <li>TD 1:1 to ≤ TD 10:1 = ±0.15 %</li> <li>TD &gt; 10:1 to TD 20:1 = ±0.2 %</li> </ul>	<ul> <li>TD 1:1 to ≤ TD 10:1 = ±0.075 %</li> <li>TD &gt; 10:1 to TD 20:1 = ±0.0075 x TD</li> </ul>	

Absolute pressure sensors			
Measuring cell	Standard reference accuracy	Platinum reference accuracy	
100 mbar (1.5 psi)	<ul> <li>TD 1:1 to ≤ TD 10:1 = ±0.15 %</li> <li>TD &gt; 10:1 to TD 20:1 = ±0.015 x TD</li> </ul>	<ul> <li>TD 1:1 to TD 5:1 = ±0.075 %</li> <li>TD &gt; 5:1 to TD 20:1 = ±0.015 x TD</li> </ul>	
250 mbar (3.75 psi)	<ul> <li>TD 1:1 to ≤ TD 10:1 = ±0.15 %</li> <li>TD &gt; 10:1 to TD 20:1 = ±0.2 %</li> </ul>	<ul> <li>TD 1:1 to ≤ TD 10:1 = ±0.075 %</li> <li>TD &gt; 10:1 to TD 13:1 = ±0.1 %</li> </ul>	
400 mbar (6 psi), 1 bar (15 psi), 2 bar (30 psi), 4 bar (60 psi), 10 bar (150 psi)	<ul> <li>TD 1:1 to ≤ TD 10:1 = ±0.15 %</li> <li>TD &gt; 10:1 to TD 20:1 = ±0.2 %</li> </ul>	<ul> <li>TD 1:1 to ≤ TD 10:1 = ±0.075 %</li> <li>TD &gt; 10:1 to TD 20:1 = ±0.1 %</li> </ul>	
40 bar (600 psi)	<ul> <li>TD 1:1 to ≤ TD 10:1 = ±0.15 %</li> <li>TD &gt; 10:1 to TD 20:1 = ±0.2 %</li> </ul>	<ul> <li>TD 1:1 to ≤ TD 10:1 = ±0.075 %</li> <li>TD &gt; 10:1 to TD 20:1 = ±0.0075 x TD</li> </ul>	

# Thermal change in the zero PMC51 with thread or flange output and the output span – PMC51

Signal output	Measuring cell	% of the calibrated measuring span		
		-40 to -20 °C (-40 to -4°F)	−10 to +60 °C (+14 to +140°F)	−20 to +100 °C (−4 to +212°F)
HART,	100 mbar (1.5 psi), 250 mbar (3.75 psi), 400 mbar (6 psi)	±(0.6 + 0.45 x TD)	±0.2 + 0.275 x TD	±(0.4 + 0.425 x TD)
PROFIBUS PA, FOUNDATION Fieldbus	1 bar (15 psi), 2 bar (30 psi), 4 bar (60 psi), 10 bar (150 psi), 40 bar (600 psi)	±0.5 + 0.35 x TD	±0.1 + 0.15 x TD	±(0.225 + 0.525 x TD)
Analog (4 to 20 mA)	100 mbar (1.5 psi), 250 mbar (3.75 psi), 400 mbar (6 psi)	±(0.6 + 0.45 x TD)	±0.4 + 0.275 x TD	±0.7 + 0.425 x TD
	1 bar (15 psi), 2 bar (30 psi), 4 bar (60 psi), 10 bar (150 psi), 40 bar (600 psi)	±0.5 + 0.35 x TD	±0.3 + 0.15 x TD	±0.525 + 0.525 x TD

## PMC51 with hygienic process connection

Signal output	Measuring cell	% of the calibrated measuring span		
		-10 to +60 °C (+14 to +140°F)	−20 to +130 °C (−4 to +266°F)	
HART, PROFIBUS PA.	100 mbar (1.5 psi), 250 mbar (3.75 psi), 400 mbar (6 psi)	±(0.4 + 0.275 x TD)	±(0.7 + 0.425 x TD)	
FOUNDATION Fieldbus	1 bar (15 psi), 2 bar (30 psi), 4 bar (60 psi), 10 bar (150 psi), 40 bar (600 psi)	±(0.3 + 0.15 x TD)	±(0.525 + 0.525 x TD)	
Analog (4 to 20 mA)	100 mbar (1.5 psi), 250 mbar (3.75 psi), 400 mbar (6 psi)	±(0.4 + 0.275 x TD)	±(0.7 + 0.425 x TD)	
	1 bar (15 psi), 2 bar (30 psi), 4 bar (60 psi), 10 bar (150 psi), 40 bar (600 psi)	±(0.3 + 0.15 x TD)	±(0.525 + 0.525 x TD)	

#### Total performance – PMC51

The "Total performance" specification comprises the non-linearity including hysteresis, non-reproducibility as well as the thermal change in the zero point. All specifications apply to the temperature range -10 to +60 °C (+14 to +140°F) and Turndown 1:1.

Signal output	Measuring cell	% URL
HART, PROFIBUS	100 mbar (1.5 psi), 250 mbar (3.75 psi), 400 mbar (6 psi)	±0.575
PA, FOUNDATION Fieldbus	1 bar (15 psi), 2 bar (30 psi), 4 bar (60 psi), 10 bar (150 psi), 40 bar (600 psi)	±0.5
	100 mbar (1.5 psi), 250 mbar (3.75 psi), 400 mbar (6 psi)	±0.775
Analog (4 to 20 mA)	1 bar (15 psi), 2 bar (30 psi), 4 bar (60 psi), 10 bar (150 psi), 40 bar (600 psi)	±0.7

## Long-term stability

## For devices with thread or flange:

Measuring range	Long-term stability of URL / 1 year	Long-term stability of URL / 5 years	Long-term stability of URL / 10 years
$\leq$ 1 bar (15 psi)	±0.2 %	±0.4 %	±0.5 %
> 1 bar (15 psi)	±0.1 %	±0.25 %	±0.4 %

#### For devices with hygienic process connections:

Measuring range	Long-term stability of URL / 1 year	
≤ 1 bar (15 psi)	±0.35 %	
> 1 bar (15 psi)	±0.2 %	

## Total error - PMC51

The total error comprises the long-term stability and the total performance. All specifications apply to the temperature range -10 to +60 °C (+14 to +140°F) and Turndown 1:1.

	Signal output	Measuring cell	% URL
			1 year
PMC51 with thread or flange		100 mbar (1.5 psi), 250 mbar (3.75 psi), 400 mbar (6 psi)	±0.55
	HART, PROFIBUS PA, FOUNDATION Fieldbus	1 bar (15 psi), 2 bar (30 psi), 4 bar (60 psi), 10 bar (150 psi), 40 bar (600 psi)	±0.47
		100 mbar (1.5 psi), 250 mbar (3.75 psi), 400 mbar (6 psi)	±0.75
	Analog (4 to 20 mA)	1 bar (15 psi), 2 bar (30 psi), 4 bar (60 psi), 10 bar (150 psi), 40 bar (600 psi)	±0.67
	I		I
PMC51 with hygienic process	HART, PROFIBUS PA,	100 mbar (1.5 psi), 250 mbar (3.75 psi), 400 mbar (6 psi)	±0.925
connection	FOUNDATION Fieldbus	1 bar (15 psi), 2 bar (30 psi), 4 bar (60 psi), 10 bar (150 psi), 40 bar (600 psi)	±0.7
		100 mbar (1.5 psi), 250 mbar (3.75 psi), 400 mbar (6 psi)	±1.125
	Analog (4 to 20 mA)	1 bar (15 psi), 2 bar (30 psi), 4 bar (60 psi), 10 bar (150 psi), 40 bar (600 psi)	±0.9

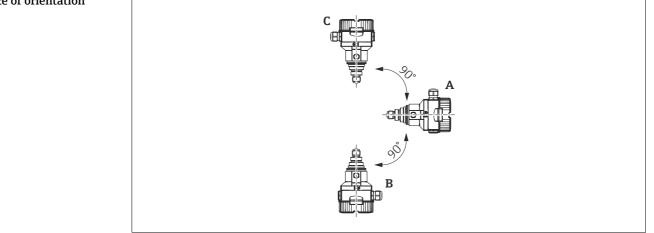
Warm-up period

- 4 to 20 mA analog:  $\leq$ 1.5 s
- 4 to 20 mA HART: ≤5 s
- PROFIBUS PA: ≤8 s
- FOUNDATION Fieldbus: ≤20 s (after a TOTAL-reset ≤45 s)

# Performance characteristics of the metallic process isolating diaphragm

Reference operating conditions	<ul> <li>As per IEC 60770</li> <li>Ambient temperature T<sub>A</sub> = constant, in the range of: +21 to +33 °C (+70 to +91°F)</li> <li>Humidity φ = constant, in the range of: 5 to 80 % RH</li> <li>Ambient pressure p<sub>A</sub> = constant, in the range of: 860 to 1060 mbar (12.47 to 15.37 psi)</li> <li>Position of the measuring cell: constant, in range: ±1° horizontally</li> <li>Input of LOW SENSOR TRIM and HIGH SENSOR TRIM for lower range value and upper range value</li> <li>Span based on zero point</li> <li>Material of the process isolating diaphragm: AISI 316L</li> <li>Filling oil: NSF-H1 synthetik oil according to FDA 21 CFR 178 3570</li> </ul>
	<ul> <li>Filling oil: NSF-H1 synthetik oil according to FDA 21 CFR 178.3570</li> <li>Supply voltage: 24 V DC ± 3 V DC</li> </ul>
	• Load with HART: 250 $\Omega$

#### Influence of orientation



#### Measuring error in mbar (psi)

	Process isolating diaphragm axis is horizontal (A)	Process isolating diaphragm pointing upwards (B)	Process isolating diaphragm pointing downwards (C)
PMP51 with process connections <sup>1</sup> ⁄ <sub>2</sub> " thread and Silicone oil	Calibration position,	< +4 mbar (0.06 psi)	< -4 mbar (0.06 psi)
PMP51 with process connections > thread ½" and flanges	no measuring error	< +10 mbar (0.145 psi) This value is doubled for inert oil.	< -10 mbar (0.145 psi) This value is doubled for inert oil.

# i

Position-dependent zero point shift can be corrected at the device.  $\rightarrow \square 34$ , "General installation instructions" ordering feature and  $\rightarrow \square 102$  ff, "Installation instructions" ordering feature.

# Uncertainty of measurement for small absolute pressure ranges

- The smallest expanded uncertainty of measurement that can be returned by our standards is:
- 0.4% of the measured value in the range of 1 to 30 mbar
  1% of the measured value in the range < 1 mbar.</li>

#### Reference accuracy – PMP51, PMP55

The reference accuracy comprises the non-linearity according to limit point setting, hysteresis and non-reproducibility as per IEC 60770. The data refer to the calibrated span.

#### Gauge pressure sensors/absolute pressure sensors

	PMP51 and PMP55 without capillary			
Measuring cell	Standard reference accuracy	Platinum reference accuracy <sup>1)</sup>		
	<ul> <li>TD 1:1 = ±0.15 %</li> <li>TD &gt;1:1 to TD 20:1 = ±0.15 % x TD</li> </ul>	Not available		
400 mbar (6 psi)	<ul> <li>PMP51 with hygienic process connection:</li> <li>TD 1:1 = ±0.3 %</li> <li>TD &gt;1:1 to TD 10:1 = ±0.3 % x TD</li> </ul>	Not available		
	<ul> <li>TD 1:1 to TD 5:1 = ±0.15 %</li> <li>TD &gt;5:1 to TD 20:1 = ±0.03 % x TD</li> </ul>	<ul> <li>TD 1:1 to TD 2.5:1 = ±0.075 %</li> <li>TD &gt;2.5:1 to TD 20:1 = ±0.03 % x TD</li> </ul>		
1 bar (15 psi)	<ul> <li>PMP51 with hygienic process connection:</li> <li>TD 1:1 = ±0.3 %</li> <li>TD &gt;1:1 to TD 10:1 = ±0.3 % x TD</li> </ul>	<ul> <li>PMP51 with hygienic process connection:</li> <li>TD 1:1 = ±0.2 %</li> <li>TD &gt;1:1 to TD 10:1 = ±0.2 % x TD</li> </ul>		
2 bar (30 psi)	<ul> <li>TD 1:1 to TD 10:1 = ±0.15 %</li> <li>TD &gt;10:1 to TD 20:1 = ±0.015 % x TD</li> </ul>	<ul> <li>TD 1:1 to TD 5:1 = ±0.075 %</li> <li>TD &gt;5:1 to TD 20:1 = ±0.015 % x TD</li> </ul>		
	PMP51 with hygienic process connection: ■ TD 1:1 to TD ≤5:1 = ±0.15 % ■ TD >5:1 to TD ≤10:1 = ±0.2 %	<ul> <li>PMP51 with hygienic process connection:</li> <li>TD 1:1 to TD ≤5:1 = ±0.075 %</li> <li>TD &gt;5:1 to TD ≤10:1 = ±0.1 %</li> </ul>		
4 bar (60 psi)	<ul> <li>TD 1:1 to TD 10:1 = ±0.15 %</li> <li>TD &gt;10:1 to TD 20:1 = ±0.2 %</li> </ul>	<ul> <li>TD 1:1 to TD 10:1 = ±0.075 %</li> <li>TD 10:1 to TD 20:1 = ±0.0075 % x TD</li> </ul>		
	PMP51 with hygienic process connection: • TD 1:1 to TD ≤10:1 = ±0.15 % • TD >10:1 to TD 20:1 = ±0.2 %	PMP51 with hygienic process connection: ■ TD 1:1 to TD ≤10:1 = ±0.075 % ■ TD >10:1 to TD 20:1 = ±0.1 %		
10 bar (150 psi), 40 bar (600 psi)	<ul> <li>TD 1:1 to TD 10:1 = ±0.15 %</li> <li>TD &gt;10:1 to TD 20:1 = ±0.2 %</li> </ul>	<ul> <li>TD 1:1 to TD 10:1 = ±0.075 %</li> <li>TD 10:1 to TD 20:1 = ±0.1 %</li> </ul>		
	PMP51 with hygienic process connection: ■ TD 1:1 to TD ≤10:1 = ±0.15 % ■ TD >10:1 to TD 20:1 = ±0.2 %	PMP51 with hygienic process connection: ■ TD 1:1 to TD ≤10:1 = ±0.075 % ■ TD >10:1 to TD 20:1 = ±0.1 %		
100 bar (1500 psi)	<ul> <li>TD 1:1 to TD 10:1 = ±0.15 %</li> <li>TD &gt;10:1 to TD 20:1 = ±0.2 %</li> </ul>	<ul> <li>TD 1:1 to TD 10:1 = ±0.075 %</li> <li>TD 10:1 to TD 20:1 = ±0.15 %</li> </ul>		
400 bar (6000 psi)	<ul> <li>TD 1:1 to TD 5:1 = ±0.15 %</li> <li>TD &gt;5:1 to TD 20:1 = ±(0.03 % x TD)</li> </ul>	<ul> <li>TD 1:1 to TD 5:1 = ±0.15 %</li> <li>TD &gt;5:1 to TD 20:1 = ±(0.03 % x TD)</li> </ul>		

1) Only PMP51, PMP55 with direct diaphragm seal mounting

#### Gauge pressure sensors/absolute pressure sensors

Measuring cell	PMP55 with capillary
400 mbar (6 psi)	<ul> <li>TD 1:1 = ±0.15 %</li> <li>TD &gt;1:1 to TD 20:1 = ±0.15 % x TD</li> </ul>
1 bar (15 psi)	<ul> <li>TD 1:1 to TD 3.75:1 = ±0.15 %</li> <li>TD &gt;3.75:1 to TD 20:1 = ±0.04 % x TD</li> </ul>
2 bar (30 psi)	<ul> <li>TD 1:1 to TD 3.75:1 = ±0.15 %</li> <li>TD &gt;3.75:1 to TD 20:1 = ±0.04 % x TD</li> </ul>
4 bar (60 psi)	<ul> <li>TD 1:1 to TD 10:1 = ±0.15 %</li> <li>TD &gt;10:1 to TD 20:1 = ±0.2 %</li> </ul>
10 bar (150 psi), 40 bar (600 psi)	<ul> <li>TD 1:1 to TD 10:1 = ±0.15 %</li> <li>TD &gt;10:1 to TD 20:1 = ±0.2 %</li> </ul>
100 bar (1500 psi)	<ul> <li>TD 1:1 to TD 10:1 = ±0.15 %</li> <li>TD &gt;10:1 to TD 20:1 = ±0.2 %</li> </ul>
400 bar (6000 psi)	<ul> <li>TD 1:1 to TD 5:1 = ±0.15 %</li> <li>TD &gt;5:1 to TD 20:1 = ±(0.03 % x TD)</li> </ul>

#### Thermal change in the zero output and the output span – PMP51 and PMP55



When using a PMP55, the influence from the respective diaphragm seal must also be taken into account ( $\rightarrow \exists$  99 ff "Planning instructions for diaphragm seal systems").

## PMP51 and PMP55 (basic device)

Measuring cell	−10 to +60 °C (+14 to +140°F)	-40 to −10 °C, +60 to +85 °C (-40 to +14°F, +140 to +185°F)
	% of the calibrate	d measuring span
400 mbar (6 psi), 1 bar (15 psi), 2 bar (30 psi), 4 bar (60 psi), 10 bar (150 psi), 40 bar (600 psi), 100 bar (1500 psi)	±(0.34 + 0.15 x TD)	±(0.4 + 0.25 x TD)
400 bar (6000 psi)	±(0.3 + 0.35 x TD)	±(0.3 + 0.7 x TD)

#### PMP51 with hygienic process connection

Signal output	Measuring cell	−10 to +60 °C (+14 to +140°F)	-40 to −10 °C, +60 to +125 °C (-40 to +14°F, +140 to +257°F)
		% of the calibrate	d measuring span
	Clamp 1/2" / 400 mbar (6 psi)	$\pm (0.1 + 0.4 \text{ x TD})$	±(0.8 + 1.5 x TD)
HART, PROFIBUS PA, FOUNDATION	400 mbar (6 psi), 1 bar (15 psi)	±(0.1 + 0.25 x TD)	±(0.1 + 1.1 x TD)
Fieldbus	2 bar (30 psi), 4 bar (60 psi), 10 bar (150 psi), 40 bar (600 psi)	±(0.1 + 0.2 x TD)	±(0.1 + 0.5 x TD)
Analog (4 to 20 mA)	Clamp 1/2" / 400 mbar (6 psi)	±(0.3 + 0.4 x TD)	±(1.1 + 1.5 x TD)
	400 mbar (6 psi), 1 bar (15 psi)	±(0.3 + 0.25 x TD)	±(0.4 + 1.1 x TD)
	2 bar (30 psi), 4 bar (60 psi), 10 bar (150 psi), 40 bar (600 psi)	±(0.3 + 0.2 x TD)	±(0.4 + 0.5 x TD)

### Total performance - PMP51

The "Total performance" specification comprises the non-linearity including hysteresis, non-reproducibility as well as the thermal change in the zero point. All specifications apply to the temperature range -10 to +60 °C (+14 to +140°F) and Turndown 1:1.

Signal output	Measuring cell	PMP51	PMP51 with hygienic process connection	PMP51 with gold/rhodium-coated process isolating diaphragm
			% of URL	
	400 mbar (6 psi)		±0.34	±1.25
	1 bar (15 psi)	±0.34	±0.25	±0.75
HART.	2 bar (30 psi)		±0.25	±0.45
PROFIBUS PA,	4 bar (60 psi)	±0.30	±0.25	±0.3
FOUNDATION Fieldbus	10 bar (150 psi), 40 bar (600 psi)	±0.25	±0.25	±0.25
	100 bar (1500 psi)	±0.25	-	±0.25
	400 bar (6000 psi)	±0.4	-	±0.4
	400 mbar (6 psi)	±0.34	±0.54	±1.25
	1 bar (15 psi)		±0.54	±0.75
	2 bar (30 psi)		±0.45	±0.45
Analog	4 bar (60 psi)	±0.30	±0.45	±0.3
(4 to 20 mA)	10 bar (150 psi), 40 bar (600 psi)	±0.25	±0.45	±0.25
	100 bar (1500 psi)	±0.25	-	±0.25
	400 bar (6000 psi)	±0.4	-	±0.4

## Long-term stability

# For devices with thread or flange:

	Measuring range	Long-term stability of URL / 1 year	Long-term stability of URL / 5 years	Long-term stability of URL / 10 years
	≤ 1 bar (15 psi)	±0.2 %	±0.4 %	±0.5 %
	> 1 bar10 bar (15150 psi)	±0.1 %	±0.175 %	±0.4 %
PMP51	40 bar (600 psi)	±0.1 %	±0.2 %	±0.4 %
	100 bar (1500 psi)	±0.1 %	±0.25 %	±0.2 %
	400 bar (6000 psi)	±0.1 %	±0.25 %	±0.1 %

For devices with hygienic process connections:

	Measuring range	Long-term stability of URL / 1 year
	$\leq$ 1 bar (15 psi)	±0.25 %
	> 1 bar10 bar (15150 psi)	±0.1 %
PMP51	40 bar (600 psi)	±0.1 %
	100 bar (1500 psi)	±0.1 %
	400 bar (6000 psi)	±0.1 %

#### Total error - PMP51

The total error comprises the long-term stability and the total performance. All specifications apply to the temperature range -10 to +60 °C (+14 to +140°F) and Turndown 1:1.

Signal output	Measuring cell	% of URL/year	
HART, PROFIBUS PA, FOUNDATION Fieldbus	400 mbar (6 psi)	±0.59	
	$\geq$ 1 bar to 40 bar (15 psi to 600 psi)	±0.35	
	≥40 bar to 100 bar (600 psi to 1500 psi)	±0.35	
	400 bar (6000 psi)	±0.5	
Analog (4 to 20 mA)	400 mbar (6 psi)	±0.79	
	$\geq$ 1 bar to 40 bar (15 psi to 600 psi)	±0.55	
	$\geq$ 40 bar to 100 bar (600 psi to 1500 psi)	±0.55	
	400 bar (6000 psi)	±0.5	

Warm-up period

- 4 to 20 mA analog:  $\leq$ 1.5 s
- 4 to 20 mA HART:  $\leq$ 5 s
- PROFIBUS PA: ≤8 s
- FOUNDATION Fieldbus:  $\leq$ 20 s (after a TOTAL-reset  $\leq$ 45 s)

	Instanation		
General installation instructions	<ul> <li>The position-dependent zero point shift can be corrected:         <ul> <li>directly at the device via operating keys on the electronic insert</li> <li>directly at the device via operating keys on the display (except analog electronics)</li> <li>via digital communication if the cover is not open (except analog electronics)</li> </ul> </li> <li>WARNING</li> </ul>		
	<b>Risk of explosion!</b> In hazardous areas, comply strictly with the safety instructions when the housing cover is closed and open.		
	<ul> <li>Endress+Hauser offers a mounting bracket for installing the device on pipes or walls, see also →  34, "Wall and pipe mounting" ordering feature.</li> <li>Use flushing rings for flange and cell diaphragm seals if medium buildup or clogging can be expected at the diaphragm seal connection. The flushing ring can be inserted between the process connection and the diaphragm seal. Thanks to the two lateral flushing bore holes, material buildup in front of the process isolating diaphragm can be rinsed away and the pressure chamber can be ventilated.</li> <li>To guarantee the leak-tightness of the transmitter, Endress+Hauser recommends that only genuine cable glands be used (also available as spare parts).</li> </ul>		
Measuring arrangement for devices without diaphragm seal – PMC51, PMP51	Cerabar M transmitters without diaphragm seals are mounted as per the norms for a manometer (DIN EN 837-2). We recommend the use of shutoff devices and siphons. The orientation depends on the measuring application.		
	Pressure measurement in gases		
	Mount Cerabar M with shutoff device above the tapping point so that any condensate can flow into the process.		
	Pressure measurement in steams		
	<ul> <li>Use a siphon if measuring pressure in steams. The siphon reduces the temperature to almost the ambient temperature. Preferably mount the Cerabar S with a siphon below the tapping point. Advantages: <ul> <li>Defined water column only causes minimal/negligible measured errors</li> <li>Only minimal/negligible thermal effects on the device</li> </ul> </li> <li>The device may also be mounted above the tapping point. Pay attention to the maximum permitted ambient temperature of the transmitter!</li> <li>Fill the siphon with liquid before commissioning.</li> </ul>		
	Pressure measurement in liquids		
	Mount Cerabar M with shutoff device below or at the same level as the tapping point.		
	Level measurement		
	<ul> <li>Mount Cerabar M below the lowest measuring point (zero point of the measurement).</li> <li>Do not mount the device at the following positions: In the filling curtain, in the tank outlet or at a point in the vessel which could be affected by pressure pulses from an agitator or a pump.</li> <li>The calibration and functional test can be carried out more easily if you mount the device</li> </ul>		
	downstream of a shutoff device.		
	downstream of a shutoff device. → 🖹 99, "Planning instructions for diaphragm seal systems" ordering feature.		
Measuring arrangement for devices with diaphragm seal – PMP55 Wall and pipe mounting			

# Installation

#### "Separate housing" version

With the "separate housing" version, you are able to mount the housing with the electronics insert at a distance from the measuring point. This version allows for trouble-free measurement:

- Under particularly difficult measuring conditions (at installation locations that are cramped or difficult to access)
- If quick cleaning of the measuring point is required
- If the measuring point is exposed to vibrations

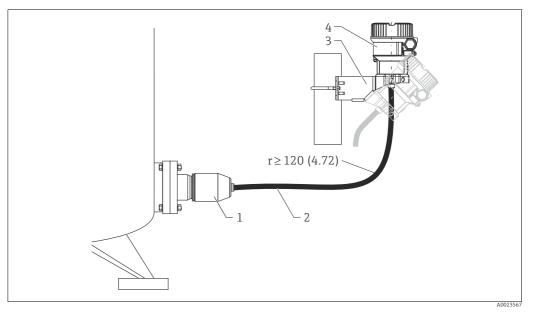
You can choose between different cable versions:

- PE (2 m (6.6 ft), 5 m (16 ft) and 10 m (33 ft))
- FEP (5 m (16 ft)).
- Ordering information:

Product Configurator, "Separate housing" ordering feature or

Product Configurator, "Enclosed accessories" ordering feature, option PA

For the dimensions, see  $\rightarrow \ge 86$ .



#### Engineering unit mm (in)

In the case of the "separate housing" version, the sensor is delivered with the process connection and cable ready mounted. The housing and a mounting bracket are enclosed as separate units. The cable is provided with a socket at both ends. These sockets are simply connected to the housing and the sensor.

- Process connection with sensor see the following section for the degrees of protection
- 2 Cable, both ends are fitted with a socket
- 3 Mounting bracket provided, suitable for pipe and wall mounting (for pipes from 1 1/4" up to 2" diameter) 4
- Housing with electronic insert degrees of protection  $\rightarrow \square 37 \, \text{ff}$

Degree of protection for the process connection and sensor with the use of

- FEP cable:
  - IP 69K
  - IP 66 NEMA 4/6P
  - IP 68 (1.83 mH<sub>2</sub>O for 24 h) NEMA 4/6P
- PE cable:
  - IP 66 NEMA 4/6P
  - IP 68 (1.83 mH<sub>2</sub>O for 24 h) NEMA 4/6P

Technical data of the PE and FEP cable:

- Minimum bending radius: 120 mm (4.72 in)
- Cable extraction force: max. 450 N (101 lbf)
- Resistance to UV light

Use in hazardous area:

- Intrinsically safe installations (Ex ia/IS)
- FM/CSA IS: for Div.1 installation only

#### **Oxygen applications**

Oxygen and other gases can react explosively to oils, grease and plastics. As a result, the following are some of the precautions that must be taken:

- All components of the system, such as measuring devices, must be cleaned in accordance with the BAM (DIN 19247) requirements.
- Depending on the materials used, a certain maximum temperature and maximum pressure must not be exceeded for oxygen applications.

The devices suitable for gaseous oxygen applications are listed in the following table with the specification  $\mathbf{p}_{\text{max}}$ 

	Ordering code for devices <sup>1)</sup> cleaned for oxygen applications	p <sub>max</sub> for oxygen applications	T <sub>max</sub> for oxygen applications	
	PMC51 <sup>2)</sup> – devices with sensors, nominal value < 10 bar (150 psi)	Over pressure limit (OPL) of sensor <sup>3), 4)</sup>	60 °C (140°F)	
	PMC51 <sup>2)</sup> − devices with sensors, nominal value $\ge$ 10 bar (150 psi)	40 bar (600 psi)	60 °C (140°F)	
	PMP51 PMP55 <sup>2)</sup>	Depends on the lowest-rated element, with regard to pressure, of the selected components: over pressure limit (OPL) of sensor <sup>3</sup> , process connection (1.5 x PN) or fill fluid (160 bar (2320 psi))	85 °C (185°F)	
	1) Only device, not accessory or enclosed accessory			
	2) Product Configurator, "Service"			
	3) Product Configurator, "Sensor range" ordering feature			
	4) PMC51 with PVDF thread or I	PVDF flange p <sub>max</sub> = 15 bar (225 psi)		
PWIS cleaning	Special cleaning of the transmitter to remove paint-wetting substances, for use in paint shops, for instance. Ordering information: Product Configurator, "Service" ordering feature, option HC The resistance of the materials used must be checked before the materials are used in the medium.			
Ultrapure gas applications (PMC51 and PMP51)	Endress+Hauser also provides devices which have been cleaned of oil and grease for special applications, such as for ultrapure gas. No special restrictions regarding the process conditions apply to these devices. Ordering information: Product Configurator, "Service" ordering feature, option "HA"			
Applications with hydrogen (PMP51 and PMP55)	With regard to materials in which hydrogen formation takes place (e.g. digested sludge), hydrogen atoms can diffuse through the metallic process isolating diaphragm. This can result in incorrect measurement results. Endress+Hauser offers process isolating diaphragms with a gold/rhodium coating for such instances. Ordering information: Product Configurator, "Process isolating diaphragm material" ordering feature, option L			
	NOTICE Fo reduce hydrogen formation, you should not use galvanized assemblies.			

### Environment

#### Ambient temperature range

Version	PMC51	PMP51	PMP55			
Without LCD display	-40	°C to +85 °C (-40°F to +18	5°F)			
With LCD display <sup>1)</sup>	-20	−20 °C to +70 °C (−4°F to +158°F)				
With M12 plug , elbowed	-25 °C to +85 °C (-13°F to +185°F)					
With separate housing	−20 °C to +60 °C (installation wit					
Diaphragm seal systems			→ 🖹 99			

1) Extended temperature application range (-40 °C to +85 °C (-40°F to +185°F)) with restrictions in optical properties such as display speed and contrast

#### NOTICE

#### High temperatures or vibrations can destroy the device!

For high-temperature applications, either a PMP55 with a temperature isolator or with a capillary can be used. If vibrations also occur in the application, Endress+Hauser recommends you use a PMP55 with a capillary. If a PMP55 with a temperature isolator or capillary is used, we recommend a suitable bracket for mounting (see "Wall and pipe mounting" ordering feature  $\rightarrow a 34$ ).

Storage temperature range	Version	PMC51	PMP51	PMP55	
	Without LCD display	-40 °C to +90 °C (-40°F to +194°F)			
	With LCD display-40 °C to +85 °C (-40°F to +185°F)		5°F)		
	With M12 plug , elbowed	-25 °C to +85 °C (-13°F to +185°F)		5°F)	
	With separate housing-40 °C to +60 °C (-40°F to +140°F)		—		
	Diaphragm seal systems	—	—	→ 🖹 99	

#### **Climate class**

Class 4K4H (air temperature: -20 to 55 °C (-4 to +131°F), relative humidity: 4 to 100%) satisfied as per DIN EN 60721-3-4 (condensation possible).

	F31	housing:	IP 68	(1.83	$mH_2O$	for 24 h)
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• Ordering information:

П

- Product Configurator, "Electrical connection" ordering feature
- Separate housing ( $\rightarrow \ge 35$ )

#### Vibration resistance

Degree of protection

Device/Additional option	Test standard	Vibration resistance
Devices without mounting bracket	<ul> <li>GL VI-7-2</li> <li>Part 7: Guidelines for the Performance of Type Approvals</li> <li>Chapter 2: Test Requirements for Electrical / Electronic Equipment and Systems</li> </ul>	guaranteed for 5 to 25 Hz: ±1.6 mm (0.06 in); 25 to 100 Hz: 4 g in all 3 planes
	IEC 61298-3 IEC 60068-2-6	guaranteed for 10 to 60 Hz: ±0.35 mm (0.01 in); 60 to 2000 Hz: 5 g in all 3 planes
Devices with mounting bracket	IEC 61298-3 IEC 60068-2-6	guaranteed for 10 to 60 Hz: ±0.15 mm (0.01 in); 60 to 500 Hz: 2 g in all 3 planes

#### NOTICE

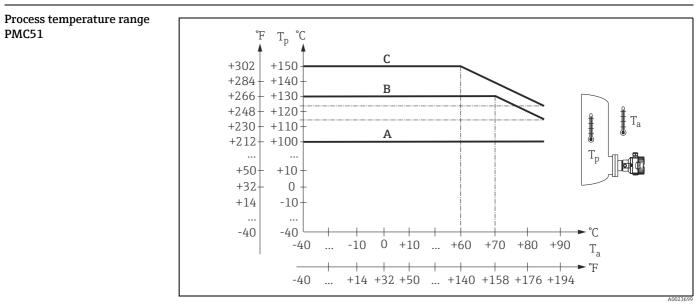
#### Strong vibrations can destroy the device!

For high-vibration applications, either a PMC51/PMP51 with a separate housing or a PMP55 with a capillary can be used. We recommend a suitable bracket for mounting (see "Wall and pipe mounting" ordering feature on  $\rightarrow \exists 34$ ).

Electromagnetic	Electromagnetic compatibility as per all the relevant requirements of the EN 61326 series and
compatibility	NAMUR Recommendation EMC (NE21). Details can be found in the Declaration of Conformity (in the Download area of "www.de.endress.com", "search area - Approvals and Certificates", "Manufact.
	Declaration").

Maximum deviation: < 0.5 % of span</li>

### **Process**



A, B and C, see next section.

Ambient temperature

 $T_a T_p$ Process temperature

#### Process temperature limits

#### PMC51 (with ceramic process isolating diaphragm)

- A: -40 to +100 °C (-40 to +212°F) for threaded process connections or flange process connections
- B: -40 to +130 °C (-40 to +266°F) for hygienic process connections
- C: For a maximum of 60 minutes: +150 °C (+302°F) for hygienic process connections
- Observe the process temperature range of the seal. See also the following table.

Seal	Notes	Process temp	Process temperature range		
		Thread or flange	Hygienic process connections	_	
FKM Viton	-	-20 to +100 °C (-4 to +212°F)	-	А	
FKM Viton	cleaned for O2 application	-5 to +60 °C (+23 to +140°F)	-	A <sup>2)</sup>	
FKM Viton	FDA <sup>3)</sup> , 3A Class I, USP Class VI	-5 to +100 °C (+23 to +212°F)	-5 to +150 °C (+23 to +302°F)	В	
NBR	FDA <sup>3)</sup>	-10 to +100 °C (-14 to +212°F)	-	F	
NBR, low temperature	-	-40 to +100 °C (-40 to +212°F)	-	Н	
HNBR	FDA <sup>3)</sup> , 3A Class I, KTW, AFNOR, BAM	-25 to +100 °C (-13 to +212°F)	-20 to +125 °C (-4 to +257°F)	G	
EPDM 70	FDA <sup>3)</sup>	-40 to +100 °C (-40 to +212°F)	-	J	
EPDM 291	FDA <sup>3)</sup> , 3A Class II, USP Class VI, DVGW, KTW, W270, WRAS, ACS, NSF61	-	-15 to +150 °C (+5 to +302°F)	К	
FFKM Kalrez 6375	-	+5 to +100 °C (+41 to +212°F)	-	L	
FFKM Kalrez 7075	-	+5 to +100 °C (+41 to +212°F)	-	М	
FFKM Kalrez 6221	FDA <sup>3)</sup> , USP Class VI	-5 to +100 °C (+23 to +212°F)	-5 to +150 °C (+23 to +302°F)	N	
Fluoroprene XP40	FDA <sup>3)</sup> , USP Class VI, 3A Class I	+5 to +100 °C (+41 to +212°F)	+5 to +150 °C (+41 to +302°F)	Р	
VMQ Silicone	FDA <sup>3)</sup>	-35 to +85 °C (-31 to +185°F)	-20 to +85 °C (-4 to +185°F)	S	

1) Product Configurator, "Seal" ordering feature

2) With "HB" option, see Product Configurator, "Service" ordering feature

Suitable for foods FDA 21 CFR 177.2600 3)

#### Applications with jumps in temperature

Extreme jumps in temperature can result in temporary measuring errors. Temperature compensation takes effect after several minutes. Internal temperature compensation is faster the smaller the jump in temperature and the longer the time interval involved.

For further information please contact your local Endress+Hauser Sales Center.

#### PMP51 (with metallic process isolating diaphragm)

Description	Temperature operating range
Process connections with internal process isolating diaphragm	-40 to +125 °C (-40 to +257°F)
Process connections with flush-mounted process isolating diaphragm, G 1 A, G 1 ½" A, G 2 A, 1 NPT, 1 ½" NPT, 2 NPT, M44x1.25, EN/DIN, ANSI flanges	-40 to +100 °C (-40 to +212°F)
Process connections with flush-mounted process isolating diaphragm, G 1/2" A	-20 to +85 °C (-4 to +185°F)
Hygienic process connections	-40 to +130 °C (-40 to +266°F) For a maximum of 60 minutes: +150 °C (+302°F)

#### PMP55 (with diaphragm seal)

Depending on the diaphragm seal and filling oil from -70 °C (-94°F) up to +400 °C (+752°F). Observe the temperature application limits  $\rightarrow \triangleq$  99.

#### NOTICE

#### The use of incorrect process isolating diaphragms can destroy the device!

- The PTFE foil used is designed to protect the unit against abrasion. It does not provide protection against corrosive media.
- ► Do not use diaphragm seals with 0.25 mm (0.01 in) PTFE foil on AISI 316L (1.4435/1.4404) for vacuum applications, upper temperature limit +204 °C (+399°F).
- For oxygen applications, observe  $\rightarrow \triangleq$  36, "Oxygen applications" ordering feature.

#### **Pressure specifications**

#### **A** WARNING

The maximum pressure for the measuring device depends on the lowest-rated element with regard to pressure  $\rightarrow \triangleq 11$  ff, "Measuring range" ordering feature and  $\rightarrow \triangleq 41$  ff "Mechanical construction" ordering feature

- Only operate the measuring device within the prescribed limits!
- ► The MWP (maximum working pressure) is specified on the nameplate. This value refers to a reference temperature of +20 °C (68°F), or 100°F (38 °C) for ANSI flanges, and may be applied to the device for an unlimited time. Observe temperature dependency of the MWP.
- Please refer to the following standards for pressure values permitted at higher temperatures: EN 1092-1: 2001 Tab. 18<sup>1)</sup>, ASME B 16.5a - 1998 Tab. 2-2.2 F316, ASME B 16.5a - 1998 Tab. 2.3.8 N10276, JIS B 2220.
- The test pressure corresponds to the over pressure limit of the device (OPL = 1.5 x MWP)<sup>2</sup> and may be applied for only a limited time period in order to avoid permanent damage.
- The Pressure Equipment Directive (EC Directive 97/23/EC) uses the abbreviation "PS". The abbreviation "PS" corresponds to the MWP (maximum working pressure) of the measuring device.
- ► In the case of sensor range and process connection combinations where the OPL (over pressure limit) of the process connection is smaller than the nominal value of the sensor, the device is set at the factory, at the very maximum, to the OPL value of the process connection. If you want to use the entire sensor range, select a process connection with a higher OPL value (1.5 x PN; PN = MWP).
- In oxygen applications, the values for "p<sub>max</sub> and T<sub>max</sub> for oxygen applications" as per → <sup>1</sup> 36, "Oxygen applications" may not be exceeded.
- Avoid steam hammering! Steam hammering can cause zero point drift. Recommendation: Residue (such as condensation or drops of water) can remain at the process isolating diaphragm after CIP cleaning and lead to local steam hammering if immediately steam is introduced. In practice, drying the process isolating diaphragm (e.g. by blowing off excess moisture) has proven to be a successful way of avoiding steam hammering.

<sup>1)</sup> With regard to their stability-temperature property, the materials 1.4435 and 1.4404 are grouped together under 13EO in EN 1092-1 Tab. 18.

The chemical composition of the two materials can be identical.

<sup>2)</sup> The equation does not apply for PMP51 and PMP55 with a 40 bar (600 psi) - or a 100 bar (1500 psi) - measuring cell.

### Mechanical construction

#### Device height

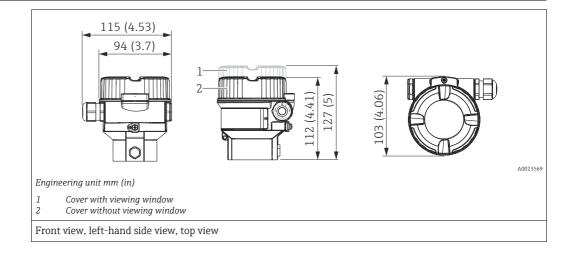
The device height is calculated from

- the height of the housing and
- the height of the individual process connection.

The individual heights of the components are listed in the following sections. To calculate the device height simply add up the individual heights of the components. Where applicable also take into consideration the installation distance (space that is used to install the device). You can use the following table for this purpose:

Section	Page	Height
Housing height	→ 🖹 41 ff	
Process connections	→ 🖹 43 ff	
Installation distance		
Device height		

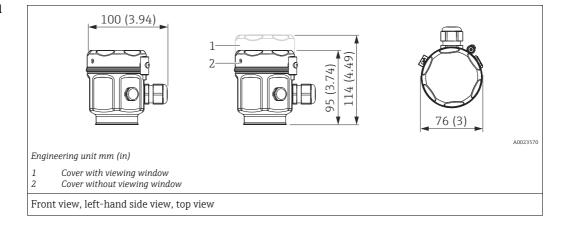
#### F31 housing, aluminum



Material	Weight kg (lbs)		Option <sup>1)</sup>
	With display	Without display	
Aluminum	1.1 (2.43)	1.0 (2.21)	Ι
Aluminum with glass viewing window		1.0 (2.21)	J

1) Product Configurator, "Housing" ordering feature

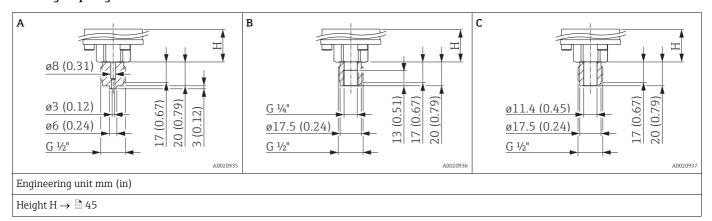
# F15 housing, stainless steel (hygienic)



Material	Weight kg (lbs)		Option <sup>1)</sup>
	With display	Without display	
Stainless steel			Q
Stainless steel with glass viewing window	1.1 (2.43)	1.0 (2.21)	R
Stainless steel with plastic viewing window	*		S

1) Product Configurator, "Housing" ordering feature

# PMC51: process connections ISO 228 G threaded connection with internal process isolating diaphragm



Item	Designation	Material	Approval <sup>1)</sup>	Weight kg (lbs)	Option <sup>2)</sup>
		AISI 316L	CRN		GCJ
		Alloy C276 (2.4819)	CRN		GCC
A ,	Thread ISO 228 G ½" A EN 837	<ul> <li>PVDF</li> <li>Mount only with enclosed mounting bracket</li> <li>MWP 10 bar (150 psi), OPL max. 15 bar (225 psi)</li> <li>Process temperature range: +10 to +60 °C (+14 to +140°F)</li> </ul>	-	0.63 (1.39)	GCF
В	Thread ISO 228 G ½" A	AISI 316L	CRN		GLJ
D	G ¼" (female) EN 837	Alloy C276 (2.4819)	CRN		GLC
C	Thread ISO 228 G ½" A EN 837,	AISI 316L	CRN		GMJ
L	Bore 11.4 mm (0.45 in)	Alloy C276 (2.4819)	CRN		GMC

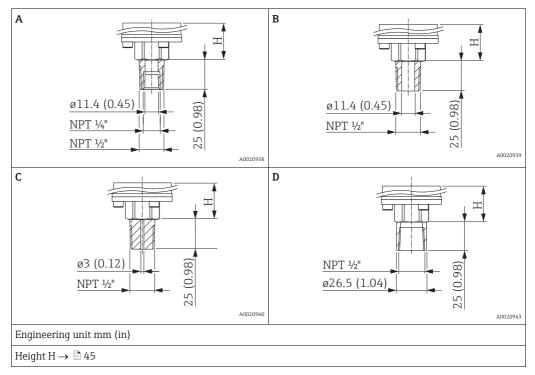
1) CSA approval: Product Configurator, "Approval" ordering feature

2) Product Configurator, "Process connection" ordering feature

# i

#### PMC51: process connections with internal process isolating diaphragm

#### ANSI threaded connection



Item	Designation	Material	Weight kg (lbs)	Approval <sup>1)</sup>	Option <sup>2)</sup>
А	ANSI ½" MNPT, ¼" FNPT	AISI 316L		CRN	RLJ
A	AINSI 72 IVIINE 1, 74 I'INE I	Alloy C276 (2.4819)		CRN	RLC
D	B ANSI ½" MNPT, Bore 11.4 mm (0.45 in)	AISI 316L	-	CRN	RKJ
Б		Alloy C276 (2.4819)		CRN	RKC
С	ANSI ½" MNPT, Bore 3 mm (0.12 in)	<ul> <li>PVDF</li> <li>Mount only with enclosed mounting bracket</li> <li>MWP 10 bar (150 psi), OPL max. 15 bar (225 psi)</li> <li>Process temperature range: +10 to +60 °C (+14 to +140°F)</li> </ul>	0.63 (1.39)	-	RJF
D	ANSI 1/2" FNPT	AISI 316L		CRN	R1J
D	Bore 11.4 mm (0.45 in)	Alloy C276 (2.4819)		CRN	R1C

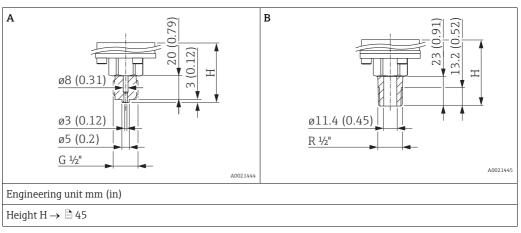
1) CSA approval: Product Configurator, "Approval" ordering feature

2) Product Configurator, "Process connection" ordering feature

# i

#### PMC51: process connections with internal process isolating diaphragm

#### JIS threaded connection



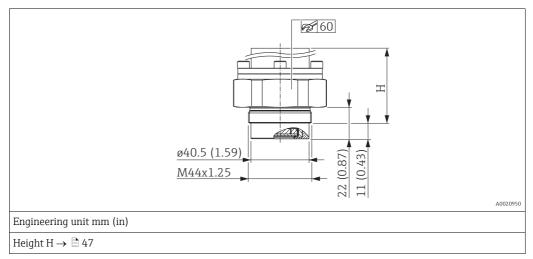
Item	Designation	Material	Weight kg (lbs)	Option <sup>1)</sup>
А	JIS B0202 G ½" (male)	AISI 316L	0.62 (1.20)	GNJ
В	JIS B0203 R ½" (male)	AISI JIOL	0.63 (1.39)	GOJ

1) Product Configurator, "Process connection" ordering feature

PMC51: process connections with internal process isolating diaphragm height H

F31 housing	F15 housing
89 mm (3.5 in)	81 mm (3.2 in)

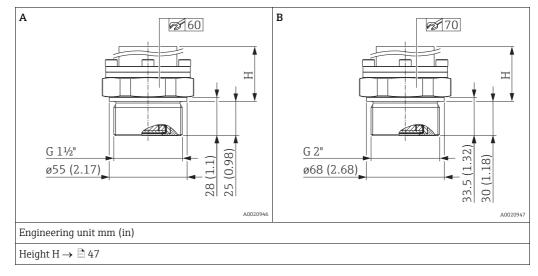
#### DIN 13 threaded connection



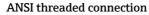
Designation	Material	Weight kg (lbs)	Option <sup>1)</sup>
DIN 13 M44 x 1.25	AISI 316L	0.63 (1.39)	G4J

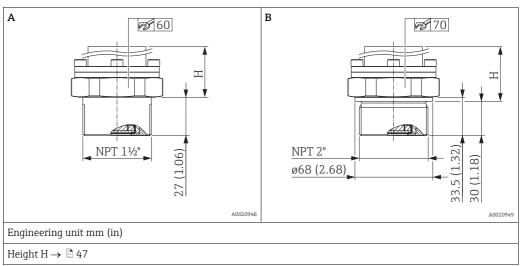
1) Product Configurator, "Process connection" ordering feature

#### ISO 228 G threaded connection



Item	Designation	Material	Weight kg (lbs)	Option <sup>1)</sup>
А	Thread ISO 228 G 1 ½" A	AISI 316L	0.62 (1.20)	GVJ
В	Thread ISO 228 G 2" A	AISI 316L	0.63 (1.39)	GWJ





Item	Designation	Material	Weight kg (lbs)	Approval <sup>1)</sup>	Option <sup>2)</sup>
А	Thread ANSI 1 1/2" MNPT	AISI 316L	0.63 (1.39)	CRN	U7J
В	Thread ANSI 2" MNPT	AISI 316L	0.0) (20,0)	CRN	U8J

1) CSA approval: Product Configurator, "Approval" ordering feature

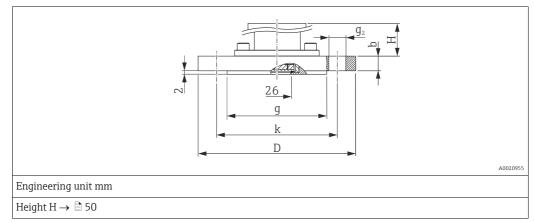
f

2) Product Configurator, "Process connection" ordering feature

PMC51: process connections
with flush-mounted process
isolating diaphragm -
height H

F31 housing	F15 housing
89 mm (3.5 in)	81 mm (3.2 in)

#### EN/DIN flanges, connection dimensions as per EN 1092-1/DIN 2527



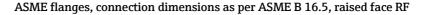
Flange							Boltholes			Weight	Option <sup>1)</sup>
Material	Nominal diameter	Nominal pressure	Shape <sup>2)</sup>	Diameter	Thickness	Raised face	Quantity	Diameter	Hole circle		
				D	b	g		<b>g</b> <sub>2</sub>	k		
				[mm]	[mm]	[mm]		[mm]	[mm]	[kg]	
AISI 316L	DN 25	PN 10-40	B1 (D)	115	18	68	4	14	85	1.4 (3.09)	CNJ
AISI 316L	DN 32	PN 10-40	B1 (D)	140	18	78	4	18	100	2.0 (4.41)	СРЈ
AISI 316L	DN 40	PN 10-40	B1 (D)	150	18	88	4	18	110	2.4 (5.29)	CQJ
ECTFE <sup>4)</sup>	DN 40	PN 10-40	B1 (D)	150	21	88	4	18	110	2.6 (5.73)	CQP
AISI 316L	DN 50	PN 10-40	B1 (D)	165	20	102	4	18	125	3.2 (7.06)	CXJ
PVDF 3)	DN 50	PN 10-16	B1 (D)	165	21.4	102	4	18	125	0.6 (1.32)	CFF
ECTFE <sup>4)</sup>	DN 50	PN 25-40	B1 (D)	165	20	102	4	18	125	3.2 (7.06)	CRP
AISI 316L	DN 80	PN 10-40	B1 (D)	200	24	138	8	18	160	5.4 (11.91)	CZJ
ECTFE <sup>4)</sup>	DN 80	PN 25-40	B1 (D)	200	24	138	8	18	160	5.5 (12.13)	CSP

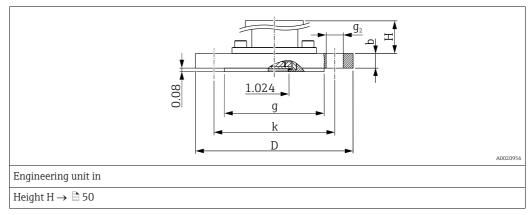
1) Product Configurator, "Process connection" ordering feature

2) Designation as per DIN 2527 in brackets

3) Mount only with mounting bracket. MWP 10 bar (150 psi), OPL max. 15 bar (225 psi). Process temperature range -10 to +60 °C (+14 to +140°F).

4) ECTFE coating on AISI 316L (1.4404). When operating in hazardous areas, avoid electrostatic charging of the plastic surfaces.





Flange						Bolthole	s		Weight	Approval <sup>1)</sup>	Option <sup>2)</sup>
Material	Nominal diameter	Class	Diamet er	Thick ness	Raised face	Quantit y	Diameter	Hole circle			
			D	b	g		<b>g</b> <sub>2</sub>	k			
	[in]	[lb./sq.in]	[in]	[in]	[in]		[in]	[in]	[kg (lbs)]		
AISI 316/316L <sup>4)</sup>	1	150	4.25	1.18	2	4	0.62	3.12	0.9 (1.98)	-	ACJ 3)
AISI 316/316L <sup>4)</sup>	1	300	4.88	1.18	2	4	0.75	3.5	1.4 (3.09)	-	ANJ 3)
AISI 316/316L 4)	1 1/2	150	5	0.69	2.88	4	0.62	3.88	1.0 (2.21)	CRN	AEJ
AISI 316/316L <sup>4)</sup>	1 1/2	300	6.12	0.81	2.88	4	0.88	4.5	2.6 (5.73)	CRN	AQJ
AISI 316/316L <sup>4)</sup>	2	150	6	0.75	3.62	4	0.75	4.75	2.4 (5.29)	CRN	AFJ
ECTFE 5)	2	150	6	0.75	3.62	4	0.75	4.75	2.4 (5.29)	-	AFN
PVDF <sup>6)</sup>	2	150	6	0.75	3.62	4	0.75	4.75	0.5 (1.1)	-	AFF
AISI 316/316L <sup>4)</sup>	2	300	6.5	0.88	3.62	8	0.75	5	3.2 (7.06)	CRN	ARJ
AISI 316/316L <sup>4)</sup>	3	150	7.5	0.94	5	4	0.75	6	4.9 (10.8)	CRN	AGJ
ECTFE 5)	3	150	7.5	0.94	5	4	0.75	6	4.9 (10.8)	-	AGN
PVDF <sup>6)</sup>	3	150	7.5	0.94	5	4	0.75	6	0.9 (1.98)	-	AGF
AISI 316/316L <sup>4)</sup>	3	300	8.25	1.12	5	8	0.88	6.62	6.8 (14.99)	CRN	ASJ
AISI 316/316L <sup>4)</sup>	4	150	9	0.94	6.19	8	0.75	7.5	7.1 (15.66)	CRN	AHJ
ECTFE 5)	4	150	9	0.94	6.19	8	0.75	7.5	7.1 (15.66)	-	AHN
AISI 316/316L 4)	4	300	10	1.25	6.19	8	0.88	7.88	11.6 (25.58)	CRN	ATJ

1) CSA approval: Product Configurator, "Approval" ordering feature

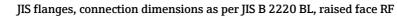
2) Product Configurator, "Process connection" ordering feature

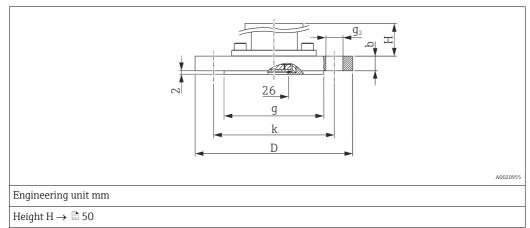
3) Screws must be 15 mm (0.59 in) longer than the standard flange screws.

4) Combination of AISI 316 for required pressure resistance and AISI 316L for required chemical resistance (dual rated)

- 5) ECTFE coating on AISI 316/316L. When operating in hazardous areas, avoid electrostatic charging of the plastic surfaces.
- 6) Mount only with mounting bracket. MWP 10 bar (150 psi), OPL max. 15 bar (225 psi). Process temperature range -10 to +60 °C (+14 to +140°F).

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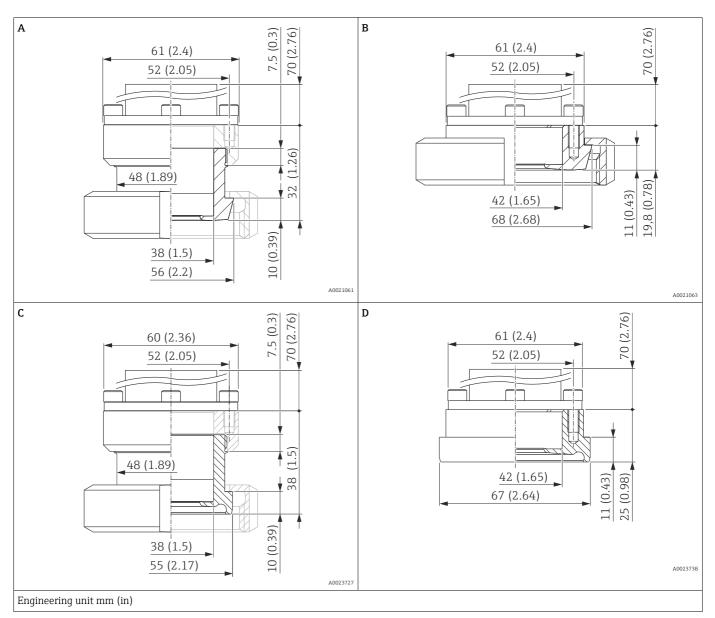


Flange						Boltholes			Weight	Option <sup>1)</sup>
Material	Nominal diameter	Nominal pressure	Diameter	Thickness	Raised face	Quantity	Diameter	Hole circle		
			D	b	g		<b>g</b> <sub>2</sub>	k		
			[mm]	[mm]	[mm]		[mm]	[mm]	[kg (lbs)]	
	50 A	10 K	155	16	96	4	19	120	2.0 (4.41)	KFJ
AISI 316L (1.4435)	80 A	10 K	185	18	127	8	19	150	3.3 (7.28)	KGJ
(	100 A	10 K	210	18	151	8	19	175	4.4 (9.7)	КНЈ

PMC51: process connections with flush-mounted process	F31 housing	F15 housing
isolating diaphragm -	89 mm (3.5 in)	81 mm (3.2 in)
height H		· · · · · · · · · · · · · · · · · · ·

In order to guarantee a hygiene approval, a seal with appropriate approval must be selected for the hygienic process connection:

- For 3A approval, you require a seal made of EPDM or HNBR ( $\rightarrow \equiv$  39).
- For EHEDG approval, you require a seal made of VMQ silicone, FFKM Kalrez, Hyjoin ( $\rightarrow \square$  39).



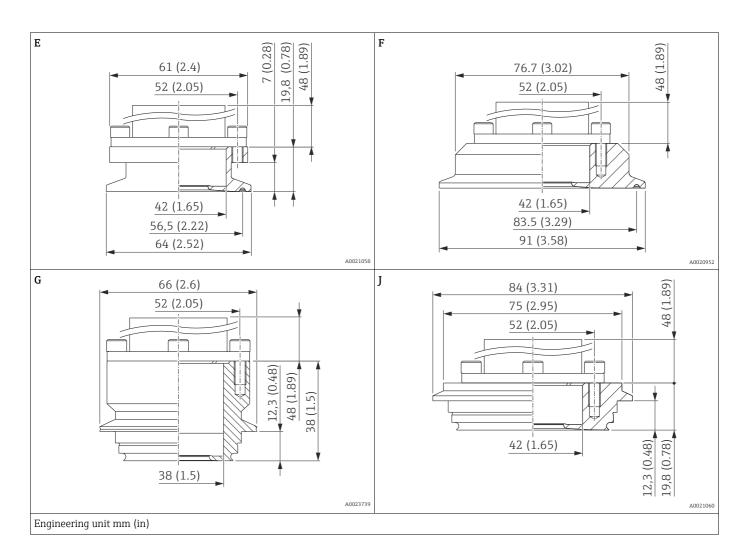
Item	Designation	Nominal pressure	Material <sup>1)</sup>	Weight kg (lbs)	Approval <sup>2)</sup>	Option <sup>3)</sup>
А	DIN 11851 DN40	PN 25		0.7 (1.54)	EHEDG, 3A with seal FDA, ASME-BPE, CRN	MZJ <sup>4)</sup>
В	DIN 11851 DN50	PN 25		0.9 (1.98)	EHEDG, 3A with seal FDA, ASME-BPE, CRN	MRJ <sup>4)</sup>
С	DIN 11864 DN40, pipe DIN 11866-A	PN 16	AISI 316L (1.4435)	0.66 (1.46)	EHEDG, 3A with seal FDA, ASME-BPE	NCJ <sup>4)</sup>
D	DIN 11864 DN50, pipe DIN 11866-A	PN 16		0.29 (0.64)	EHEDG, 3A with seal FDA, ASME-BPE	NDJ <sup>4)</sup>

1) Delta ferrite content <1 %. The roughness of the surface in contact with the medium is  $R_a 0.76 \mu m (30 \mu in)$ .

2) CSA approval: Product Configurator, "Approval" ordering feature

3) Product Configurator, "Process connection" ordering feature

4) Endress+Hauser supplies these slotted nuts in stainless steel AISI 304 (DIN/EN material number 1.4301) or in AISI 304L (DIN/EN material number 1.4307).



Item	Designation	Nominal pressure	Material <sup>1)</sup>	Weight kg (lbs)	Approval <sup>2)</sup>	Option <sup>3)</sup>
Е	Tri-Clamp ISO 2852, DN40-DN51 (2")	PN 40		0.65 (1.44)	EHEDG, 3A with seal FDA, CRN, ASME-BPE	TDJ <sup>4)</sup>
F	Tri-Clamp ISO 2852, DN76.1 (3")	PN 40	AISI 316L	0.9 (1.98)	EHEDG, 3A with seal FDA, CRN, ASME-BPE	TFJ <sup>4)</sup>
G	Varivent F pipe, DN25-32	PN 40	(1.4435)	0.46 (1)	EHEDG, 3A with seal FDA, ASME-BPE	TQJ <sup>4)</sup>
Н	Varivent N pipe, DN40–162	PN 40		1 (2.21)	EHEDG, 3A with seal FDA, ASME-BPE	TRJ <sup>4)</sup>

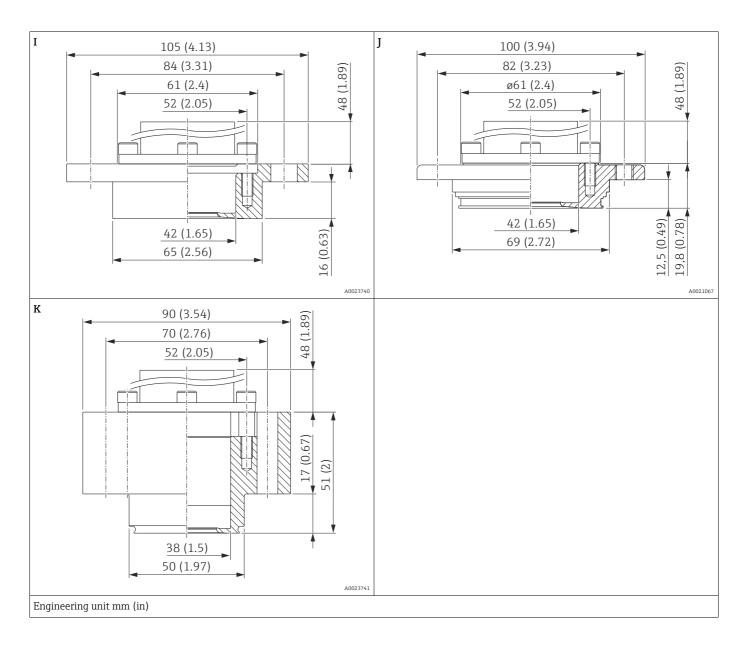
1) Delta ferrite content <1 %. The roughness of the surface in contact with the medium is  $R_a$  0.76  $\mu$ m (30  $\mu$ in).

2) CSA approval: Product Configurator, "Approval" ordering feature

3) Product Configurator, "Process connection" ordering feature

4) Endress+Hauser supplies these slotted nuts in stainless steel AISI 304 (DIN/EN material number 1.4301) or in AISI 304L (DIN/EN material number 1.4307).

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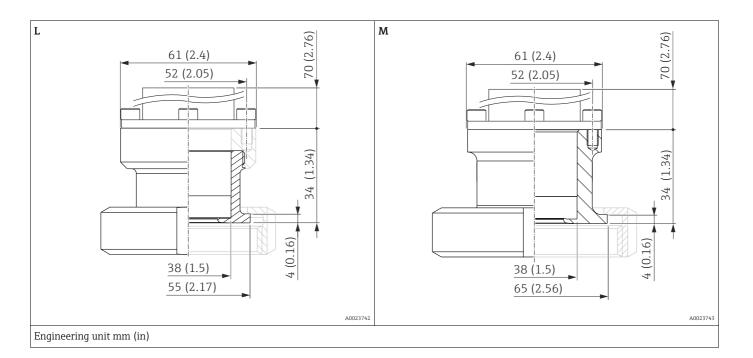
Item	,	Nominal pressure	Material <sup>1)</sup>	Weight kg (lbs)	Approval	Option <sup>2)</sup>
Ι	DRD, DN50 (65 mm)	PN 25		0.9 (1.98)	ASME-BPE	TIJ <sup>3)</sup>
J	APV Inline, DN50	PN 40	AISI 316L (1.4435)	0.52 (1.15)	3A with seal FDA, CRN, ASME-BPE	TMJ
К	NEUMO BioControl, DN50	PN 16		1.34 (2.6)	3A with seal FDA, ASME-BPE	S4J <sup>4)</sup>

1) Delta ferrite content <1 %. The roughness of the surface in contact with the medium is  $R_a 0.76 \mu m$  (30  $\mu in$ ).

2) Product Configurator, "Process connection" ordering feature

3) Endress+Hauser supplies these slotted nuts in stainless steel AISI 304 (DIN/EN material number 1.4301) or in AISI 304L (DIN/EN material number 1.4307).

4) 4 screws DIN912 M8 x 45 are enclosed (material A4-80)



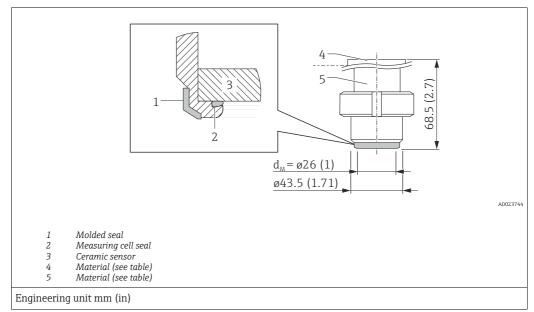
Item	Designation	Nominal pressure	Material <sup>1)</sup>	Weight kg (lbs)	Approval	Option <sup>2)</sup>
L	SMS 1 1/2"	PN 25	AISI 316L (1.4435)	0,65 (1.43)	EHEDG, 3A, ASME- BPE	TXJ <sup>3)</sup>
М	SMS 2"	PN 25	1.4455)	0,65 (1.43)	EHEDG, 3A, ASME- BPE	T7J <sup>3)</sup>

1) Delta ferrite content <1 %. The roughness of the surface in contact with the medium is  $R_a 0.76 \mu m$  (30  $\mu in$ ).

2) Product Configurator, "Process connection" ordering feature

3) Endress+Hauser supplies the slotted nuts in stainless steel AISI 304 (DIN/EN material number 1.4301) or in AISI 304L (DIN/EN material number 1.4307).

#### Universal adapter



Designation	Nominal pressure	Material <sup>1)2)</sup>	5	Approval Process connection <sup>3)</sup>	Option <sup>4)</sup>
Universal adapter with pre-installed silicone molded seal	PN 10	<ul> <li>4: top section AISI 316L (1.4404)</li> <li>5: bottom section AISI 316L</li> </ul>	0.74 (1.63)	EHEDG, 3A with seal FDA, ASME-BPE	UPJ
Universal adapter with pre-installed EPDM molded seal		(1.4435)		EHEDG, ASME-BPE	UNJ

1) The roughness of the surface in contact with the medium is  $R_a$  0.76 µm (30 µin).

2) Endress+Hauser supplies these slotted nuts in stainless steel AISI 304 (1.4301) or in AISI 304L (1.4307).

3) EHEDG or 3A approval only with approved process connection.

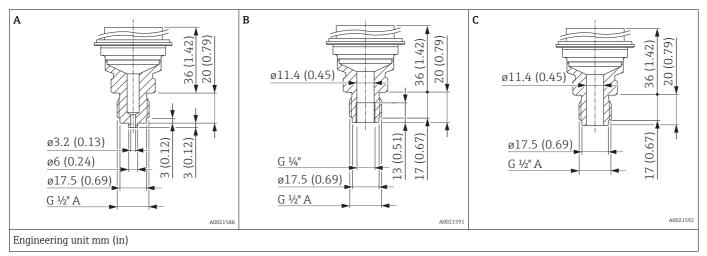
4) Product Configurator, "Process connection" ordering feature

Material of the molded seal (changeable seal)	Material of the measuring cell seal at the ceramic sensor (seal not changeable)	Approval of measuring cell seal	Option <sup>1)</sup>
Silicone (Spare part order no.: 52023572)	EPDM	FDA <sup>2)</sup> 3A Class II, USP Class VI. DVGW, KTW, W270, WRAS, ACS, NSF61	К
EPDM (Spare part order no.: 71100719)	EPDM	FDA <sup>2)</sup>	J

1) Product Configurator, "Seal" ordering feature

2) Suitable for foods FDA 21 CFR 177.2600

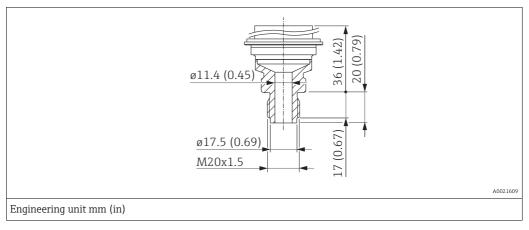
# PMP51: process connections ISO 228 G threaded connection with internal process isolating diaphragm



Item	Designation	Material	Weight kg (lbs)	Option <sup>1)</sup>
А	Thread ISO 228 G ½" A EN 837	AISI 316L		GCJ
	1111eau 150 220 G 72 A EN 657	Alloy C276 (2.4819)		GCC
D	Thread ISO 228 G ½" A G ¼" (female) EN 837	AISI 316L	0.63 (1.39)	GLJ
В		Alloy C276 (2.4819)	0.05 (1.59)	GLC
С	Thread ISO 228 G ½" A EN 837,	AISI 316L		GMJ
	Bore 11.4 mm (0.45 in)	Alloy C276 (2.4819)		GMC

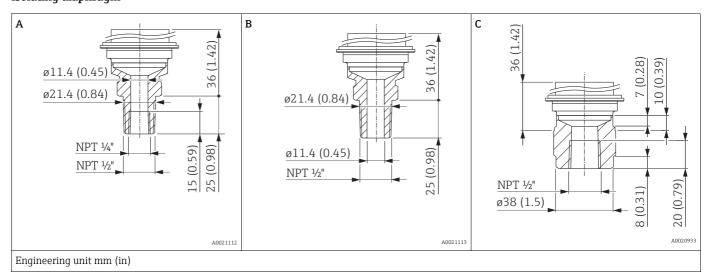
1) Product Configurator, "Process connection" ordering feature

#### DIN 13 threaded connection



Designation	Material	Weight kg (lbs)	Option <sup>1)</sup>
DIN 13 M20 x 1.5, EN 837 Bore 11.4 mm (0.45 in)	AISI 316L	0.6 (1.32)	G1J

# PMP51: process connections ANSI threaded connection with internal process isolating diaphragm



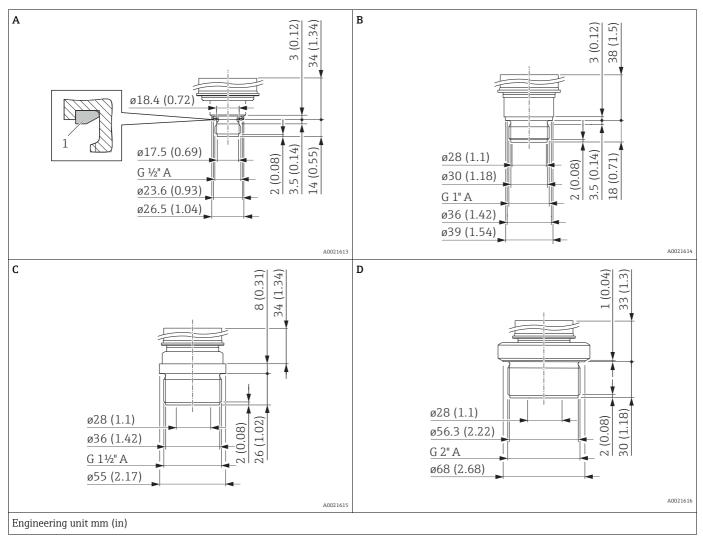
Item	Designation	Material	Weight kg (lbs)	Approval <sup>1)</sup>	Option <sup>2)</sup>
А	ANSI ½" MNPT. ¼" FNPT	AISI 316L		CRN	RLJ
	AIN51 72 IVINP 1, 74 FINP 1	Alloy C276 (2.4819)		CRN	RLC
D	ANSI ½" MNPT,	AISI 316L	0.63 (1.39)	CRN	RKJ
В	Bore 11.4 mm (0.45 in) (400 bar (6000 psi))	Alloy C276 (2.4819)	-	CRN	RKC
С	ANSI ½" FNPT	AISI 316L	07/15/	CRN	R1J
	ANSI 72 FINP I	Alloy C276 (2.4819)	0.7 (1.54)	CRN	R1C

1) CSA approval: Product Configurator, "Approval" ordering feature

2) Product Configurator, "Process connection" ordering feature

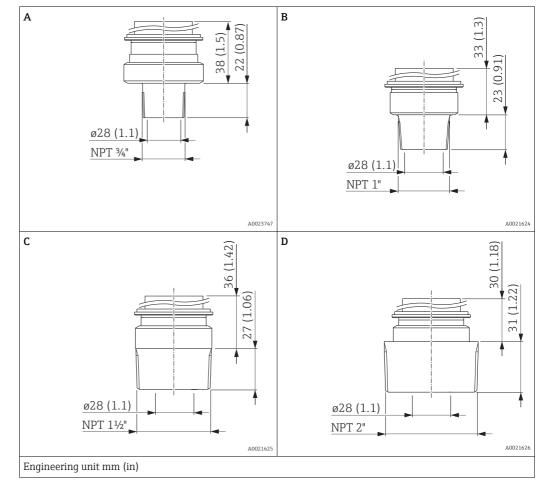


#### ISO 228 G threaded connection



Item	Designation	Material	Weight kg (lbs)	Option <sup>1)</sup>
А	Thread ISO 228 G ½" A DIN 3852	AISI 316L	0.4 (0.88)	GRJ
	FKM seal (item 1) pre-istalled	Alloy C276 (2.4819)	0.4 (0.88)	GRC
В	Thread ISO 228 G 1" A	AISI 316L	0.7 (1.54)	GTJ
С	Thread ISO 228 G 1½" A	AISI 316L	1.1 (2.43)	GVJ
D	Thread ISO 228 G 2" A	AISI 316L	1.5 (3.31)	GWJ

#### ANSI threaded connection

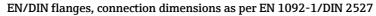


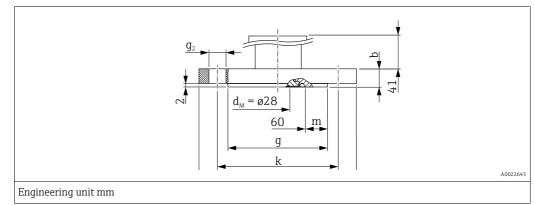
Item	Designation	Material	Weight kg (lbs)	Approval <sup>1)</sup>	Option <sup>2)</sup>
А	ANSI 34" MNPT		0.6 (1.32)	CRN	U4J
В	ANSI 1" MNPT		0.7 (1.54)	CRN	U5J
С	ANSI 1 ½" MNPT	AISI 316L	1 (2.21)	CRN	U7J
D	ANSI 2" MNPT		1.3 (2.87)	CRN	U8J

1) CSA approval: Product Configurator, "Approval" ordering feature

2) Product Configurator, "Process connection" ordering feature

## i





Flange 1) 2	2)						Boltholes		-	Option <sup>3)</sup>	
Nominal diameter	Nominal pressure	Shape <sup>4)</sup>	Diameter	Thickness	Raised face	Width of the raised face	Quantity	Diameter	Hole circle	weight	
			D	b	g	(m)		g <sub>2</sub>	k		
			[mm]	[mm]	[mm]	[mm]		[mm]	[mm]	[kg (lbs)]	
DN 25	PN 10-40	B1 (D)	115	18	68 <sup>5)</sup>	4	4	14	85	1.2 (2.65)	CNJ
DN 32	PN 10-40	B1 (D)	140	18	78 <sup>5)</sup>	9	4	18	100	1.9 (4.19)	СРЈ
DN 40	PN 10-40	B1 (D)	150	18	88 <sup>5)</sup>	14	4	18	110	2.2 (4.85)	CQJ
DN 50	PN 10-40	B1 (D)	165	20	102	-	4	18	125	3.0 (6.62)	CXJ
DN 80	PN 10-40	B1 (D)	200	24	138	-	8	18	160	5.3 (11.69)	CZJ

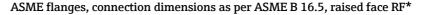
1) The roughness of the surface in contact with the medium including the raised face of the flange (all standards) is Ra <0.8  $\mu$ m (31.5  $\mu$ in). Lower surface roughness available on request.

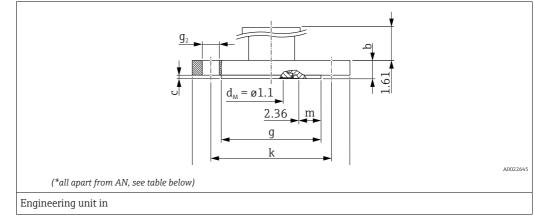
2) Material: AISI 316L

3) Product Configurator, "Process connection" ordering feature

4) Designation as per DIN 2527 in brackets

5) With these process connections the raised face is smaller than described in the standard. Due to the smaller raised face a special seal must be used. Contact a seal manufacturer or your local Endress+Hauser Sales Center.





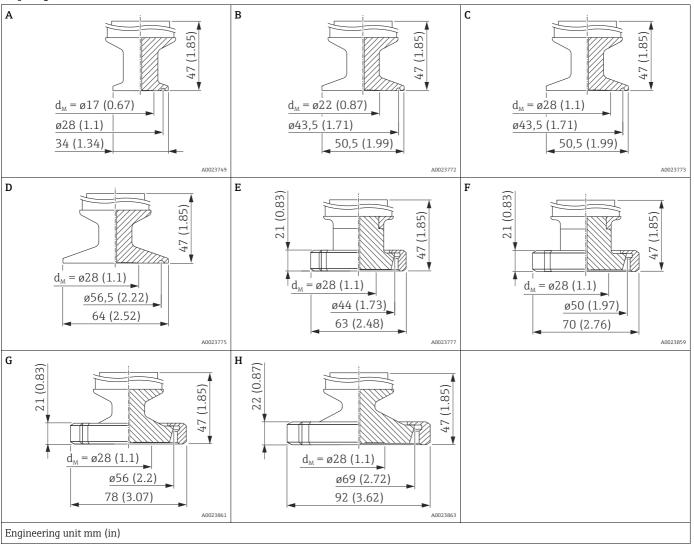
Flange 1) 2	2)						Bolthol	es		Weight	Approval <sup>3)</sup>	Option <sup>4)</sup>
Nominal diameter	Class/ Nominal pressure	Diamet er	Thick ness	Diameter of raised face	Thickness of raised face	Width of raised face	Quanti ty	Diamet er	Hole circle			
		D	b	g	с	(m)		<b>g</b> <sub>2</sub>	k			
[in]	[lb./sq.in]	[in]	[in]	[in]	[in]	[in]		[in]	[in]	[kg (lbs)]		
1	300	4.88	0.69	2 5)	0.06	0.2	4	0.75	3.5	1.3 (2.87)	CRN	ANJ
1 1/2	150	5	0.69	2.88 5)	0.08	0.52	4	0.62	3.88	1.5 (3.31)	CRN	AEJ
1 1/2	300	6.12	0.81	2.88 5)	0.08	0.52	4	0.88	4.5	2.6 (5.73)	CRN	AQJ
2	150	6	0.75	3.62	0.08	-	4	0.75	4.75	2.4 (5.29)	CRN	AFJ
2	300	6.5	0.88	3.62	0.08	-	8	0.75	5	3.2 (7.06)	CRN	ARJ
3	150	7.5	0.94	5	0.08	-	4	0.75	6	4.9 (10.8)	CRN	AGJ
3	300	8.25	1.12	5	0.08	-	8	0.88	6.62	6.7 (14.77)	CRN	ASJ
4	150	9	0.94	6.19	0.08	-	8	0.75	7.5	7.1 (15.66)	CRN	AHJ
4	300	10	1.25	6.19	0.08	-	8	0.88	7.88	11.6 (25.88)	CRN	ATJ

1) The roughness of the surface in contact with the medium including the raised face of the flange (all standards) is Ra <0.8  $\mu$ m (31.5  $\mu$ in). Lower surface roughness available on request.

2) Material: AISI 316/316L; combination of AISI 316 for required pressure resistance and AISI 316L for required chemical resistance (dual rated)

- 3) CSA approval: Product Configurator, "Approval" ordering feature
- 4) Product Configurator, "Process connection" ordering feature
- 5) With these process connections the raised face is smaller than described in the standard. Due to the smaller raised face a special seal must be used. Contact a seal manufacturer or your local Endress+Hauser Sales Center.

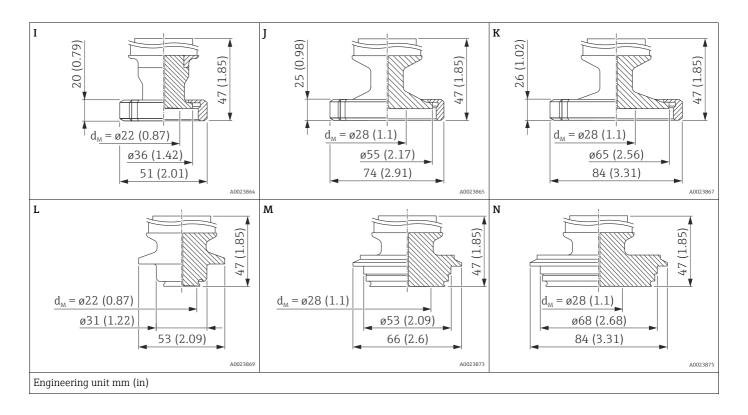




Item <sup>1) 2)</sup>	Designation	Nominal pressure	Weight kg (lbs)	Approval	Option <sup>3)</sup>
А	Clamp ISO2852, DN 18-22, DIN 32676 DN 15-20	PN 40	0.5 (1.10)	EHEDG, 3A, ASME-BPE	TBJ
В	Tri-Clamp ISO2852 DN 25 (1"), DIN 32676 DN 25	PN 40	0.6 (1.32)	EHEDG, 3A, ASME-BPE	TCJ
С	Tri-Clamp ISO2852 DN 38 (1½"), DIN 32676 DN 40	PN 40	0.6 (1.32)	EHEDG, 3A, ASME-BPE	TJJ
D	Tri-Clamp ISO2852 DN 40-51 (2"), DIN 32676 DN 50	PN 40	0.7 (1.54)	EHEDG, 3A, ASME-BPE	TDJ
E	DIN 11851 DN 25	PN 25	0.7 (1.54)	EHEDG, 3A, ASME-BPE	MXJ
F	DIN 11851 DN 32	PN 25	0.8 (1.76)	EHEDG, 3A, ASME-BPE	MIJ
G	DIN 11851 DN 40	PN 25	0.9 (1.98)	EHEDG, 3A, ASME-BPE	MZJ
Н	DIN 11851 DN 50	PN 25	1.1 (2.43)	EHEDG, 3A, ASME-BPE	MRJ

1) Material: AISI 316L (1.4435)

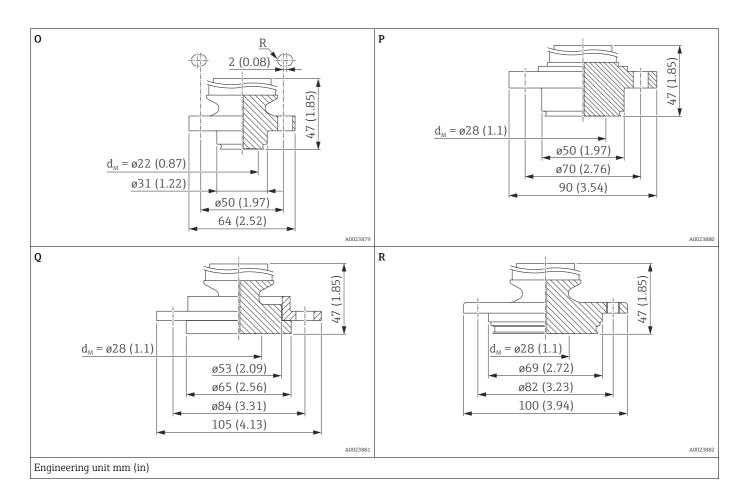
2) The roughness of the surface in contact with the medium is  $R_a 0.76 \mu m$  (30  $\mu in$ ). Version optionally in conformity with ASME-BPE for use in biochemical processes, wetted surfaces  $R_a 0.38 \mu m$  (15  $\mu in$ ), electropolished; to be ordered using order feature 570 "Service", option "HK" in the order code.



Item <sup>1) 2)</sup>	Designation	Nominal	Weight	Approval	Option <sup>3)</sup>
	pressure		kg (lbs)		
Ι	SMS 1"	PN 25	0.7 (1.54)	EHEDG, 3A, ASME-BPE	T6J
J	SMS 11/2"	PN 25	0.8 (1.76)	EHEDG, 3A, ASME-BPE	T7J
К	SMS 2"	PN 25	0.9 (1.98)	EHEDG, 3A, ASME-BPE	TXJ
L	Varivent B pipe DN 10-15	PN 40	0.7 (1.54)	EHEDG, 3A, ASME-BPE	TPJ
М	Varivent F pipe DN 25-32	PN 40	0.9 (1.98)	EHEDG, 3A, ASME-BPE	TQJ
N	Varivent N pipe DN 40-162	PN 40	1.1 (2.43)	EHEDG, 3A, ASME-BPE	TRJ

1) Material: AISI 316L (1.4435)

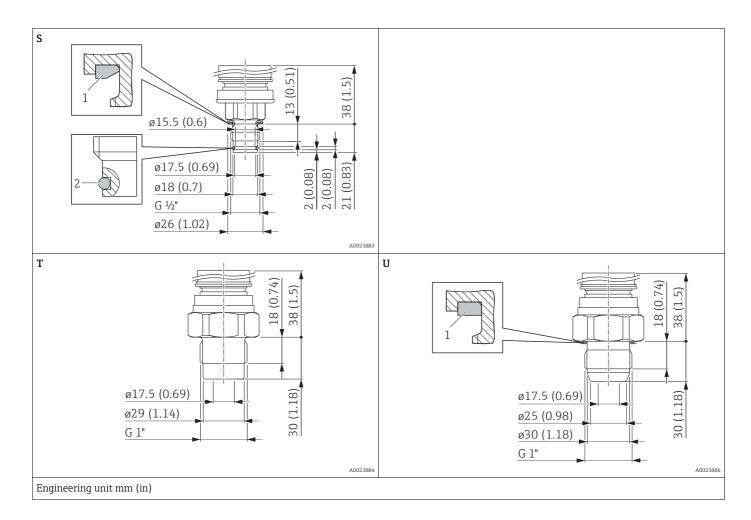
2) The roughness of the surface in contact with the medium is R<sub>a</sub> 0.76 μm (30 μin). Version optionally in conformity with ASME-BPE for use in biochemical processes, wetted surfaces R<sub>a</sub> 0.38 μm (15 μin), electropolished; to be ordered using order feature 570 "Service", option "HK" in the order code.



Item <sup>1) 2)</sup>	Designation	Nominal	Boltholes		Weight	Approval	Option <sup>3)</sup>
		pressure	Quantity	Diameter	kg (lbs)		
0	NEUMO BioControl D 25	PN 16	4	R: 3.5 mm (0.14 in)	0.8 (1.76)	EHEDG, 3A, ASME-BPE	S1J
Р	NEUMO BioControl D 50	PN 16	4	9 mm (0.35 in)	1.2 (2.65)	EHEDG, 3A, ASME-BPE	S4J
Q	DRD DN 50	PN 25	4	11.5 mm (0.45 in)	1.0 (2.21)	ASME-BPE	TIJ
R	APV Inline DN 50	PN 40	6	8.6 mm (0.34 in)	1.2 (2.65)	EHEDG, ASME-BPE	TMJ
			2	M8			

1) Material: AISI 316L (1.4435)

2) The roughness of the surface in contact with the medium is R<sub>a</sub> 0.76 μm (30 μin). Version optionally in conformity with ASME-BPE for use in biochemical processes, wetted surfaces R<sub>a</sub> 0.38 μm (15 μin), electropolished; to be ordered using order feature 570 "Service", option "HK" in the order code.

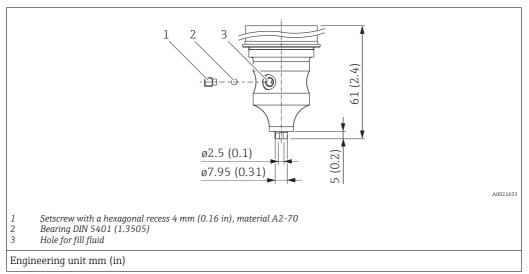


Item 1) 2)	Designation	Seal		Nominal	Weight	Approval	Option <sup>3)</sup>	
		Item	Designation	pressure	kg (lbs)			
S	Thread ISO228 G ½"	1	FKM molded seal pre-installed	PN 40	0.5 (1.1)	ASME-BPE	GOJ	
		2	FKM O-ring pre-installed	-				
Т	Thread ISO228 G1"	-	Sealing via O-ring. VMQ O-ring included with the accessories QE and QF.	PN 40	0.8 (1.76)	3A, ASME-BPE	GZJ	
U	Thread ISO228 G1"	1	Metall joint FKM molded seal pre-installed	PN 100	0.8 (1.76)	ASME-BPE	GXJ	

1) Material: AISI 316L

2) The roughness of the surface in contact with the medium is R<sub>a</sub> 0.76 μm (30 μin). Version optionally in conformity with ASME-BPE for use in biochemical processes, wetted surfaces R<sub>a</sub> 0.38 μm (15 μin), electropolished; to be ordered using order feature 570 "Service", option "HK" in the order code.

#### PMP51: process connections Prepared for diaphragm seal mount

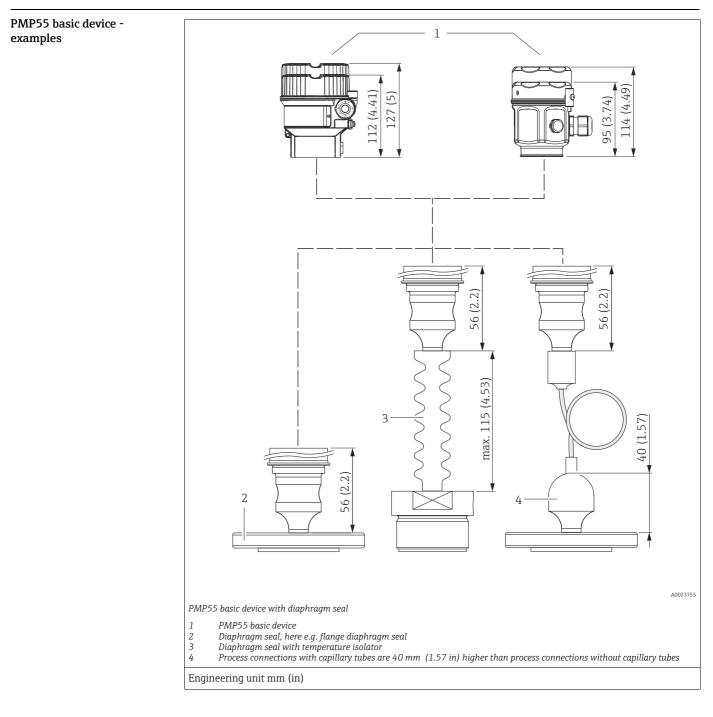


Material	Designation	Weight kg (lbs)	Approval <sup>1)</sup>	Option <sup>2)</sup>
AISI 316L (1.4404)	Prepared for diaphragm seal mount	1.9 (4.19)	CRN	XSJ

1) CSA approval: Product Configurator, "Approval" ordering feature

2) Product Configurator, "Process connection" ordering feature

## i



#### Diaphragm seal connection

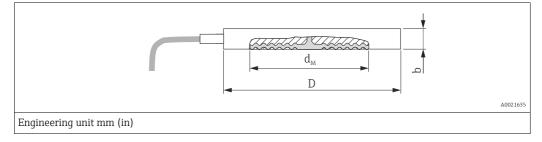
Designation	Option <sup>1)</sup>
Direct	А
Temperature isolator	В
m capillary	D
ft capillary	Е

1) Product Configurator, "Diaphragm seal connection" ordering feature



- The weights of the diaphragm seals are given in the tables. See → 
   <sup>1</sup>/<sub>2</sub> 41 ff for the weight of the housing.
- The following drawings are schematic diagrams. In other words, the dimensions of a diaphragm seal supplied may deviate from the dimensions given in this document.
- When using high-temperature oils the design can deviate significantly.
- Observe the information in the "Planning instructions for diaphragm seal systems" ordering feature
   → <sup>1</sup> 99 ff.
- For further information please contact your local Endress+Hauser Sales Center.

#### Diaphragm seal cell structure (Pancake)



Flange	Flange					Diaphragm seal		
Material	Nominal diameter	Nominal pressure <sup>3)</sup>	Max. Diameter	Thickness	Max. diameter of the process isolating diaphragm	Weight of two diaphragm seals		
			D	b	d <sub>M</sub>			
			[mm]	[mm]	[mm]	[kg (lbs)]		
	DN 50	PN 16-400	102	20	59	2.6 (5.73)	-	UIJ
	DN 80	PN 16-400	138	20	89	4.6 (10.14)	-	UJJ
	DN 100	PN 16-400	162	20	89	6.2 (13.67)	-	UKJ
AISI 316L	[in]	[lb/sq.in]	[in (mm)]	[in (mm)]	[in (mm)]	[kg]		
	2	150-2500	4.01 (102)	0.79 (20)	2.32 (59)	2.6 (5.73)	CRN	ULJ
	3	150-2500	5.35 (136)	0.79 (20)	3.50 (89)	4.6 (10.14)	CRN	UMJ
	4	150-2500	6.22 (158)	0.79 (20)	3.50 (89)	6.2 (13.67)	CRN	URJ

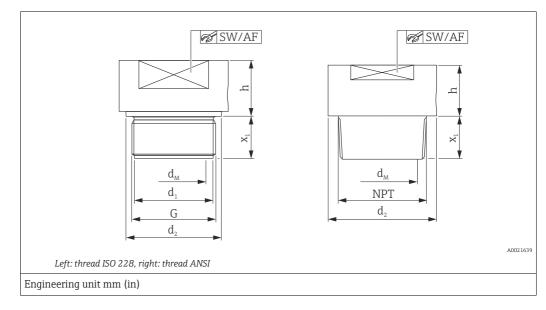
1) CSA approval: Product Configurator, "Approval" ordering feature

2) Product Configurator, "Process connection" ordering feature

3) The specified nominal pressure applies to the diaphragm seal. The maximum pressure for the measuring device is dependent on the lowest-rated element, with regard to pressure, of the selected components (see also → 🗎 40, "Pressure specifications" ordering feature).

# i

#### Thread ISO 228 and ANSI



Threaded co	onnection						Diaphragm s	seal		Approval <sup>1)</sup>	Option <sup>2)</sup>
Material	Thread	Nominal pressure	Diameter	Diameter	Screw-in length	Across flats	Max. diaphragm diameter	Height	Weight		
		PN	<b>d</b> <sub>1</sub>	d <sub>2</sub>	<b>x</b> <sub>1</sub>	SW/AF	d <sub>M</sub>	h			
			[mm]	[mm]	[mm]		[mm]	[mm]	[kg (lbs)]		
AISI 316L	G 1" A	400	30	39	21 <sup>3)</sup>	41	30	19	0.4 (0.88)	-	GTJ
Alloy C276									0.5 (1.1)	-	GTC
AISI 316L	G 1 ½" A	400	44	55	30	50	42	20	0.9 (1.98)	-	GVJ
Alloy C276									1.0 (2.21)	-	GVC
AISI 316L	G 2"	400	56	68	30	65	50	20	1.9 (4.19)	-	GWJ
Alloy C276									2.1 (4.63)	-	GWC
AISI 316L	1" MNPT	400	-	48	28	41	24	37	0.6 (1.32)	CRN	U5J
Alloy C276									0.7 (1.54)	CRN	U5C
AISI 316L	1 ½" MNPT	400	-	60	30	41	36	20	0.9 (1.98)	CRN	U7J
Alloy C276									1.0 (2.21)	CRN	U7C
AISI 316L	2" MNPT	400	-	78	30	65	38	35	1.8 (3.97)	CRN	U8J
Alloy C276									2.0 (4.41)	CRN	U8C

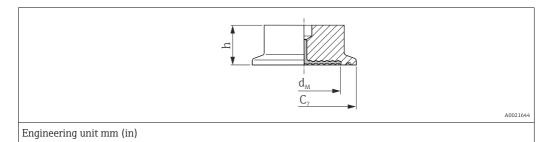
1) CSA approval: Product Configurator, "Approval" ordering feature

2) Product Configurator, "Process connection" ordering feature

3) 28 mm (1.1 in) in conjunction with high-temperature oil

# i

#### Tri-Clamp ISO 2852



Material 1) Approval<sup>2)</sup> Option <sup>3)</sup> Nominal Nominal Diameter Weight Nominal Max. diaphragm diameter Height diameter diameter diameter With TempC Standard ISO 2852 DIN 32676 diaphragm C<sub>7</sub> [mm] [kg (lbs)] [in] d<sub>M</sub> [mm] h [mm] d<sub>M</sub> [mm] ND 25 / 33.7 DN 25 50.5 24 37 0.32 (0.71) EHEDG, 3A, 1 TCI CRN, ASME-BPE TJJ <sup>4) 5)</sup> ND 38 DN 40 1 1/2 50.5 36 36 30 1 (2.21) EHEDG, 3A, CRN ASME-BPE TDJ <sup>4) 5)</sup> ND 40 / 51 DN 50 2 64 48 41 30 1.1 (2.43) EHEDG, 3A, AISI 316L CRN. ASME-BPE TEJ<sup>6)</sup> 2 1/2 77.5 EHEDG, 3A, ND 63.5 61 61 30 0.7 (1.54) ASME-BPE ND 76.1 3 91 73 61 30 1.2 (2.65) EHEDG, 3A, TFJ 5) CRN, ASME-BPE

1) Surface roughness of the surfaces in contact with the medium  $R_a \le 0.76 \mu m$  (29.9  $\mu in$ ) as standard. Lower surface roughness available on request.

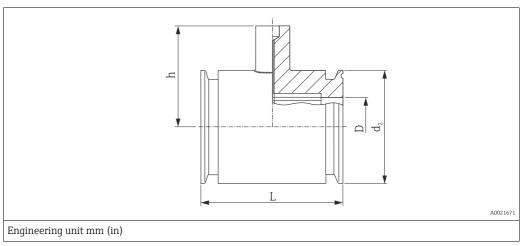
2) CSA approval: Product Configurator, "Approval" ordering feature

3) Product Configurator, "Process connection" ordering feature

- 4) Process connections without TempC diaphragm: diaphragm seal versions optionally in conformity with ASME-BPE for use in biochemical processes, wetted surfaces  $R_a \le 0.38 \ \mu m$  (0.15  $\mu in$ ), electropolished; to be ordered using feature 110 "Additional options", option P in the order code.
- 5) Alternatively available with TempC diaphragm.
- 6) With TempC diaphragm

## i

#### Pipe diaphragm seal Tri-Clamp ISO 2852



Material <sup>1)</sup>	Nominal diameter ISO 2852	Nominal diameter	Nominal pressure	Diameter	Diameter	Height	Face-to- face length	Weight	Approval <sup>2)</sup>	Option <sup>3)</sup>
		[in]		D [in]	d <sub>2</sub> [mm]	h [mm]	L [mm]	[kg (lbs)]		
	DN 25	1	PN 40	22.5	50.5	67	126	1.7 (3.75)	3A, CRN	SBJ
	DN 38	1 1/2	PN 40	35.5	50.5	67	126	1.0 (2.21)	3A, CRN	SCJ <sup>4)</sup>
AISI 316L	DN 51	2	PN 40	48.6	64	79	100	1.7 (3.75)	3A, CRN	SDJ <sup>4)</sup>
	DN 10	3⁄4	PN 40	10.3	25	42	138.5	0.6 (1.32)	3A, CRN	SIJ
	DN 16	3⁄4	PN 40	15.7	25	67	116	0.9 (1.98)	3A	SJJ

1) Surface roughness of the surfaces in contact with the medium  $R_a \le 0.8 \ \mu m$  (31.5  $\mu in$ ) as standard.

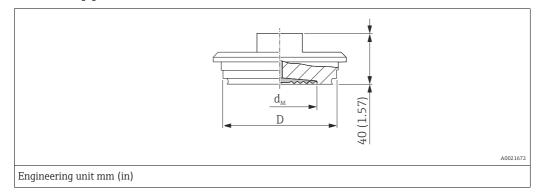
2) CSA approval: Product Configurator, "Approval" ordering feature

3) Product Configurator, "Process connection" ordering feature

4) incl. 3.1 and pressure test according to Pressure Equipment Directive, Category II

## i

Varivent for pipes



Material 1)	Designation	Nominal	Diameter	Max. diaphrag	m diameter	Weight	Approval	Option <sup>2)</sup>
		pressure		Standard	With TempC diaphragm			
			D	d <sub>M</sub> [mm]	d <sub>M</sub> [mm]	[kg (lbs)]		
AISI 316L	Type F for tubes DN 25 - DN 32	PN 40	71	34	36	0.4 (0.88)	EHEDG, 3A, ASME-BPE	TQJ <sup>3)</sup>
AISI 316L	Type N for tubes DN 40 - DN 162	PN 40	68	58	61	0.8 (1.76)	EHEDG, 3A, ASME-BPE	TRJ <sup>4)5)</sup>

1) Surface roughness of the surfaces in contact with the medium  $R_a \le 0.76 \ \mu m$  (29.9  $\mu in$ ) as standard.

2) Product Configurator, "Process connection" ordering feature

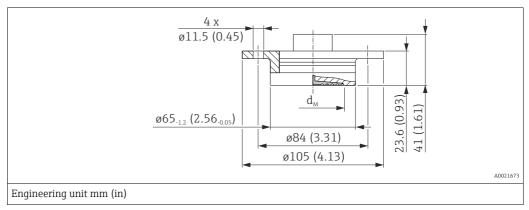
3) With TempC diaphragm

4) Diaphragm seal versions optionally in conformity with ASME-BPE for use in biochemical processes, wetted surfaces  $R_a \le 0.38 \mu m (15 \mu in)$ , electropolished; ordering information: Product Configurator "Service" ordering feature, option HK. In combination with the option "electropolished", the wetted parts of the Varivent connection are made of 316L (1.4435) with a delta-ferrite content of < 1% (welding seams excluded).

5) Alternatively available with TempC diaphragm.

PMP55: hygienic process connections with flushmounted process isolating diaphragm

#### DRD DN50 (65 mm)



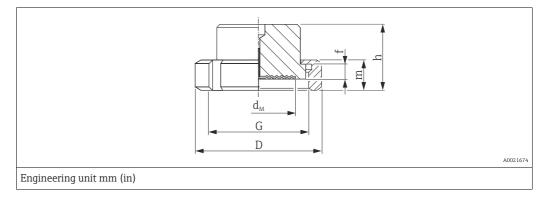
Material <sup>1)</sup>	Nominal	Max. diaphragm dia	meter	Weight	Option <sup>2)</sup>
	pressure	Standard	Standard With TempC diaphragm		
		d <sub>M</sub> [mm]	d <sub>M</sub> [mm]	[kg (lbs)]	
AISI 316L	PN 25	50	48	0.75 (1.65)	TIJ <sup>3)</sup>

1) Surface roughness of the surfaces in contact with the medium  $R_a \le 0.76 \mu m$  (29.9  $\mu in$ ) as standard.

2) Product Configurator, "Process connection" ordering feature

3) Alternatively available with TempC diaphragm.

#### SMS nozzles with coupling nut



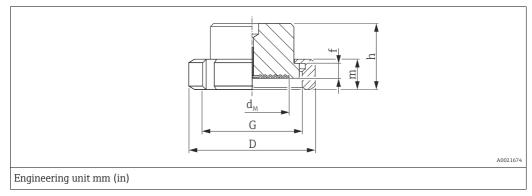
Material <sup>1)</sup>	Nominal diameter	Nominal pressure	Diameter	Adapter height	Thread	Height	Height	Max. diaphragm diameter	Weight	Approval	Option <sup>2)</sup>
			D	f	G	m	h	d <sub>M</sub>			
	[in]	[bar]	[mm]	[mm]		[mm]	[mm]	[mm]	[kg (lbs)]		
	1	PN 25	54	3.5	Rd 40 - 1/6	20	42.5	24	0.25 (0.55)	EHEDG, 3A, ASME-BPE	T6J
AISI 316L	1 1⁄2	PN 25	74	4	Rd 60 - 1/6	25	57	36	0,65 (1.43)	EHEDG, 3A, ASME-BPE	T7J <sup>3)</sup>
	2	PN 25	84	4	Rd 70 – 1/6	26	62	48	1.05 (2.32)	EHEDG, 3A, ASME-BPE	TXJ <sup>3)</sup>

1) Surface roughness of the surfaces in contact with the medium  $R_a \le 0.76 \ \mu m$  (29.9  $\mu in$ ) as standard.

2) Product Configurator, "Process connection" ordering feature

3) With TempC diaphragm

### APV-RJT nozzles with coupling nut

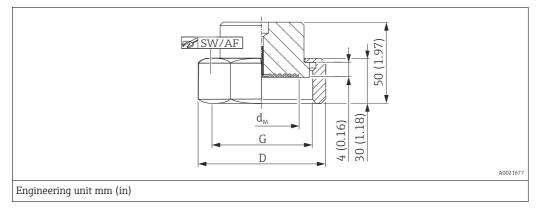


Material <sup>1)</sup>	Nominal diameter	Nominal pressure	Diameter	Adapter height	Thread	Height	Height	Max. diaphragm diameter	Weight	Option <sup>2)</sup>
		PN	D	f	G	m	h	d <sub>M</sub>		
	[in]	[bar]	[mm]	[mm]		[mm]	[mm]	[mm]	[kg (lbs)]	
	1	PN 40	77	6.5	1 13/16 - 1/8"	22	42.6	21	0.45 (0.99)	ТОЈ
AISI 316L	1 1/2	PN 40	72	6.4	2 5/16 - 1/8"	22	42.6	28	0.75 (1.65)	T1J
	2	PN 40	86	6.4	2 7/8 - 1/8"	22	42.6	38	1.2 (2.65)	T2J

1) Surface roughness of the surfaces in contact with the medium  $R_a \le 0.8 \ \mu m$  (31.5  $\mu$ in) as standard.

2) Product Configurator, "Process connection" ordering feature

# APV-ISS nozzles with coupling nut



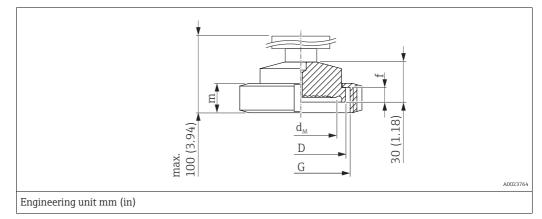
Material <sup>1)</sup>	Nominal diameter	Nominal pressure	Diameter	Thread		Max. diaphragm diameter	Weight	Option <sup>2)</sup>
			D	G	AF	d <sub>M</sub>		
	[in]	[bar]	[mm]			[mm]	[kg (lbs)]	
	1	PN 40	54.1	1 1⁄2" - 1/8"	46.8	24	0.4 (0.88)	T3J
AISI 316L	1 1/2	PN 40	72	2" - 1/8"	62	34	0.6 (1.32)	T4J
	2	PN 40	89	2 1⁄2" - 1/8"	77	45	1.1 (2.43)	T5J

1) Surface roughness of the surfaces in contact with the medium  $R_a\!\le\!0.8~\mu m$  (31.5  $\mu in)$  as standard.

2) Product Configurator, "Process connection" ordering feature

PMP55: hygienic process connections with flushmounted process isolating diaphragm

#### Aseptic screwed union, nozzle, DIN 11864-1 Form A; pipe DIN 11866-A

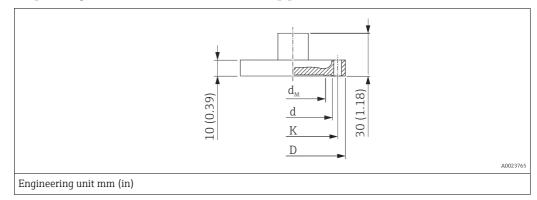


Material 1)	Taper adap	ter			Slotted nut		Diaphragm	seal	Approval	Option <sup>2)</sup>
	Nominal diameter	Nominal pressure	Diameter	Adapter height	Thread	Height	Max. diaphragm diameter	Weight Diaphragm seal		
			D	f	G	m	d <sub>M</sub>			
			[mm]	[mm]		[mm]	[mm]	[kg (lbs)]		
AISI 316L	DN 40	PN 40	55	10	Rd 65 x 1/6"	21	36	0.63 (1.39)	EHEDG, 3A, ASME-BPE	NCJ
AISI STOL	DN 50	PN 25	67	11	Rd 78 x 1/6"	22	48	0.92 (2.03)	EHEDG, 3A, ASME-BPE	NDJ

1) Surface roughness of the surfaces in contact with the medium  $R_a \le 0.8 \ \mu m$  (31.5  $\mu in$ ) as standard.

2) Product Configurator, "Process connection" ordering feature

#### Aseptic flange connection, DIN 11864-2 Form A; pipe DIN 11866-1

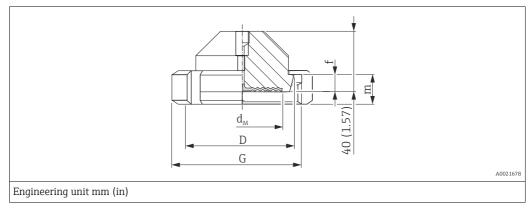


Material 1)	Collar flan	ge				Diaphragm	seal	Approval	Option <sup>2)</sup>
	Nominal diameter	Nominal pressure				Max. diaphragm diameter	Weight Diaphragm seal		
			К	d	D	d <sub>M</sub>			
			[mm]	[mm]	[mm]	[mm]	[kg]		
	DN 32		59	47.7	76	25	1.5 (3.31)	EHEDG, 3A, ASME-BPE	NFJ
AISI 316L	DN 40	PN 16	65	53.7	82	35	1.7 (3.75)	EHEDG, 3A, ASME-BPE	NXJ
	DN 50		77	65.7	94	45	2.2 (4.85)	EHEDG, 3A, ASME-BPE	NZJ

1) Surface roughness of the surfaces in contact with the medium  $R_a \le 0.8 \mu m$  (31.5  $\mu in$ ) as standard.

2) Product Configurator, "Process connection" ordering feature

## Taper adapter with coupling nut, DIN 11851



Material 1)	Taper adap	oter			Slotted nut		Diaphragm	seal		Approval	Option
	Nominal diameter	Nominal pressure	Diameter	Adapter height	Thread	Height	Max. diaphragm diameter		Weight		2)
			D	f	G	m	Standard	With TempC diaphragm			
			[mm]	[mm]		[mm]	d <sub>M</sub> [mm]	d <sub>M</sub> [mm]	[kg (lbs)]		
	DN 32	PN 40	50	10	Rd 58 x 1/6"	21	32	28	0.45 (0.99)	EHEDG, 3A, ASME-BPE	MIJ <sup>3)</sup>
	DN 40	PN 40	56	10	Rd 65 x 1/6"	21	38	36	0.45 (0.99)	EHEDG, 3A, ASME-BPE	MZJ <sup>3)</sup>
AISI 316L	DN 50	PN 25	68.5	11	Rd 78 x 1/6"	19	52	48	1.1 (2.43)	EHEDG, 3A, ASME-BPE	MRJ <sup>4)</sup>
	DN 65	PN 25	86	12	Rd 95 x 1/6"	21	66	61	2.0 (4.41)	EHEDG, 3A, ASME-BPE	MSJ <sup>4)</sup>
	DN 80	PN 25	100	12	Rd 110 x 1/4"	26	81	61	2.55 (5.62)	EHEDG, 3A, ASME-BPE	MTJ <sup>4)</sup>

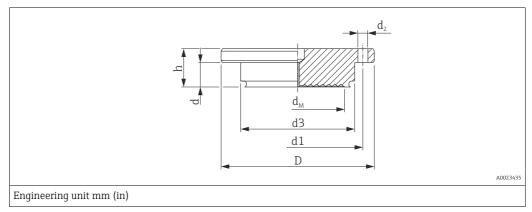
1) Surface roughness of the surfaces in contact with the medium  $R_a \le 0.76 \ \mu m$  (29.9  $\mu in$ ) as standard.

2) Product Configurator, "Process connection" ordering feature

3) With TempC diaphragm

4) Alternatively available with TempC diaphragm.

#### **NEUMO BioControl**



Material 1)	Threaded	adapter							Diaphragn	n seal		Approval	Option <sup>2)</sup>
	Nominal diameter	Nominal pressure	D	d	d <sub>1</sub>	d <sub>2</sub>	d <sub>3</sub>	Height	Max. diaphragm Wei diameter		Weight		
								h	Standard	With TempC diaphragm			
			[mm]	[mm]	[mm]	[mm]	[mm]	[mm]	d <sub>M</sub> [mm]	d <sub>M</sub> [mm]	[kg]		
	DN 50	PN 16	90	17	70	4 x Ø 9	50	27	40	41	1.1 (2.43)	3A, ASME-BPE	S4J <sup>3)</sup>
AISI 316L	DN 80	PN 16	140	25	115	4 x Ø 11	87.4	37	-	61	2.6 (5.73)	EHEDG, 3A, ASME-BPE	S6J <sup>3)</sup>

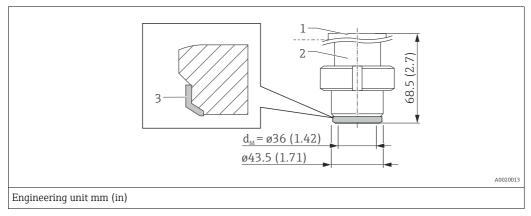
1) Surface roughness of the surfaces in contact with the medium  $R_a \le 0.76 \ \mu m$  (29.9  $\mu in$ ) as standard.

2) Product Configurator, "Process connection" ordering feature

3) With TempC diaphragm

*Temperature application range* -10 °C to +200 °C (14 °F to +392 °F)

### Universal adapter

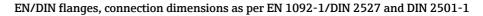


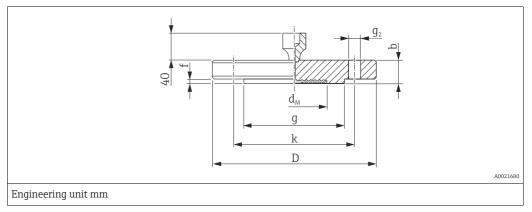
Designation	Nominal pressure	Material <sup>1)2)</sup>	Weight [kg/lbs]	Approval <sup>3)</sup>	Option <sup>4)</sup>
Universal adapter with pre-installed silicone <sup>5)</sup> molded seal (item 3)	PN 10	<ul> <li>Item 1: top section AISI 316L (1.4404)</li> <li>Item 2: bottom section AISI 316L (1.4435)</li> </ul>	0.8 (1.76)	EHEDG, 3A, ASME-BPE	UPJ <sup>6)</sup>

 The roughness of the surface in contact with the medium is R<sub>a</sub> 0.76 µm (30 µin). Version optionally in conformity with ASME-BPE for use in biochemical processes, wetted surfaces R<sub>a</sub> 0.38 µm (15 µin), electropolished; ordering information: Product Configurator, "Service" ordering feature, option "HK".

- 2) Endress+Hauser supplies these slotted nuts in stainless steel AISI 304 (1.4301) or in AISI 304L (1.4307).
- 3) EHEDG or 3A approval only with approved process connection.
- 4) Product Configurator, "Process connection" ordering feature
- 5) Molded seal FDA 21CFR177.2600/USP Class VI-70C, EHEDG, 3A, spare part no.: 52023572
- 6) Alternatively available with TempC diaphragm.

PMP55: process connections with flush-mounted process isolating diaphragm





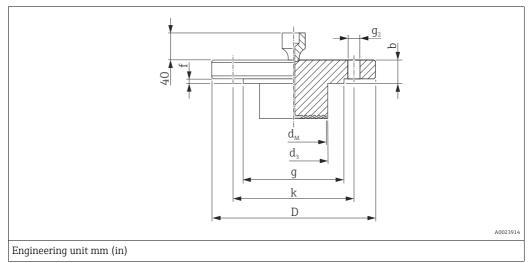
Flanges 1)	2)							Bolthol	es		Diaphragm	seal	Option <sup>3)</sup>
Material	Nominal diameter	Nominal pressure	Shape 4)	Diameter	Thick ness	Raise	d face	Quanti ty	Diamet er	Hole circle	Max. diaphragm diameter	Weight	-
				D	b	g	f		<b>g</b> <sub>2</sub>	k	d <sub>M</sub>		
		PN		[mm]	[mm]	[mm]			[mm]	[mm]	[mm]	[kg (lbs)]	
	DN 25	10-40	B1 (D)	115	18	68	3	4	14	85	32	2.1 (4.63)	CNJ
	DN 25	63-160	B2 (E)	140	24	68	2	4	18	100	28	2.5 (5.51)	QIJ
	DN 25	250	B2 (E)	150	28	68	2	4	22	105	28	3.7 (8.16)	QJJ
	DN 25	400	B2 (E)	180	38	68	2	4	26	130	28	7.0 (15.44)	QSJ
	DN 32	10-40	B1 (D)	140	18	77	2,6	4	18	100	34	1.9 (4.19)	СРЈ
	DN 40	10-40	B1 (D)	150	18	87	2,6	4	18	110	48	2.2 (4.85)	CQJ
AISI 316L	DN 50	10-40	B1 (D)	165	20	102	3	4	18	125	59	3.0 (6.62)	CXJ
AISI 510L	DN 50	63	B2 (E)	180	26	102	3	4	22	135	59	4.6 (10.14)	PDJ
	DN 50	100-160	B2 (E)	195	30	102	3	4	26	145	59	6.2 (13.67)	QOJ
	DN 50	250	B2 (E)	200	38	102	3	8	26	150	59	7.7 (16.98)	QMJ
	DN 50	400	B2 (E)	235	52	102	3	8	30	180	59	14.7 (32.41)	QVJ
	DN 80	10-40	B1 (D)	200	24	138	3.5	8	18	160	89	5.3 (11.69)	CZJ
	DN 80	100	B2 (E)	230	32	138	4	8	24	180	89	8.9 (19.62)	РРЈ
	DN 100	100	B2 (E)	265	36	175	5	8	30	210	89	13.7 (30.21)	PQJ

1) The roughness of the surface in contact with the medium, including the raised face of the flanges (all standards) made of Alloy C, Monel or tantalum is Ra <0.8  $\mu$ m (31.5  $\mu$ in). Lower surface roughness available on request.

2) In the case of process isolating diaphragms made of Alloy C, Monel or tantalum, the flange raised face is made of the same material as the process isolating diaphragm.

3) Product Configurator, "Process connection" ordering feature

4) Designation as per DIN 2527 in brackets



# EN/DIN flanges with barrel (extended diaphragm seal), connection dimensions as per EN 1092-1/DIN 2527 and DIN 2501-1

Flanges 1)					Boltholes			Diaphragm s	Option <sup>2)</sup>				
Material	Nominal diameter	Nominal pressure	Shape <sup>3)</sup>	Diameter	Thickn ess	Raise	d face	Quant ity	Diameter	Hole circle	Max. diaphragm diameter	Weight	
				D	b	g	f		<b>g</b> <sub>2</sub>	k	d <sub>M</sub>		
				[mm]	[mm]	[mm]	[mm]		[mm]	[mm]	[mm]	[kg (lbs)]	
AISI 316L	DN 50	PN 10-40	B1 (D)	165	20	102	3	4	18	125	47	4)	FDJ <sup>4)</sup>
AISI 510L	DN 80	PN 10-40	B1 (D)	200	24	138	3.5	8	18	160	72	4)	FEJ <sup>4)</sup>

1) The roughness of the surface in contact with the medium, including the raised face of the flanges (all standards) made of Alloy C, Monel or tantalum is Ra <0.8  $\mu$ m (31.5  $\mu$ in). Diaphragm seal versions optionally in conformity with ASME-BPE for use in biochemical processes, wetted surfaces R<sub>a</sub> < 0.38  $\mu$ m (15  $\mu$ in), electropolished; ordering information: Product Configurator "Service" ordering feature, option HK.

2) Product Configurator, "Process connection" ordering feature

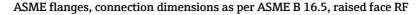
3) Designation as per DIN 2527 in brackets

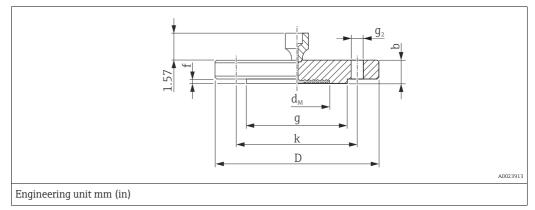
4) Available with 50 mm (1.97 in), 100 mm (3.94 in) or 200 mm (7.87 in) barrel (extended diaphragm seal), for barrel (extended diaphragm seal) diameter and weight see the following table

Option <sup>1)</sup>	Nominal diameter	Nominal pressure	Barrel (extended diaphragm seal) length (L)	Barrel (extended diaphragm seal) diameter d <sub>3</sub>	Weight
			[mm]	[mm]	[kg (lbs)]
FDJ	DN 50	PN 10-40	50 / 100 / 200	48.3	3.2 (7.1)/ 3.8 (8.4)/ 4.4 (9.7)
FEJ	DN 80	PN 10-40	50 / 100 / 200	76	6.2 (13.7)/ 6.7 (14.8)/ 7.8 (17.2)

1) Product Configurator, "Process connection" ordering feature

PMP55: process connections with flush-mounted process isolating diaphragm





Material 1)	Flange <sup>2) 3</sup>	;)					Boltho	les		Diaphragm	seal	Approval	Option <sup>5)</sup>
	Nominal diameter	Class	Diamet er	Thick ness	Raise	d face	Quant ity	Diame ter	Hole circle	Max. diaphragm diameter	Weight	- 4)	
			D	b	g	f		<b>g</b> <sub>2</sub>	k	d <sub>M</sub>			
	[in]	[lb./sq.in]	[in]	[in]	[in]	[in]		[in]	[in]	[in]	[kg (lbs)]		
	1	150	4.25	0.56	2	80.0	4	0.62	3.12	1.26	1.2 (2.65)	CRN	ACJ
	1	300	4.88	0.69	2	80.0	4	0.75	3.5	1.26	1.3 (2.87)	CRN	ANJ
	1	400/600	4.88	0.69	2	0.25	4	0.75	3.5	1.26	1.4 (3.09)	CRN	A0J
	1	900/1500	5.88	1.12	2	0.25	4	1	4	1.26	3.2 (7.06)	CRN	A2J
	1	2500	6.25	1.38	2	0.25	4	1	4.25	1.26	4.6 (10.14)	CRN	A4J
	1 1/2	150	5	0.69	2.88	0.06	4	0.62	3.88	1.89	1.5 (3.31)	CRN	AEJ
	1 1/2	300	6.12	0.81	2.88	0.06	4	0.88	4.5	1.89	2.6 (5.73)	CRN	AQJ
AISI 316/	2	150	6	0.75	3.62	0.06	4	0.75	4.75	2.32	2.2 (4.85)	CRN	AFJ
316L	2	300	6.5	0.88	3.62	0.06	8	0.75	5	2.32	3.4 (7.5)	CRN	ARJ
	2	400/600	6.5	1	3.62	0.25	8	0.75	5	2.32	4.3 (9.48)	CRN	A1J
	2	900/1500	8.5	1.5	3.62	0.25	8	1	6.5	2.32	10.3 (22.71)	CRN	A3J
	2	2500	9.25	2	3.62	0.25	8	1.12	6.75	2.32	15.8 (34.84)	CRN	A5J
	3	150	7.5	0.94	5	0.06	4	0.75	6	3.50	5.1 (11.25)	CRN	AGJ
	3	300	8.25	1.12	5	0.06	8	0.75	6	3.50	7.0 (15.44)	CRN	ASJ
	4	150	9	0.94	6.19	0.06	8	0.75	7.5	3.50	7.2 (15.88)	CRN	AHJ
	4	300	10	1.25	6.19	0.06	8	0.88	7.88	3.50	11.7 (25.8)	CRN	ATJ

1) Combination of AISI 316 for required pressure resistance and AISI 316L for required chemical resistance (dual rated)

 The roughness of the surface in contact with the medium, including the raised face of the flanges (all standards) made of Alloy C, Monel or tantalum is Ra <0.8 μm (31.5 μin). Lower surface roughness available on request.</li>

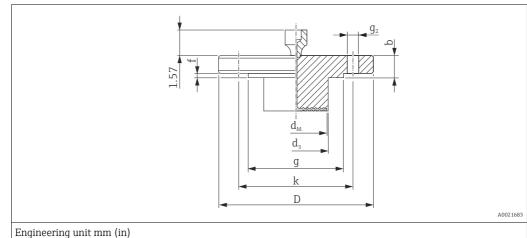
3) In the case of process isolating diaphragms made of Alloy C, Monel or tantalum, the flange raised face is made of the same material as the process isolating diaphragm.

4) CSA approval: Product Configurator, "Approval" ordering feature

5) Product Configurator, "Process connection" ordering feature

i

Some device versions have CRN approval. A CRN-approved process connection with a CSA approval must be ordered for a CRN-approved device. These devices are fitted with a separate plate bearing the registration number 0F10525.5C.



#### ASME flanges with barrel (extended diaphragm seal), connection dimensions as per ASME B 16.5, raised face RF

Engineering unit mm (in)

Flange 1)	Flange <sup>1)</sup>						Bolthol	tholes Diaphragm seal		eal	Approval <sup>2)</sup>	Option <sup>3)</sup>	
Material <sup>4)</sup>	Nominal diameter	Class	Diamet er	Thick ness		sed .ce	Quanti ty	Diamet er	Hole circle	Max. diaphragm diameter	Weight	-	
			D	b	g	f		<b>g</b> <sub>2</sub>	k	d <sub>M</sub>			
	[in]	[lb./sq.in]	[in]	[in]	[in]	[in]		[in]	[in]	[in]	[kg (lbs)]		
	2	150	6	0.75	3.62	0.06	4	0.75	4.75	1.85	5)	CRN	FMJ <sup>5)</sup>
	3	150	7.5	0.94	5	0.06	4	0.75	6	2.83	5)	CRN	FNJ <sup>5)</sup>
AISI 316/ 316L	3	300	8.25	1.12	5	0.06	8	0.88	6.62	2.83	5)	CRN	FWJ 5)
2102	4	150	9	0.94	6.19	0.06	8	0.75	7.5	3.50	5)	CRN	FOJ 5)
	4	300	10	1.25	6.19	0.06	8	0.88	7.88	3.50	5)	CRN	FXJ <sup>5)</sup>

1) The roughness of the surface in contact with the medium, including the raised face of the flanges (all standards) made of Alloy C, Monel or tantalum is Ra 0.8 µm (31.5 µin). Diaphragm seal versions optionally in conformity with ASME-BPE for use in biochemical processes, wetted surfaces  $R_a \le 0.38 \ \mu m$  (15  $\mu in$ ), electropolished; ordering information: Product Configurator "Service" ordering feature, option HK.

2) CSA approval: Product Configurator, "Approval" ordering feature

3) Product Configurator, "Process connection" ordering feature

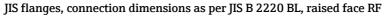
- 4) Combination of AISI 316 for required pressure resistance and AISI 316L for required chemical resistance (dual rated)
- Available with 2", 4", 6" and 8" barrel (extended diaphragm seal), for barrel (extended diaphragm seal) diameter and weight see the following table 5)

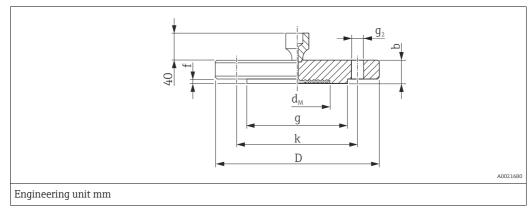
# fi

Some device versions have CRN approval. A CRN-approved process connection with a CSA approval must be ordered for a CRN-approved device. These devices are fitted with a separate plate bearing the registration number 0F10525.5C.

-	Nominal diameter	Class	(L)	Barrel (extended diaphragm seal diameter d <sub>3</sub>	Weight
	[in]	[lb./sq.in]	in (mm)	in (mm)	[kg (lbs)]
FMJ	2	150	2 (50.8) / 4 (101.6) / 6 (152.4) / 8 (203.2)	1.9 (48.3)	3.0 (6.6)/ 3.4 (7.5)/ 3.9 (8.6)/ 4.4 (9.7)
FNJ	3	150	2 (50.8) / 4 (101.6) / 6 (152.4) / 8 (203.2)	2.99 (76)	6.0 (13.2) / 6.6 (14.5) / 7.1 (15.7) / 7.8 (17.2)
FWJ	3	300	2 (50.8) / 4 (101.6) / 6 (152.4) / 8 (203.2)	2.99 (76)	7.9 (17.4) / 8.5 (18.7) / 9.0 (19.9) / 9.6 (21.2)
FOJ	4	150	2 (50.8) / 4 (101.6) / 6 (152.4) / 8 (203.2)	3.7 (94)	8.6 (19) / 9.9 (21.8) / 11.2 (24.7) / 12.4 (27.3)
FXJ	4	300	2 (50.8) / 4 (101.6) / 6 (152.4) / 8 (203.2)	3.7 (94)	13.1 (28.9)/ 14.4 (31.6)/ 15.7 (34.6)/ 16.9 (37.3)

1) Product Configurator, "Process connection" ordering feature





Flange 1) 2)	lange <sup>1) 2)</sup>						Bolthol	es		Diaphragm s	eal	Option <sup>3)</sup>
Material	Nominal diameter	Nominal pressure	Diameter	Thickn ess	Diameter of raised face	Height of raised face	Quanti ty	Diamet er	Hole circle	Max. diaphragm diameter	Weight	
			D	b	g	f		<b>g</b> <sub>2</sub>	k	d <sub>M</sub>		
			[mm]	[mm]	[mm]	[mm]		[mm]	[mm]	[mm]	[kg (lbs)]	
	25 A	10 K	125	14	67	1	4	19	90	32	1.5 (3.31)	КСЈ
	40 A	10 K	140	16	81	2	4	19	105	48	2.0 (4.41)	KEJ
AISI 316L	50 A	10 K	155	16	96	2	4	19	120	59	2.3 (5.07)	KFJ
	80 A	10 K	185	18	127	2	8	19	150	89	3.3 (7.28)	KGJ
	100 A	10 K	210	18	151	2	8	19	175	89	4.4 (9.7)	КНЈ

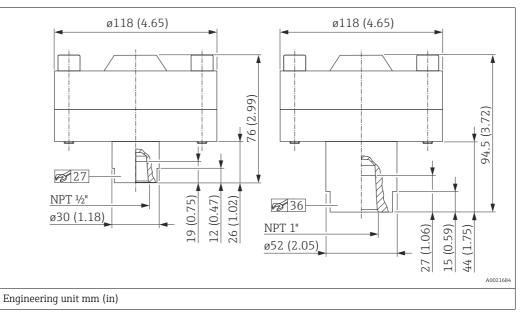
 The roughness of the surface in contact with the medium, including the raised face of the flanges (all standards) made of Alloy C, Monel or tantalum is Ra 0.8 μm (31.5 μin). Lower surface roughness available on request.

2) In the case of process isolating diaphragms made of Alloy C, Monel or tantalum, the flange raised face is made of the same material as the process isolating diaphragm.

3) Product Configurator, "Process connection" ordering feature

PMP55: process connections with flush-mounted process isolating diaphragm

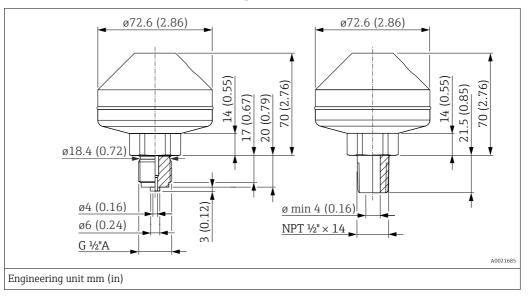
Thread 1/2 NPT and 1 NPT, separator



Material	Designation	Measuring range [bar (psi)]	Nominal pressure	Weight [kg (lbs)]	Option <sup>1)</sup>
AISI 316L	Threaded, ½" NPT with Viton seal	· ≤ 250 (3625)	PN 250	4.75 (10.47)	UGJ
AISI J I UL	Threaded, 1" NPT with Viton seal		PN 250	5.0 (11.03)	UHJ

1) Product Configurator, "Process connection" ordering feature

#### Thread ISO 228 G 1/2 A and ANSI 1/2 MNPT, separator



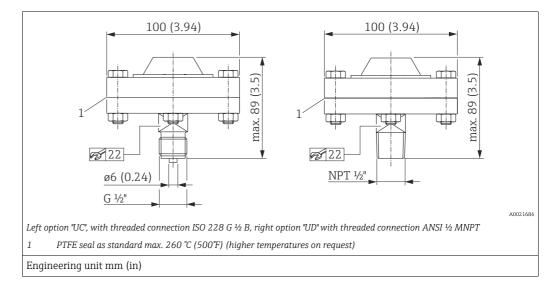
Material	Designation	Measuring range [bar (psi)]	Nominal pressure	Weight [kg (lbs)]	Approval	Option <sup>1)</sup>
AISI 316L	Welded, ISO 228 G ½ A EN837	<ul> <li>≤ 160 (2320)</li> </ul>	PN 160	1.43 (3.15)	-	UBJ
	Welded, ANSI ½ MNPT	≤ 100 (2320)	PN 160	1.45 (5.15)	CRN <sup>2)</sup>	UCJ

1) Product Configurator, "Process connection" ordering feature

2) CSA approval: Product Configurator, "Approval" ordering feature

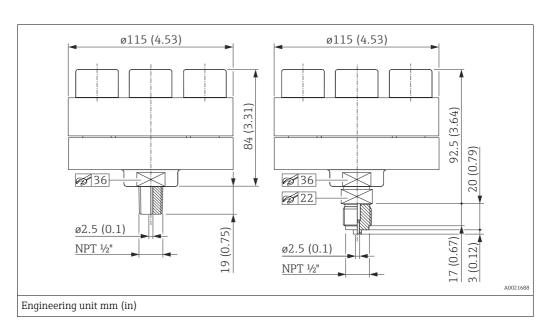
# i

Some device versions have CRN approval. A CRN-approved process connection with a CSA approval must be ordered for a CRN-approved device. These devices are fitted with a separate plate bearing the registration number 0F10525.5C.



Material	Designation	Measuring range [bar (psi)]	Nominal pressure	Weight [kg (lbs)]	Option <sup>1)</sup>
AISI 316L (1.4404),	ISO 228 G ½ B EN837	≤ 40 (580)	PN 40	1.43 (3.15)	UDJ
screws made of 1.4571	ANSI ½ MNPT	≤ 40 bar (580)	PN 40	1.45 (5.15)	UEJ

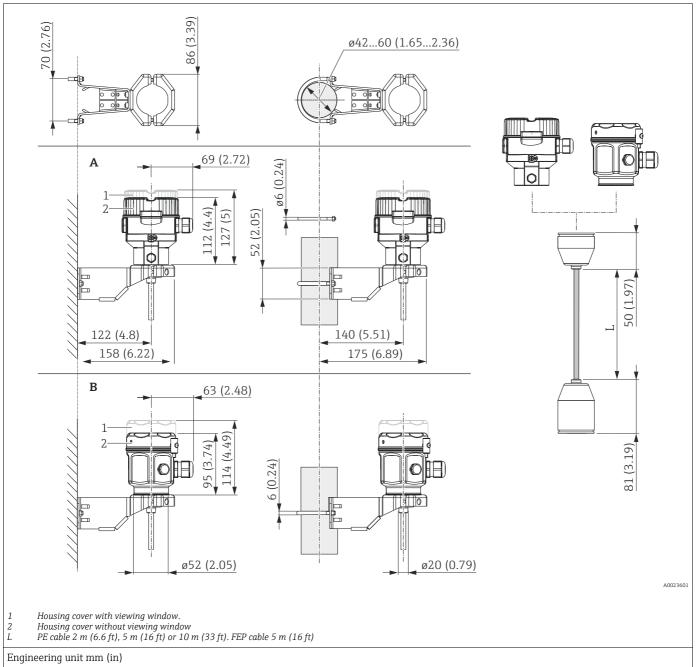
1) Product Configurator, "Process connection" ordering feature



Material	Designation	Measuring range [bar (psi)]	Nominal pressure	Weight [kg (lbs)]	Option <sup>1)</sup>
AISI 316L (1.4404), screws made of 1.4571	Threaded, ISO 228 G ½ B EN837, with integrated seal lip	> 40 (580)	PN 400	4.75 (10.47)	UDJ
	Threaded, ANSI ½ MNPT, with integrated seal lip	> 40 (580)	PN 400	4.75 (10.47)	UEJ

1) Product Configurator, "Process connection" ordering feature

# Wall and pipe mounting with mounting bracket



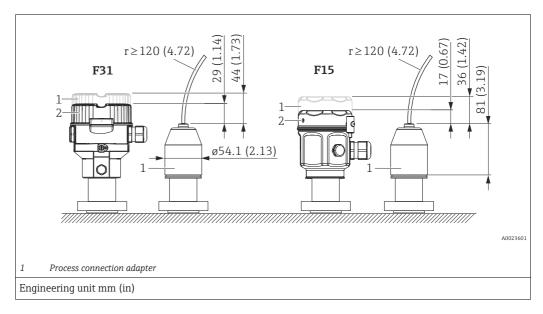
Item	Designation	Weight		Option <sup>1)</sup>
		Housing (F31 or F15)	Mounting bracket	
А	Dimensions with F31 housing	$\rightarrow$ $\triangleq$ 41 ff	0 = lra (1, 10)	TT
В	Dimensions with F15 housing	$\rightarrow$ $\equiv$ 41 II	0.5 kg (1.10)	U

1) Product Configurator, "Separate housing" ordering feature

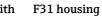
Also available for order as a separate accessory: part number 71102216

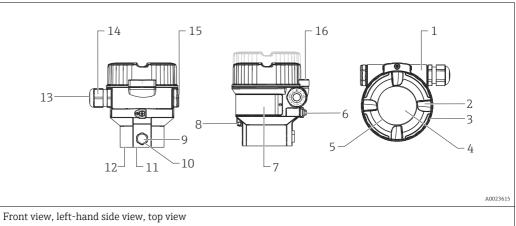
# Reduction in installation height

If the separate housing is used, the mounting height of the process connection is reduced compared to the dimensions of the standard version.



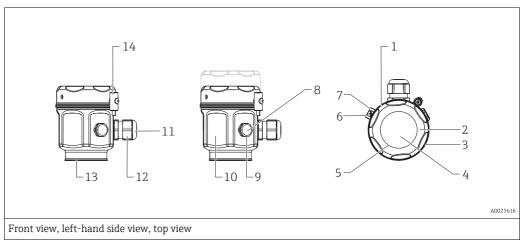
### Materials not in contact with process





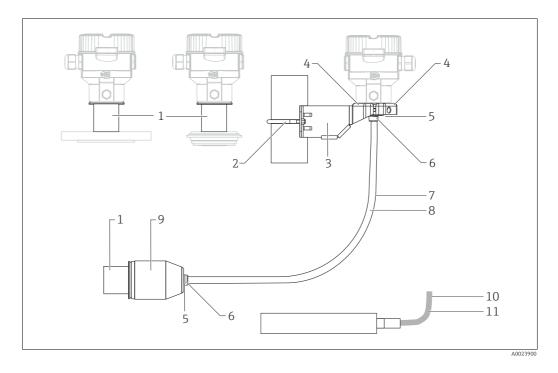
Item number	Component part	Material
1	F31 housing, RAL 5012 (blue)	Die-cast aluminum with protective powder-coating on polyester base
2	Cover, RAL 7035 (gray)	Die-cast aluminum with protective powder-coating on polyester base
3	Cover seal	EPDM
4	Sight glass	Mineral glass
5	Sight glass seal	Silicone (VMQ)
6	External ground terminal	AISI 304 (1.4301)
7	Nameplates	Plastic film
8	Attachement for tie-on label	AISI 304 (1.4301)/ AISI 316 (1.4401)
9	Pressure compensation filter	AISI 316L (1.4404) and PBT-FR
10	Pressure compensation filter, O-ring	VMQ or EPDM
11	Sealing ring	EPDM
12	Snap ring	PC Plastic
13	Seal of cable gland and blind plug	EPDM/NBR
14	Cable gland	Polyamide (PA), for dust ignition-proof: CuZn nickel- plated
15	Blind plug	PBT-GF30 FR
		for dust ignition-proof, Ex d, FM XP and CSA XP: AISI 316L (1.4435)
16	Cover clamp	Clamp AISI 316L (1.4435), screw A4

## F15 housing



Item number	Component part	Material			
1	F15 housing				
2	Cover	- AISI 316L (1.4404)			
3	Cover seal	Silicone with PTFE coating			
4	Sight glass for non-hazardous area, ATEX Ex ia, NEPSI Zone 0/1 Ex ia, IECEx Zone 0/1 Ex ia, FM NI, FM IS, CSA IS	Polycarbonate (PC)			
4	Sight glass for ATEX 1/2 D, ATEX 1/3 D, ATEX 1 GD, ATEX 1/2 GD, ATEX 3 G, FM DIP, CSA dust ignition-proof	Mineral glass			
5	Sight glass seal	Silicone (VMQ)			
6	External ground terminal	AISI 304 (1.4301)			
7	Attachement for tie-on label	AISI 304 (1.4301)/ AISI 316 (1.4401)			
8	Pressure compensation filter	AISI 316L (1.4404) and PBT-FR			
9	Pressure compensation filter, O-ring	VMQ or EPDM			
10	Nameplates	lasered			
11	Cable gland	Polyamide (PA), for dust ignition-proof: CuZn nickel-plated			
12	Seal of cable gland and blind plug	NBR/Silicone/EPDM			
13	Sealing ring	EPDM			
14	Screw	A4-50			

## Connecting parts



Item number	Component part	Material
1	Connection between the housing and process connection	AISI 316L (1.4404)
2	Mounting bracket	Bracket AISI 316L (1.4404)
3		Screw and nuts A4-70
4		Half-shells: AISI 316L (1.4404)
5	Seal for cable from Separate housing	FKM, EPDM
6	Gland for cable from separate housing: Screws:	AISI 316L (1.4404) A2
7	PE cable for separate housing	Abrasion-proof cable with strain-relief Dynema members; shielded using aluminum-coated film; insulated with polyethylene (PE-LD), black; copper wires, twisted, UV-resistant
8	FEP cable for separate housing	Abrasion-proof cable; shielded using galvanized steel wire netting; insulated with fluorinated ethylene propylene (FEP), black; copper wires, twisted, UV-resistant
9	Process connection adapter for separate housing	AISI 316L (1.4404)
10	Capillary	AISI 316 Ti (1.4571)
11	Protective hose for capillary	AISI 304 (1.4301)

## Fill fluid

Designation	Option PMP51 <sup>1)</sup>	Option PMP55 <sup>1)</sup>
Silicone oil	1	1
Inert oil	2	2
NSF-H1 synthetik oil according to FDA 21 CFR 178.3570	3	-

Designation	Option PMP51 <sup>1)</sup>	Option PMP55 <sup>1)</sup>
Vegetable oil, FDA	-	4
High-temperature oil	-	5
Low-temperature oil	-	6

1) Product Configurator, "Fill fluid" ordering feature

# Materials in contact with the process

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The wetted device components are listed in the "Mechanical construction" ( $\rightarrow \triangleq 41 \text{ ff}$ ) and "Ordering information" ( $\rightarrow \triangleq 108 \text{ ff}$ ) sections.

#### TSE Certificate of Suitability (Transmissible Spongiform Encephalopathy)

The following applies to all process wetted device components:

- They do not contain any materials derived from animals.
- No auxiliaries or operating materials derived from animals are used in production or processing.

#### **Process connections**

- "Clamp connections" and "Hygienic process connections" (see also "Ordering information" ordering feature): AISI 316L (DIN/EN material number 1.4435)
- Endress+Hauser supplies process connections with threaded connections and DIN/ EN flanges made of stainless steel as per AISI 316L (DIN/EN material number 1.4404 (AISI 316) or 14435). With regard to their stability-temperature property, the materials 1.4404 and 1.4435 are grouped together under 13E0 in EN 1092-1 Tab.18. The chemical composition of the two materials can be identical.
- Some process connections are also available in the material Alloy C276 (DIN/EN material number 2.4819). See the information in the "Mechanical construction" ordering feature.

#### Process isolating diaphragm

Туре	Designation	Option <sup>1)</sup>
PMC51	$Al_2O_3$ aluminum oxide ceramic (FDA 21CFR186.1256, USP Class VI), ultrapure 99.9 % (see also www.endress.com/ceraphire)	Standard
	AISI 316L (DIN/EN material number 1.4435)	А
PMP51	AISI 316L with gold-rhodium coating	М
	Alloy C276 (DIN/EN material number 2.4819)	В
	AISI 316L (DIN/EN material number 1.4435)	А
	AISI 316L, TempC	E
	AISI 316L with gold-rhodium coating	М
PMP55	AISI 316L with 0.25 mm (0.01 in) PTFE foil (not for vacuum applications)	S
	Alloy C276 (DIN/EN material number 2.4819)	B <sup>2)</sup>
	Monel	C <sup>2)</sup>
	Tantalum	D <sup>2)</sup>

1) Product Configurator, "Material of the process isolating diaphragm" ordering feature

2) The flange raised face is made from the same material as the process isolating diaphragm.

Туре	Designation	Option 1)
	FKM Viton	А
	FKM Viton, FDA, 3A Class I, USP Class VI	В
	NBR	F
	HNBR, FDA, 3A Class II, KTW, AFNOR, BAM	G
	NBR, Low temperature	Н
PMC71	EPDM, FDA	J
	EPDM, FDA, 3A Class II, USP Class VI, DVGW, KTW, W270, WRAS, ACS, NSF61	К
	FFKM Kalrez 6375	L
	FFKM Kalrez 7075	М
	FFKM Kalrez 6221, FDA, USP Class VI	N
	Fluoroprene XP40, FDA, USP Class VI, 3A Class I	Р
	VMQ Silicone, FDA	S

1) Product Configurator, "Seal" ordering feature

# Operability

Operating concept	Operator-oriented menu structure for user-specific tasks						
	<ul> <li>Commissioning</li> </ul>						
	<ul> <li>Operation</li> </ul>						
	Diagnostics     Fynort loval						
	<ul> <li>Expert level</li> </ul>						
	Quick and safe commissioning						
	Guided menus for applications						
	Reliable operation						
	<ul> <li>Onsite operation possible in several languages</li> </ul>						
	<ul> <li>Standardized operation at the device and in the operating tools</li> </ul>						
	<ul> <li>Parameters can be locked/unlocked using the device's write protection switch, using the device software or via remote control.</li> </ul>						
	Efficient diagnostics increase measurement availability						
	<ul><li>Remedial measures are integrated in plain text</li><li>Diverse simulation options</li></ul>						
Onsite operation	Local display (optional) for devices with HART, PROFIBUS PA or FOUNDATION Fieldbu electronics						
	A 4-line liquid crystal display (LCD) is used for display and operation. The local display shows measured values, dialog texts as well as fault and notice messages in plain text, thereby supporting the user at every stage of operation. The liquid crystal display of the device can be turned in 90° stages. Depending on the orientation of the device, this makes it easy to operate the device and read the measured values.						
	<ul> <li>Functions</li> <li>8-digit measured value display including sign and decimal point, bar graph for 4 to 20 mA HART a current display; or for PROFIBUS PA as graphic display of the standardized value of the AI Block; fo FOUNDATION Fieldbus as graphic display of the transducer output in relation to the set pressure range.</li> <li>Simple and complete menu guidance as parameters are split into several levels and groups</li> <li>Each parameter is given a 3-digit ID number for easy navigation</li> <li>Possibility of configuring the display to suit individual requirements and preferences, such as language, alternating display, contrast setting, display of other measured values such as sensor temperature etc.</li> <li>Comprehensive diagnostic functions (fault and warning message, peak-hold indicators, etc.)</li> </ul>						
	$\begin{array}{c} & & & & & & \\ & & & & \\ & & & & & & \\ & & & & & & & \\ & & & & & & \\ & & & & & & \\ & & & & & & \\ & & & & & & \\ & &$						

- Operating keys Bar graph Symbol Header
- 1 2 3 4 5
- Parameter ID number

Ordering information: Product Configurator, "Output" ordering feature

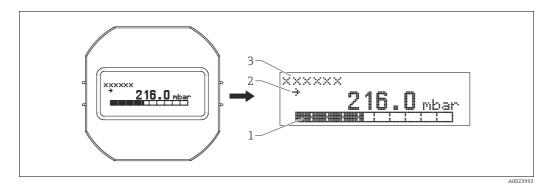
Function		Operat	tion with display	
	Analog electronics	HART	PROFIBUS PA	FOUNDATION Fieldbus
Position adjustment (zero point correction)	_	~	V	V
Setting lower range value and upper range value - reference pressure present at the device	_	V	V	V
Device reset	_	~	~	V
Locking and unlocking parameters relevant to the measured value	_	~	~	V
Value acceptance indicated by the green LED	_	_	_	_
Switching damping on and off	_	~	~	V

### Local display (optional) for devices with analog electronics

A 4-line liquid crystal display (LCD) is used. The local display shows measured values, fault messages and notice messages. The liquid crystal display of the device can be turned in 90° stages. Depending on the orientation of the device, this makes it easy to operate the device and read the measured values.

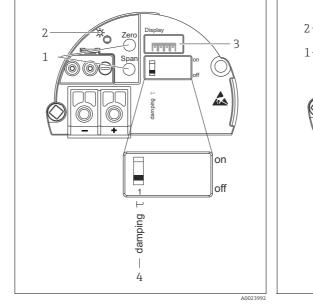
#### Functions:

- 8-digit measured value display including sign and decimal point, bar graph for 4 to 20 mA as current display.
- Diagnostic functions (fault and warning message etc.)



Ordering information:

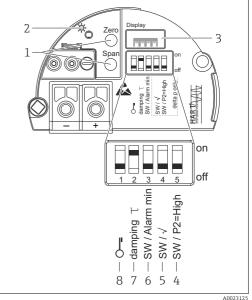
Product Configurator, "Display, operation" ordering feature



#### Operating keys and elements located inside on the electronic insert

Analog electronic insert

- Operating keys for lower range value (zero), upper range 1 value (span), position zero adjustment or reset
- 2 Green LED to indicate successful
- operation Slot for optional local display 3
- DIP switch for switching damping on/off 4



HART electronic insert

2

1

1

2

3

4

5

6 7

8

2

3

4

5

8

- Operating keys for lower range value (zero) and upper range value (span)
- Green LED to indicate successful operation

- Slot for optional local display DIP switch only for Deltabar M DIP switch only for Deltabar M DIP switch for alarm current SW / Alarm Min (3.6 mA)

3

on

off

5 4

- SW / √ - SW / P2=High

Simulation damping

7654

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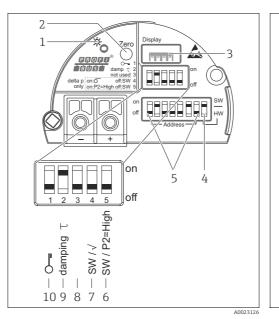
8

P2= NS

- DIP switch for switching damping on/off DIP switch for locking/unlocking parameters
  - relevant to the measured value

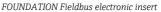
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F



PROFIBUS PA electronic insert

- Green LED to indicate successful operation 1
- Operating key for position zero adjustment (Zero) or reset 2
- 3 Slot for optional local display
- DIP-switch for bus address SW / HW 4
- DIP-switch for hardware address 5 6 7
- DIP switch only for Deltabar M DIP switch only for Deltabar M
- 8 Not used
- 9 DIP switch for switching damping on/off
- 10 DIP switch for locking/unlocking parameters relevant to the measured value



- Operating key for position zero adjustment (Zero) or reset Green LED to indicate successful operation
- Slot for optional local display
- DIP switch only for Deltabar M
- 6 7
- DIP switch only for Deltabar M DIP-switch for simulation mode DIP switch for switching damping on/off DIP switch for locking/unlocking parameters relevant to the measured value

Function	Operation with operating keys and elements on the electronic insert					
	Analog electronics	HART	PROFIBUS PA	FOUNDATION Fieldbus		
Position adjustment (zero point correction)	~	~	~	۲		
Setting lower range value and upper range value - reference pressure present at the device	V	V	_	_		
Device reset	~	V	~	V		
Locking and unlocking parameters relevant to the measured value	-	V	v	v		
Value acceptance indicated by the green LED	~	V	~	V		
Switching damping on and off	~	~	~	v		

## Ordering information: Product Configurator, "Output" ordering feature

#### **Operating languages**

You can also choose another language in addition to the standard language "English":

Designation	Option <sup>1)</sup>
English	AA
German	AB
French	AC
Spanish	AD
Italian	AE
Dutch	AF
Chinese simplified	AK
Japanese	AL

1) Product Configurator, "Additional operating language" ordering feature

#### Remote operation

All software parameters are accessible depending on the position of the write protection switch on the device.

Hardware and software for remote operation	HART	PROFIBUS PA	FOUNDATION Fieldbus
FieldCare $\rightarrow \triangleq 96 \text{ ff}$	✓ <sup>1)</sup>	✓ <sup>2)</sup>	V
FieldXpert SFX100 $\rightarrow$ 🖹 97 ff	V	_	V
NI-FBUS Configurator $\rightarrow$ $\stackrel{\frown}{=}$ 97 ff	_	_	V

- 1) Commubox FXA195 required  $\rightarrow \Rightarrow 97$  ff
- 2) Profiboard or Proficard required  $\rightarrow \Rightarrow 97$  ff

#### FieldCare

FieldCare is an Endress+Hauser asset management tool based on FDT technology. With FieldCare, you can configure all Endress+Hauser devices as well as devices from other manufacturers that support the FDT standard.

FieldCare supports the following functions:

- Configuration of transmitters in offline and online mode
- Loading and saving device data (upload/download)
- HistoROM<sup>®</sup>/M-DAT analysis
- Documentation of the measuring point

Connection options:

- HART via Commubox FXA195 and the USB port on a computer
- PROFIBUS PA via segment coupler and PROFIBUS interface card
- Service interface with Commubox FXA291 and ToF adapter FXA291 (USB).

For further information please contact your local Endress+Hauser Sales Center.

#### Field Xpert SFX100

Field Xpert is an industrial PDA with integrated 3.5" touchscreen from Endress+Hauser based on Windows Mobile. It offers wireless communication via the optional VIATOR Bluetooth modem or via WiFi and Endress+Hauser's Fieldgate FXA520. Field Xpert also works as a stand-alone device for asset management applications. For details refer to BA00060S/00/EN.

#### Commubox FXA195

For intrinsically safe HART communication with FieldCare via the USB interface. For details refer to TI00404F/00/EN.

#### Commubox FXA291

The Commubox FXA291 connects Endress+Hauser field devices with a CDI interface (= Endress+Hauser Common Data Interface) and the USB port of a computer or laptop. For details, see TI00405C/07/EN.

# i

For the following Endress+Hauser devices, you also need the "ToF adapter FXA291" accessory:

- Cerabar S PMC71, PMP7x
- Deltabar S PMD7x, FMD7x
- Deltapilot S FMB70

#### **ToF adapter FXA291**

The ToF adapter FXA291 connects the Commubox FXA291 to devices in the ToF platform, pressure devices and Gammapilot via the USB port of a computer or laptop. For details, see KA00271F.

#### Profiboard

For connecting a PC to PROFIBUS.

#### Proficard

For connecting a laptop to PROFIBUS.

#### FF configuration program

FF configuration program, such as NI-FBUS Configurator, to

- connect devices with "FOUNDATION Fieldbus signal" into an FF-network
- set FF-specific parameters

Remote operation via:

Operation with NI-FBUS Configurator:

The NI-FBUS Configurator is an easy-to-use graphical environment for creating linkages, loops, and a schedule based on the fieldbus concepts.

You can use the NI-FBUS Configurator to configure a fieldbus network as follows:

- Set block and device tags
- Set device addresses
- Create and edit function block control strategies (function block applications)
- Configure vendor-defined function and transducer blocks
- Create and edit schedules
- Read and write to function block control strategies (function block applications)
- Invoke Device Description (DD) methods
- Display DD menus
- Download a configuration
- Verify a configuration and compare it to a saved configuration
- Monitor a downloaded configuration
- Replace a virtual device by a real device
- Save and print a configuration

System integration (except analog electronics)

The device can be given a tag name (max. 8 alphanumeric characters).

Designation	Option <sup>1)</sup>
Measuring point (TAG), see additional spec.	Z1
Bus address, see additional spec.	Z2

1) Product Configurator, "Identification" ordering feature

# Planning instructions for diaphragm seal systems

#### NOTICE

#### Diaphragm seal systems sized/ordered incorrectly

The performance and the permitted range of application of a diaphragm seal system depend on the process isolating diaphragm used, the filling oil, the coupling, the unit design and on the specific process and ambient conditions present in the individual application.

 To help you select the right diaphragm seal systems for your particular applications, Endress+Hauser provides its customers with the "Applicator Sizing Diaphragm Seal" selection tool, which is available free of charge at "www.endress.com/applicator" or can be ordered on a DVD.

Applicator + Ausle	gung Pressu	re				MyApplicator Kontakt	lutzungsb	edingunger	n Bugrepo	rt   Über Appli	cator
1 Selection (2	Sizing		3	Configuration	1		Applicator	Tool wähl	en		+
Sizing Diaphragm Se	al Auslegung v	on Druckn	hittlermes	sumformern	-	1					
Auslegung Diagramme Bes					lenumrec	hner Einheiteneinstellung					
the Contract of the											-
Hauptparameter Produkt	Cerabar S PMP	75									٩.
Produkt	Colubal S Pill	15			-	3					din.
						1					-
Hinweis: Verwenden Sie "My	Applicator" um vers	chiedene O	tionen fest	rulegen							
Transmitterdaten						Messgenauigkeit und Offset					_
Sensor	1bar/100kPa/15	insi relativ							1010 -	mbar/10K	
								% span /	TUR.	mbarriuk	
Eingestellte Spanne	1 000	Aport Galary		mbar		Fehler durch Umgebungstemperatura	inderung	% span /		0.728	-
	and the second division of the second divisio			mbar	•	Fehler durch Umgebungstemperature     Fehler durch Prozesstemperaturande					_
Eingestellte Spanne	1 000	portoauv		mbar	•			0.073		0.728	
Eingestelte Spanne Membranmaterial	1 000 316L			mbar	•	Eehler durch Prozesstemperaturand		0.073	maximal	0.728	
Eingestelte Spanne Membranmaterial Prozessanschluss Filter Druckmittler	1 000 316L Alle			mbar	•	Eehler durch Prozesstemperaturand	erung	0.073		0.728	
Eingestelte Spanne Membranmaterial Prozessanschluss Fiter Druckmitter Transmittermontage	1 000 316L Alle DN50 PN10-40			mbar	•	Fehler durch Prozesstemperaturände Kalibration Offset	erung minimal	0.073 0.048 nominal	maximal	0.728 0,477 Einheit	
Eingestellte Spanne Membranmaterial Prozessanschluss Filter Druckmittler Transmittermontage Füllflüssigkeit	1 000 316L Alle DN50 PN10-40 Direkt Silkonöl			mbar	•	Fehler durch Prozesstemperaturände Kalibration Offset	minimal -4.2 -0.4	0.073 0.046 nominal 0 0	maximal 6.1 0.6	0.728 0.477 Einheit mbar %span	
Eingestelte Spanne Membranmaterial Prozessanschluss Fiter Druckmitter Transmittermontage	1 000 316L Alle DN50 PN10-40 Direkt Silkonöl		maximal	mbar	•	Fehler durch Prozesstemperaturände Kalibration Offset     Maximaler Offset nach Installation     Ergebnisse	minimal -4.2 -0.4 minimal	0.073 0.046 nominal 0 0 0	maximal 6.1 0.6 maximal	0.728 0.477 Einheit mbar %span Einheit	
Eingestelte Spanne Membranmaterial Prozessanschluss Filter Druckmitter Transmittermontage Fültflüssigket	1 000 316L Alle DN50 PN10-40 Direkt Silkonöl dingungen	B1, 316L	maximal 100		•	Fehler durch Prozesstemperaturände Kalibration Offset     Maximaler Offset nach Installation     Ergebnisse     Antwortzeit Tau (T63)	minimal -4.2 -0.4 minimal 0.2	0.073 0.046 nominal 0 0 0	maximal 6.1 0.6 maximal 0.2	0.728 0.477 Einheit mbar %span Einheit 5	
Eingestelte Spanne Membranmaterial Prozessanschluss Filter Druckmitter Transmittermontage Füllflüssigket Prozess- und Umgebungsber	1 000 316L Alle DNS0 PN10-40 Direkt Silkonöl dingungen minimal	B1, 316L nominal		Einheit	•	Fehler durch Prozesstemperaturände Kalibration Offset     Maximaler Offset nach Installation     Ergebnisse	minimal -4.2 -0.4 minimal	0.073 0.046 nominal 0 0 0	maximal 6.1 0.6 maximal	0.728 0.477 Einheit mbar %span Einheit	-
Eingestelte Spanne Membranmaterial Prozessanschluss Fiter Druckmitter Transmittermontage Fülflössigkeit Prozess- und Umgebungsber Prozesstemperatur Umgebungstemperatur	1 000 316L Alle DNS0 PN10-40 Direkt Silkonöl dingungen minimal -10	B1, 316L nominal 25	100	Einheit *C	•	Pehler durch Prozesstemperaturändr Kalibration Offset     Maximaler Offset nach installation     Ergebnisse     Antwortzeit Tau (T63)     Membranauslastung	minimal -4.2 -0.4 minimal 0.2 -23	0.073 0.046 0 0 0 0 0 0 0 0 0	maximal 6.1 0.6 maximal 0.2	0.728 0.477 Einheit mbar %span Einheit 5 5	-
Eingestelte Spanne Membranmaterial Prozessanschluss Fiter Druckmitter Transmittermontage Füllflüssigket Prozess- und Umgebungsber Prozesstemperatur	1 000 316L Alle DN50 PN10-40 Direkt Silkonöl dingungen -10 -10 900	B1, 316L nominal 25 25 1 000	100 60	Einhet °C °C	•	Fehler durch Prozesstemperaturände Kalibration Offset     Maximaler Offset nach Installation     Ergebnisse     Antwortzeit Tau (T63)	minimal -4.2 -0.4 minimal 0.2 -23	0.073 0.046 nominal 0 0 0	maximal 6.1 0.6 maximal 0.2	0.728 0.477 Einheit mbar %span Einheit 5	n

- 1 My Applicator Configuration of the Applicator settings
- 2 Applicator help
- 3 Mouse-Over help slide with the mouse pointer over these fields and get short informations

For further details, or for information on an optimum diaphragm seal solution, please contact your local Endress+Hauser Sales Center.

Applications

- Diaphragm seal systems should be used if the process and the device need to be separated. Diaphragm seal systems offer clear advantages in the following instances:
  - In the case of extreme process temperatures
  - For aggressive media
  - If extreme measuring point cleaning is necessary, or in the event of very damp mounting locations
  - If the measuring point is exposed to severe vibrations
  - For mounting locations that are difficult to access

#### Function and design

Diaphragm seals separate the measuring system from the process.

A diaphragm seal system consists of:

- A diaphragm seal
- A capillary tube or a temperature isolator if necessary
- Fill fluid
- A pressure transmitter

The process pressure acts via the process isolating diaphragm of a diaphragm seal on the liquid-filled system, which transfers the process pressure to the sensor of the pressure transmitter. Endress+Hauser delivers all diaphragm seal systems as welded versions. The system is hermetically sealed, which ensures greater reliability.

The diaphragm seal determines the application range of the system on the basis of

- The diameter of the process isolating diaphragm
- The process isolating diaphragm: stiffness and material
- The design (oil volume)

#### Diameter of the process isolating diaphragm

The greater the diameter of the process isolating diaphragm (less stiff), the smaller the temperature effect on the measurement result.

#### Stiffness of the process isolating diaphragm

The stiffness depends on the diameter of the process isolating diaphragm, the material, any existing coating, the thickness and shape of the process isolating diaphragm. The thickness of the process isolating diaphragm and the shape are determined by the design. The stiffness of a process isolating diaphragm of a diaphragm seal influences the temperature application range and the measuring error caused by temperature effects.

# The new TempC diaphragm: maximum accuracy and process safety during pressure and differential pressure measurement with diaphragm seals

To measure with even greater accuracy in these applications and increase process safety, Endress+Hauser has developed the TempC diaphragm which is based on a completely revolutionary technology. This diaphragm guarantees the utmost level of accuracy and process safety in diaphragm seal applications.

- The very low temperature effect minimizes the effect of process and ambient temperature fluctuations, thereby guaranteeing accurate and reliable measurements. Measurement inaccuracies caused by temperature are reduced to a minimum.
- The TempC diaphragm can be used at temperatures between -40 °C (-40°F) and +250 °C (+482°F). This guarantees maximum process safety even in the event of very long sterilization and cleaning cycles (SIP/CIP) in tanks and pipes at high temperatures.
- Smaller instrumentation is possible thanks to the TempC diaphragm. With a smaller process connection, the new diaphragm measures at least as accurately as a conventional diaphragm with a larger diameter.
- Short recovery times following thermal shocks allow shorter downtimes during batch processes and therefore a far higher level of availability of the production facilities.
- In addition, the TempC diaphragm excels in terms of improved hygienic cleanability and its insensitivity to large changes in the pressure load.

Ordering information:

See the Product Configurator for the individual process connection and the choice of process isolating diaphragm.

Selection in the Applicator:

Under "Transmitter data" in the "Diaphragm material" field.

#### Capillary

Capillaries with an internal diameter of 1 mm (0.04 in) are used as standard. As a result of its length and internal diameter, the capillary tube influences the thermal change, the ambient temperature application range and the response time of a diaphragm seal system.

#### Filling oil

When selecting the filling oil, the medium temperature and ambient temperature, as well as the process pressure, are of crucial importance. Observe the temperatures and pressures during commissioning and cleaning. A further selection criterion is the compatibility of the filling oil with the requirements of the medium. For example, only filling oils that do not present a health hazard are used in the food industry, e.g. vegetable oil or silicone oil.  $\rightarrow$  See also the following section "Diaphragm seal filling oils".

The filling oil used influences the thermal change, the temperature application range of a diaphragm seal system and the response time. A temperature change results in a volume change in the filling oil. The volume change depends on the thermal expansion coefficient of the filling oil and on the volume of the fill fluid at calibration temperature (constant in the range: +21 to +33 °C (+70 to 91°F)). For example, the filling oil expands in the event of a temperature increase. The additional volume presses against the process isolating diaphragm of a diaphragm seal. The stiffer a process isolating diaphragm is, the greater its return force, which counteracts a volume change and acts together with the process pressure on the measuring cell, thus shifting the zero point.

#### Pressure transmitter

The pressure transmitter influences the temperature application range, the thermal change and the response time as a result of its volume change. The volume change is the volume that has to be shifted in order to pass through the complete measuring range.

Pressure transmitters from Endress+Hauser are optimized with regard to minimum volume change.

#### Diaphragm seal filling oils

Filling oil	Permissible temperature range <sup>1)</sup> at 0.05 bar (0.725 psi) $\leq p_{abs} \pounds 1$ bar (14.5 psi)	Permissible temperature range <sup>2)</sup> at $p_{abs} \ge 1$ bar (14.5 psi)	Density [g/cm <sup>3</sup> ] / [SGU]	Viscosity [mm²/s] / [cSt] at 25 °C (77°F)	Thermal expansion coefficient <sup>2)</sup> [1/K]	Notes	Option <sup>3)</sup>
Silicone oil	−40 to +180 °C (−40 to +356°F)	−40 to +250 °C (−40 to +482°F)	0.96	100	0.00096	Suitable for foods FDA 21 CFR 175.105	1
Inert oil	-40 to +80 °C (-40 to +176°F)	−40 to +175 °C (−40 to +347°F)	1.87	27	0.000876	For ultrapure gas and oxygen applications	2
Vegetable oil	-10 to +120 °C (+14 to +248°F)	−10 to +200 °C (+14 to +392°F)	0.94	9.5	0.00101	Suitable for foods FDA 21 CFR 172.856	4
High- temperature oil <sup>4)</sup>	−10 to +200 °C (+14 to +392°F)	−10 to +400 °C (+14 to +752°F)	1.07	37	0.0007	High temperatures	5
Low-temperature oil	−70 to +80 °C (−94 to +176°F)	−70 to +180 °C (−94 to +356°F)	0.92	4.4	0.00108	Low temperatures	6

1) Observe temperature limits of the device ( $\rightarrow \square$  39) and of the system ( $\rightarrow \square$  99).

2) Please refer to the "Applicator Sizing Diaphragm Seal" tool for the thermal change of the diaphragm seal and other important technical features.

3) Product Configurator, "Fill fluid" ordering feature

4) When simultaneously using the diaphragm seal systems at high process temperatures and low absolute pressures, Endress+Hauser recommends the vacuum service (Product Configurator, "Service" ordering feature, option "HG").

Operating temperature range	The operating temperature range of a diaphragm seal system depends on the fill fluid, capillary length and internal diameter, process temperature and oil volume of the diaphragm seal. The range of application can be extended by using a fill fluid with a smaller expansion coefficient and a shorter capillary.
Cleaning instructions	<ul> <li>Endress+Hauser offer flushing rings as accessories to clean process isolating diaphragms without taking the transmitters out of the process. For further information please contact your local Endress+Hauser Sales Center.</li> <li>We recommend you perform CIP (cleaning in place (hot water)) before SIP (sterilization in place (steam)) for pipe diaphragm seals. A frequent use of sterilization in place (SIP) will increase the stress on the process isolating diaphragm. Under unfavorable circumstances in the long term view we cannot exclude that a frequent temperature change could lead to a material fatigue of the process isolating diaphragm and possibly to a leakage.</li> </ul>

#### Installation instructions

#### Diaphragm seal systems

- A diaphragm seal together with the transmitter form a closed, calibrated system, which is filled through openings in the diaphragm seal and in the transmitter's measurement system. These openings are sealed and must not be opened.
- In the case of devices with diaphragm seals and capillaries, the zero point shift caused by the hydrostatic pressure of the filling liquid column in the capillaries must be taken into account when selecting the measuring cell. If a measuring cell with a small measuring range is selected, a position adjustment can cause range violation.
- For devices with a temperature isolator or capillary, a suitable fastening device (mounting bracket) is recommended.
- When using diaphragm seal systems with a capillary, sufficient strain relief must be ensured in order to prevent the capillary bending down (bending radius ≥ 100 mm (3.94 in)).

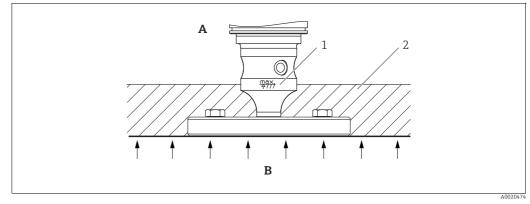
### Capillary

In order to obtain more precise measurement results and to avoid a defect in the device, mount the capillaries as follows:

- Vibration-free (in order to avoid additional pressure fluctuations)
- Not in the vicinity of heating or cooling lines
- Insulate if the ambient temperature is below or above the reference temperature
- With a bending radius of  $\geq 100 \text{ mm}$  (3.94 in).

#### Thermal insulation

The PMP55 may only be insulated up to a certain height. The maximum permitted insulation height is indicated on the devices and applies to an insulation material with a heat conductivity  $\leq 0.04 \text{ W/}$  (m x K) and to the maximum permitted ambient and process temperature. The data were determined under the most critical application "quiescent air".



Maximum permitted insulation height, here indicated on a PMP55 with a flange

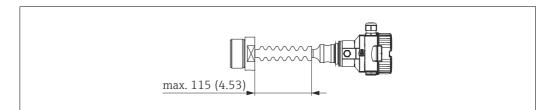
- A Ambient temperature: ≤ 70 °C (158°F)
- B Process temperature: max. 400  $^{\circ}$  C (752 F), depending on the diaphragm seal filling oil used
- 1 Maximum permitted insulation height
- 1 Maximum permitte 2 Insulation material

#### Mounting with temperature isolator

Endress+Hauser recommends the use of temperature isolators in the event of constant extreme medium temperatures which lead to the maximum permissible electronics temperature of +85  $^{\circ}$ C (+185 $^{\circ}$ F) being exceeded.

Depending on the filling oil used, diaphragm seal systems with temperature isolators can be used for maximum temperatures of up to 260 °C (+500°F).  $\rightarrow$  For the temperature application limits, see  $\rightarrow \triangleq 101$ , "Diaphragm seal filling oils" ordering feature.

To minimize the influence of rising heat, Endress+Hauser recommends the device be mounted horizontally or with the housing pointing downwards. The additional installation height also brings about a maximum zero point shift of 21 mbar (0.315 psi) due to the hydrostatic column in the temperature isolator. You can correct this zero point shift at the device.



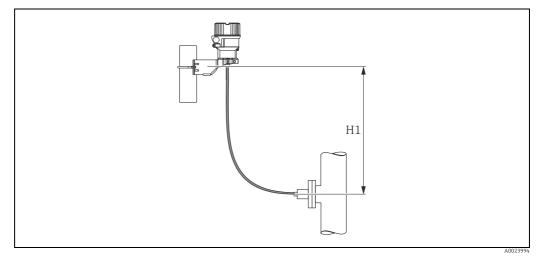
PMP55 with temperature isolator, material 316L (1.4404)

#### Vacuum applications

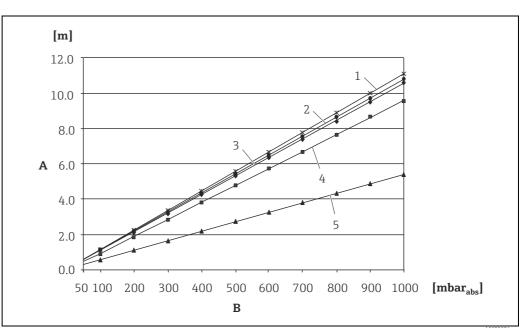
#### Mounting instructions

For applications under vacuum, Endress+Hauser recommends mounting the pressure transmitter below the diaphragm seal. This prevents vacuum loading of the diaphragm seal caused by the presence of fill fluid in the capillary.

When the pressure transmitter is mounted above the diaphragm seal, the maximum height difference H1 in accordance with the illustrations below must not be exceeded.



Installation above the lower diaphragm seal



The maximum height difference depends on the density of the filling oil and the smallest ever pressure that is permitted to occur at the diaphragm seal (empty vessel), see illustration below:

Diagram of maximum installation height above the lower diaphragm seal for vacuum applications depending on the pressure at the diaphragm seal on the positive side

- Height difference H1 Α
- В Pressure at diaphragm seal
- 1 Low temperature oil Vegetable oil 2
- 3
- Silicone oil
- 4 High-temperature oil
- 5 Inert oil

# Certificates and approvals

	11			
CE mark	The device meets the legal requirements of the relevant EC directives. Endress+Hauser confirms that the device has been successfully tested by applying the CE mark.			
C-tick symbol	The measuring system complies with the EMC requirements of the "Australian Communications and Media Authority (ACMA)".			
Ex approvals	<ul> <li>ATEX</li> <li>IECEx</li> <li>FM</li> <li>CSA</li> <li>Also combinations of different approvals</li> <li>All explosion protection data are given in separate documentation which is available upon request Ex documentation is supplied as standard with all devices approved for use in explosion hazard areas. →  </li></ul>			
Suitable for hygiene applications	<ul> <li>All materials in contact with foodstuffs comply with framework Regulation (EC) 1935/2004. The device is available with hygienic process connections (overview: see order code).</li> <li>A CAUTION</li> <li>Contamination in the process!</li> <li>Risk of contamination if incorrect seals and parts are used!</li> <li>To avoid the risk of contamination, when installing the device comply with the design principles of EHEDG, Guideline 37 "Hygienic Design and Application of Sensors" and Guideline 16 "Hygienic Pipe Couplings".</li> <li>Suitable assemblies and seals must be used to ensure hygienic design in accordance with 3-A SSI and EHEDG specifications.</li> <li>The leak-proof connections can be cleaned with the cleaning methods typical of this industry (CIP and SIP). Attention must be paid to the pressure and temperature specifications of the sensor and process connections for CIP and SIP processes (clean in place/sterilize in place).</li> </ul>			
	Image: Construction of the second of the			
	The gap-free connections can be cleaned of all residue using the typical cleaning methods within this industry.			
Pharma (CoC)	Certificate of Compliance (CoC) (according to ASME BPE-2007)			
	Ordering information: Product Configurator, "Additional approval" ordering feature, option "LW"			
Functional safety SIL	The Cerabar M with 4 to 20 mA output signal has been developed to assessed and certified by TÜV NORD CERT as per IEC 61508 Edition 2.0 and IEC 61511. These devices can be used to monitor the process level and pressure up to SIL 2. For a detailed description of the safety functions with Cerabar M, settings and functional safety data, see the "Functional safety manual - Cerabar M" SD00347P. Ordering information: Product Configurator, "Additional approval" ordering feature, option "LA"			

CRN approvals	Some device versions have CRN approval. A CRN-approved process connection with a CSA approval must be ordered for a CRN-approved device. PMP55 devices with a capillary are not CRN-approved. These devices are fitted with a separate plate bearing the registration number 0F10525.5C.					
	Ordering information: Product Configurator, "Process connection" section and Product Configurator, "Approval" ordering feature					
Standards and guidelines	DIN EN 60770 (IEC 60770): Transmitters for use in industrial process control systems Part 1: Methods for inspection and routine testing					
	DIN 16086: Electrical pressure measuring instruments, pressure sensors, pressure transmitters, pressure measuring instruments, concepts, specifications on data sheets					
	EN 61326 series: EMC product family standard for elect	rical equipment for r	neasurem	ent, contro	ol and labo	oratory use.
AD2000	The pressure retaining material 316L (1.4435/1.4404) corresponds to AD2000 - W2/W10.					
Pressure Equipment Directive (PED)	The devices PMC51, PMP51 and PMP (Pressure Equipment Directive) and ha engineering practice.					
<ul> <li>The following also applies:</li> <li>PMP51/PMP55 with threaded connection and internal Suitable for stable gases in group 1, category I</li> <li>PMP55 with pipe diaphragm seal ≥ 1.5"/PN40: Suitable for stable gases in group 1, category II</li> <li>PMP55 with separators PN400: Suitable for stable gases in group 1, category I</li> </ul>				olating dia	phragm Pl	N > 200:
Marine approval	Designation	Option <sup>1)</sup>				
	GL (Germanischer Lloyd)	LE				
	ABS (American Bureau of Shipping)	LF				
	LR (Lloyd's Register )	LG				
	BV (Bureau Veritas)	LH				
	DNV (Det Norske Veritas)	LI				
	1) Product Configurator, "Additional approval" ordering feature					
Drinking water approval	NSF 61 - approval for PMC51 and PMP51 Ordering information: Product Configurator, "Additional approval" ordering feature, option "LR"					
	Endress+Hauser instruments are designed according to ANSI/ISA 12.27.01 either as single seal or dual seal devices with annunciation, allowing the user to waive the use and save the cost of installing external secondary process seals in the conduit as required by the process sealing sections of ANSI/ NFPA 70 (NEC) and CSA 22.1 (CEC). These instruments comply with the North-American installation practice and provide a very safe and cost-saving installation for pressurized applications with hazardous fluids. Further information can be found in the control drawings of the relevant devices.					
Classification of process sealing between electrical systems and (flammable or combustible) process fluids in accordance with ANSI/ ISA 12.27.01	dual seal devices with annunciation, a external secondary process seals in the NFPA 70 (NEC) and CSA 22.1 (CEC). T practice and provide a very safe and co hazardous fluids.	llowing the user to w e conduit as required These instruments con ost-saving installation	vaive the u by the pro mply with n for press	ocess seali the North surized apj	ng sectior -Americar plications	ns of ANSI/
sealing between electrical systems and (flammable or combustible) process fluids in accordance with ANSI/	dual seal devices with annunciation, a external secondary process seals in the NFPA 70 (NEC) and CSA 22.1 (CEC). T practice and provide a very safe and co hazardous fluids.	llowing the user to w e conduit as required These instruments con ost-saving installation	vaive the u by the pro mply with n for press	ocess seali the North surized apj	ng sectior -Americar plications	ns of ANSI/

Designation	PMC51	PMP51	PMP55	Option <sup>1)</sup>
Conformity to NACE MR0175, wetted metallic parts	~	~	r	JB
Conformity to NACE MR0103, wetted metallic parts	~	~	r	JE
Conformity to AD2000, wetted metallic parts, excepting process membrane	_	v	v	JF
Surface finish measurement ISO4287/Ra, wetted metallic parts, Inspection certificate	~	v	v	KB
Helium leak test, internal procedure, inspection certificate	~	V	V	KD
Pressure test, internal procedure, inspection certificate	~	V	V	KE
3.1 Material certificate+Delta-Ferrit measurement, internal procedure, wetted metallic parts, EN10204-3.1 inspection certificate	~	v	r	KF
3.1 Material certificate+PMI test (XRF), internal procedure, wetted metallic parts, EN10204-3.1 inspection certificate	_	v	r	KG

1) Product Configurator, "Test, certificate" ordering feature

#### Calibration; unit

Designation	Option <sup>1)</sup>
Sensor range; %	А
Sensor range; mbar/bar	В
Sensor range; kPa/MPa	С
Sensor range; mm/mH2O	D
Sensor range; inH2O/ftH2O	E
Sensor range; psi	F
Customized pressure; see additional specification	J
Customized level; see additional specification	К

1) Product Configurator, "Calibration; unit" ordering feature

# Calibration

Designation	Option 1)	
Factory calibration, 5-point	F1	
DKD/DAkkS calibration certificate 10-point		

1) Product Configurator, "Calibration" ordering feature

#### Service

Designation	Option <sup>1)</sup>
Oil and grease removed <sup>2)</sup>	HA
Cleaned for oxygen service <sup>2)</sup>	HB
Cleaned from PWIS (PWIS = paint wetting impairment substances) <sup>2)</sup>	HC
Configured min alarm current	IA
Configured HART Burst Mode PV	IB

1) Product Configurator, "Service" ordering feature

2) Only device, not accessory or enclosed accessory

# **Ordering information**

Detailed ordering information is available from the following sources:

- In the Product Configurator on the Endress+Hauser website: www.endress.com → Select country → Instruments → Select instrument → Product page function: Configure this product
- From your Endress+Hauser Sales Center: www.endress.com/worldwide

### **Product Configurator - the tool for individual product configuration**

- Up-to-the-minute configuration data
- Depending on the device: direct input of information specific to measuring point, such as measuring range or operating language
- Automatic verification of exclusion criteria
- Automatic creation of the order code and its breakdown in PDF or Excel output format
- Ability to order directly in the Endress+Hauser Online Shop

#### Configuration data sheet (HART, PROFIBUS PA, FOUNDATION Fieldbus electronics)

#### Pressure

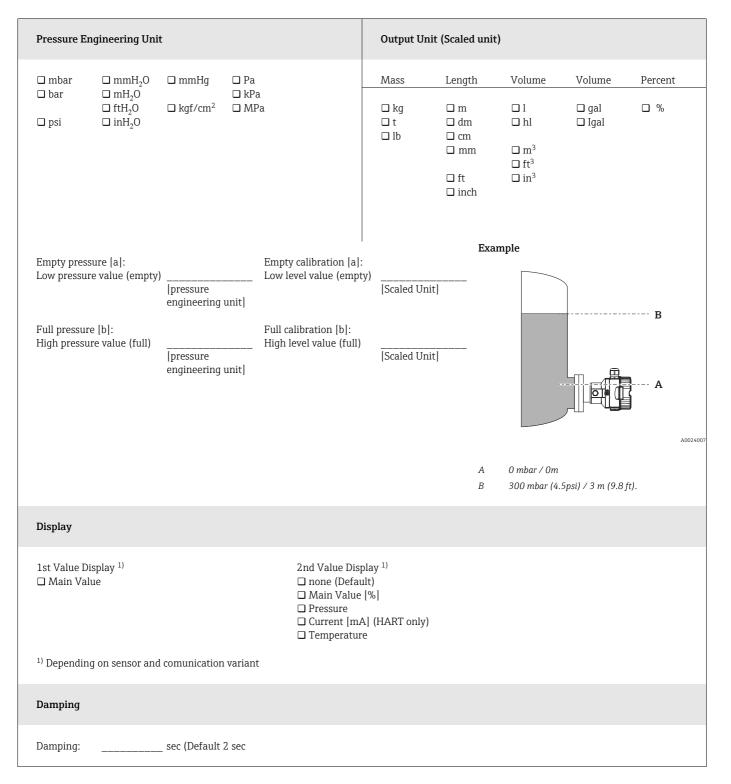
The following configuration data sheet has to be filled in and included with the order if the option "J" has been selected in the Product Configurator, "Calibration; Unit" ordering feature.

Pressure Engineering Unit					
□ mbar □ bar □ psi	□ mmH <sub>2</sub> 0 □ mH <sub>2</sub> 0 □ ftH <sub>2</sub> 0 □ inH <sub>2</sub> 0	□ mmHg □ kgf/cm <sup>2</sup>	□ Pa □ kPa □ MPa		
Calibration	Range / Outp	ut			
Low range v	alue (LRV):			[pressure engineering unit]	
Upper range	value (URV):			[pressure engineering unit]	
Display					
1st Value Di 🗆 Main Valu				2nd Value Display <sup>1)</sup> <ul> <li>none (Default)</li> <li>Main Value [%]</li> <li>Pressure</li> <li>Current [mA] (HART only)</li> <li>Temperature</li> </ul>	
<sup>1)</sup> Depending on sensor and comunication variant					
Damping					
Damping:		_ sec (Default )	2 sec)		

Smallest calibratable span (preset at the factory)  $\rightarrow$   $\supseteq$  11 ff.

#### Level

The following configuration data sheet has to be filled in and included with the order if the option "K" has been selected in the Product Configurator, "Calibration; Unit" ordering feature.



# Configuration data sheet (analog electronics)

### Pressure

The following configuration data sheet has to be filled in and included with the order if the option "J" has been selected in the Product Configurator, "Calibration; Unit" ordering feature.

Pressure En	gineering Uni	t			
□ mbar □ bar □ psi	□ mmH <sub>2</sub> 0 □ mH <sub>2</sub> 0 □ ftH <sub>2</sub> 0 □ inH <sub>2</sub> 0	□ mmHg □ kgf/cm <sup>2</sup>	□ Pa □ kPa □ MPa		
Calibration	Range / Outpı	ıt			
Low range va Upper range	alue (LRV): value (URV):			[pressure engineering unit] [pressure engineering unit]	
Display					
1st Value Dis □ Main Valu <sup>1)</sup> Depending	10	l comunication	variant	2nd Value Display <sup>1)</sup> □ none (Default)	
Damping					
Damping:		_ sec (Default 2	2 sec)		

Smallest calibratable span (preset at the factory)  $\rightarrow$   $\stackrel{>}{=}$  11 ff.

## Documentation

Technical Information	<ul> <li>EMC test procedures TI00241F/00/EN</li> <li>Deltabar M: TI00434P/00/EN</li> <li>Deltapilot M: TI00437P/00/EN</li> </ul>
Operating Instructions	<ul> <li>4 to 20 mA Analog: BA00385P/00/EN</li> <li>4 to 20 mA HART: BA00382P/00/EN</li> <li>PROFIBUS PA: BA00383P/00/EN</li> <li>FOUNDATION Fieldbus: BA00384P/00/EN</li> </ul>
Brief Operating Instructions	<ul> <li>4 to 20 mA Analog: KA01036P/00/EN</li> <li>4 to 20 mA HART: KA01030P/00/EN</li> <li>PROFIBUS PA: KA01031P/00/EN</li> <li>FOUNDATION Fieldbus: KA01032P/00/EN</li> </ul>
Functional safety manual (SIL)	Cerabar M (4 to 20 mA): SD00347P/00/EN

#### Safety Instructions

Directive	Approval	Category	Туре	Hou	sing	Electronics	Documentation	Option <sup>1)</sup>
				F31	F15			
	Ex ia IIC	II 1/2 G	PMC51, PMP51, PMP55	r	V	- 4 to 20 mA HART	- XA00464P/00	BA
	Ex t IIC	II 1/2 D	PMC51, PMP51, PMP55	V	V	- 4 to 20 mA HART	- XA00466P/00	BB
	Ex d	II 2 G	PMP51, PMP55	r	_	<ul> <li>4 to 20 mA HART, PROFIBUS PA, FOUNDATION Fieldbus</li> </ul>	- XA00467P/00	BC
	Ex nA	II 3 G	PMC51, PMP51, PMP55	r	r	<ul> <li>4 to 20 mA HART, PROFIBUS PA, FOUNDATION Fieldbus</li> </ul>	- XA00469P/00	BD
	Ex ia IIC	II 2 G	PMC51, PMP51, PMP55	V	V	- 4 to 20 mA HART	- XA00464P/00	BE
ATEX	Ex ia IIC	II 1/2 D	PMC51	~	r	- 4 to 20 mA HART	- XA00465P/00	BF
	Ex ic IIC	II 3 G	PMC51, PMP51, PMP55	~	r	- 4 to 20 mA HART	- XA00489P/00	BG
	Ex ia Ex ia IIIC	II 1/2 G II 1/2 D	PMC51, PMP51, PMP55	r	r	- 4 to 20 mA HART	- XA00468P/00	B1
	Ex ia IIC	II 2 G II 1/2 G	PMP51, PMP55	r	r	- 4 to 20 mA HART	- XA00468P/00	B2
	Ex d IIC Ex ia IIC	II 2 G II 1/2 G	PMP51, PMP55	V	_	<ul> <li>4 to 20 mA HART, PROFIBUS PA, FOUNDATION Fieldbus</li> </ul>	- XA00504P/00	8A

1) Product Configurator, "Approval" ordering feature

Directive	Approval	EPL	Туре	Hou	sing	Electronics	Documentation	Option <sup>1)</sup>
				F31	F15			
	Ex ia IIC	Ga/Gb	PMC51, PMP51, PMP55	V	V	- 4 to 20 mA HART	- XA00470P/00	IA
	Ex d IIC	Gb	PMP51, PMP55	V	_	<ul> <li>4 to 20 mA HART, PROFIBUS PA, FOUNDATION Fieldbus</li> </ul>	- XA00471P/00	IB
IECEx	Ex t IIIC	Da/Db	PMP51, PMP55	r	V	- 4 to 20 mA HART	- XA00472P/00	ID
IECEX	Ex ic	Gc	PMC51, PMP51, PMP55	r	V	- 4 to 20 mA HART	- XA00488P/00	IE
	Ex ia IIIC	Da/Db	PMC51	r	V	- 4 to 20 mA HART	- XA00487P/00	IF
	Ex ia IIC Ex ia IIIC	Ga/Gb Da/Db	PMC51, PMP51, PMP55	۷	r	- 4 to 20 mA HART	- XA00473P/00	I1

1) Product Configurator, "Approval" ordering feature

Directive	Approval	Туре	Hou	sing	Electronics	Documentation	Option <sup>1)</sup>
			F31	F15	*		
NEPSI	Ex ia IIC	PMC51, PMP51, PMP55	~	>	- 4 to 20 mA HART	- XA00533P/00	NA
NEPSI	Ex d IIC	PMP51, PMP55	V		- 4 to 20 mA HART	- XA00515P/00	NB

1) Product Configurator, "Approval" ordering feature

Directive	Approval	Electronics	Documentation	Option <sup>1)</sup>
TIIS	Ex ia IIC T4	- 4 to 20 mA HART	-	TA

1) Product Configurator, "Approval" ordering feature

Directive	Approval	Electronics	Documentation	Option <sup>1)</sup>
INMETRO	Ex ia IIC T6T4 Ga/Gb Ex ia IIC T6T3 Ga/Gb	<ul> <li>4 to 20 mA HART</li> <li>PROFIBUS PA</li> <li>FOUNDATION Fieldbus</li> </ul>	- XA01302P/00	MA
INMETRO	Ex d IIC T6/T4 Gb	<ul> <li>4 to 20 mA HART</li> <li>PROFIBUS PA</li> <li>FOUNDATION Fieldbus</li> </ul>	- XA01284P/00	MB

1) Product Configurator, "Approval" ordering feature

#### Installation/Control Drawings

Directive	Approval	Туре	Hou	ising	Electronics	Documentation	Option 1)
			F31	F15	-		
	FM IS Cl.I,II,III Div.1 Gr.A-G, AEx ia FM NI Cl.I Div.2 Gr.A-D FM IS: Zone 0,1,2,20,21,22/FM NI: Zone 2	PMC51, PMP51, PMP55	~	r	<ul> <li>4 to 20 mA HART</li> <li>PROFIBUS PA, FOUNDATION Fieldbus</li> </ul>	- XA00563P/00 - XA00564P/00	FA
	FM XP Cl.I, II Div.1 Gr.A-D, AEx d (Factory sealed) Zone 1,2	PMP51, PMP55	r	_	<ul> <li>4 to 20 mA HART</li> <li>PROFIBUS PA</li> <li>FOUNDATION Fieldbus</li> </ul>	- XA01163P/00	FB
FM	FM DIP Cl.II, III Div.1 Gr.A-D Zone 21,22	PMP51, PMP55	V	V	- 4 to 20 mA HART	– In preparation	FC
	FM NI Cl.I Div.2 Gr.A-D, Zone 2	PMC51, PMP51, PMP55	r	۷	- 4 to 20 mA HART	- FM3035394	FD
	FM IS/XP Cl.I, II Div.1 Gr.A-G, Zone 1,2	PMP51, PMP55	r		<ul> <li>4 to 20 mA HART</li> <li>PROFIBUS PA, FOUNDATION Fieldbus</li> </ul>	- XA01160P/00 - XA00567P/00	F1
	C/US IS Cl.I,II,III Div.1 Gr.A-G, C/US IS Cl.I Div.2 Gr.A-D, Ex ia	PMC51, PMP51, PMP55	r	۷	<ul> <li>4 to 20 mA HART</li> <li>PROFIBUS PA, FOUNDATION Fieldbus</li> </ul>	- XA00556P/00 - XA00558P/00	CA
CSA	CSA C/US CP Cl.I, II Div.1 Gr.B-G, Ex d (factory sealed) Zone 1,2	PMP51, PMP55	~	-	- 4 to 20 mA HART	- XA00577P/00	СВ
	CSA C/US Cl.II, III Div.1 Gr.E-G, Zone 21,22	PMP51, PMP55	V	V	- 4 to 20 mA HART	– In preparation	CC
	CSA C/US IS/XP CL.I, II Div.1 Gr.A-G/B-G, Zone 1,2	PMP51, PMP55	r	_	<ul> <li>4 to 20 mA HART</li> <li>PROFIBUS PA, FOUNDATION Fieldbus</li> </ul>	- XA00577P/00 - XA00561P/00	C1
FM CSA	FM/CSA IS + XP Cl.I, II Div.1 Gr.A-D/B-G FM IS/FM XP Cl.I, II Div.1 Gr.A-G+ CSA IS/XP Cl.I, II Div.1 Gr.A-G, Zone 1,2	PMP55	r	_	- 4 to 20 mA HART	– In preparation	8B

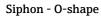
1) Product Configurator, "Approval" ordering feature

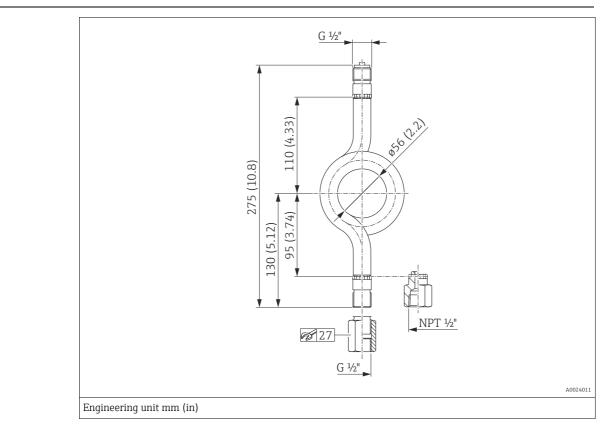
### Combination certificate

Directive	Approval	Туре	Electronics	Documentation	Option <sup>1)</sup>
			- 4 to 20 mA HART, PROFIBUS PA, FOUNDATION Fieldbus	- XA00464P/00	
ATEX II Ex ia + FM/CSA IS KEMA/ ATEX II 1/2G Ex ia IIC T6 + FM / CSA FM/CSA IS CL.I Div.1 Gr.A-	PMC51	- 4 to 20 mA HART	- XA00556P/00+ XA00536P/00	8C	
	D, FM/CSA: Zone 0,1,2		– PROFIBUS PA, FOUNDATION Fieldbus	- XA00564P/00	

1) Product Configurator, "Approval" ordering feature

## Accessories





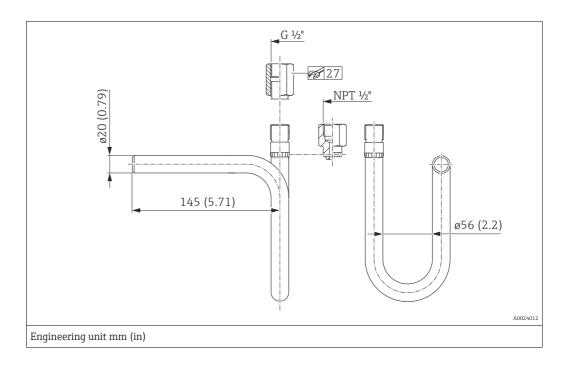
Max. operating pressure [bar (psi)]		Max. operating temperature upstream from siphon (on process side) [°C (°F)]
104 (1508)	=	400 (752)
120 (1740)	=	300 (572)
160 (2320)	=	120 (248)

Connection thread [d]	Material	Option <sup>1)</sup>		
G <sup>1</sup> /2"	1.0345		-	
G 42	316Ti (1.4571)	RA22	BA22 <sup>2)</sup>	
NPT ½"	316Ti (1.4571)	-	BB22 <sup>2)</sup>	

1) Product Configurator, "Accessory enclosed" ordering feature, option "P4".

2) with 3.1 inspection certificate

### Siphon - U-shape

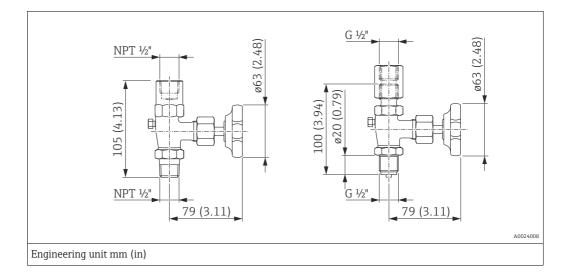


Max. operating pressure [bar (psi)]		Max. operating temperature upstream from siphon (on process side) [°C (°F)]
104 (1508)	=	400 (752)
120 (1740)	-	300 (572)
160 (2320)	=	120 (248)

Connection thread [d]	Material	Option <sup>1)</sup>
G ½"	1.0345	RC11
NPT 1/2"	1.0345	RD11

1) Product Configurator, "Accessory enclosed" ordering feature, option "P4".

#### Shutoff valve



Max. working pressure [bar (psi)]	Connection thread [d]	Material	Option <sup>1)</sup>
400 (5800)	G <sup>1</sup> /2"	C22.8 (1.0460)	R1A1
	0 12	316Ti (1.4571)	R1A2, B1A2
	NPT ½"	C22.8 (1.0460)	R1D1
	INP 1 72	316Ti (1.4571)	R1D2, B1D2

1) Product Configurator, "Accessory enclosed" ordering feature, option "P2".

# Welding necks and Weld-in tool flanges

Designation	PMC51	PMP51	PMP55	Option <sup>1)</sup>
Weld-in adapter G1/2, 316L,		v	~	QA
Weld-in adapter G1/2, 316L, 3.1 EN10204-3.1 material, inspection certificate		v	~	QB
Weld-in tool adapter G1/2, Brass		v	~	QC
Weld-in adapter G1, 316L, conical metal joint		v	_	QE
Weld-in adapter G1, 316L, 3.1 EN10204-3.1 material, inspection certificate, conical metal joint		v	_	QF
Weld-in tool adapter G1, Brass conical metal joint		v	_	QG
Weld-in adapter G1-1/2, 316L	V	v	~	QJ
Weld-in adapter G1-1/2, 316L, 3.1 EN10204-3.1 material, inspection certificate		v	~	QK
Weld-in tool adapter G1-1/2, Brass		v	~	QL
Weld-in flange DRD DN50 65mm, 316L		v	~	QP
Weld-in fl. DRD DN50 65mm, 316L 3.1 EN10204-3.1 material, inspection certificate	V	v	~	QR
Weld-in tool flange DRD DN50 65mm, Brass		v	~	QS
Weld-in adapter Uni D65, 316L	~	_	_	QT
Weld-in adapter Uni D65, 316L, 3.1 EN10204-3.1 material, inspection certificate		_	_	QU
Weld-in tool adapter Uni D65/D85, Brass		_	_	Q1
Weld-in adapter Uni D85, 316L		_	_	Q2
Weld-in adapter Uni D85, 316L, 3.1 EN10204-3.1 material, inspection certificate	V	_	_	Q3

1) Product Configurator, "Accessories" ordering feature

For dimensions and technical data see technical Information TI00426F/00.

Mounting bracket for wall and pipe mounting	$\rightarrow$ $\supseteq$ 34 ff
M12 connector	$\rightarrow$ $\supseteq$ 23 ff

# Registered trademarks

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PROFIBUS®	Registered trademark of the PROFIBUS User Organization, Karlsruhe, Germany	
FOUNDATION™ Fieldbus	Registered trademark of the Fieldbus Foundation, Austin, Texas, USA	



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